



**University of
Nottingham**
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The Fundamental Interactions Between Hydrogen and group III-VI and IV-VI van der Waals Crystals

Thesis submitted to the University of Nottingham for the degree of
Doctor of Philosophy, September 2022.

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Date: 28 / 09 / 2022

Abstract

Eighteen years since the exfoliation of graphene was first demonstrated, van der Waals (vdW) materials have attracted incredible fundamental and applied research interest. The sustained level of interest can be attributed to the unique properties and the diversity of vdW crystals, which can be readily exfoliated via the simple method first used for graphene. Over the same period, a renewed wave of hydrogen research has emerged with the aim of reducing greenhouse gas emissions. As such, the two fields have often intersected, with the properties of vdW materials often well suited to applications in hydrogen storage, sensing, generation and purification. This PhD considers the fundamental interactions of vdW materials with hydrogen. Specifically, the focus of this work is on the interactions with the vdW semiconductors SnS₂, SnS, γ -InSe and ϵ -GaSe. It was found that SnS₂ can be converted to SnS upon hydrogen exposure, producing a heterostructure with surprising uniformity and a step-like interface. Exposure of γ -InSe to H-ions modifies its optical and vibrational properties, whilst theoretical studies reveal an exciting modification to the phonon modes upon H₂ incorporation. Finally, water exposed ϵ -GaSe is partially oxidised, modifying its electronic band structure, relevant to solar water splitting applications. These results are of fundamental interest and relevant to both hydrogen and semiconductor technologies, ranging from engineered vdW heterostructures and optoelectronics, to hydrogen storage and generation.

Acknowledgements

This PhD is part of the Fuel Cells and their Fuels centre for doctoral training, funded by the Engineering and Physical Sciences Research Council [grant number EP/L015749/1].

I would like to thank my supervisors Prof. Amalia Patanè, Dr. Zakhar Kudrynskyi and Prof. Gavin Walker for their guidance, advice and assistance throughout the course of this PhD.

Collaboration has been a vital component of this PhD. As such, I would like to acknowledge and thank some of the individuals who have assisted in its completion: Elena Blundo, Prof. Antonio Polimeni and Dr. Giorgio Pettinari (Sapienza University of Rome) have all been of great help in conducting exposures of both InSe and SnS₂ to hydrogen ions and the study of some of their optoelectronic properties; Prof. Zakhar Kovalyuk (National Academy of Sciences of Ukraine) for the growth of SnS₂, InSe and GaSe used over the course of this PhD; Dr. Sanliang Ling (University of Nottingham) for providing DFT simulations of SnS₂ and InSe systems; Dr. Vladimir Korolkov (Park Systems) for the AFM measurements of large area GaSe samples; similarly, Dr. Jonathan Bradford (University of Nottingham) for the AFM on SnS₂ and GaSe samples. NAP-XPS studies of GaSe have been conducted thanks to the assistance of Jack Hart and Dr. James O'Shea (University of Nottingham). Dr. Timothy Cooper, Dr. Matthew Wadge and Prof. David Grant (University of Nottingham) have made available a system in Nottingham for the exposure to hydrogen at low pressures. Dr. Fumin Huang and Anna Casey (Queen's University Belfast) have provided large area GaSe samples used for oxidation studies. The facilities at the Nanoscale and Microscale Research Centre (University of Nottingham) have been used for the study of materials via SEM, TEM and XPS.

Contents

Abstract	i
Acknowledgements	ii
List of Publications	vi
Chapter 1 Introduction: Motivation, Literature & Scope	1
1.1 Motivation	3
1.2 Literature Review	6
1.2.1 Modes of interaction: Physisorption, Chemisorption and Intercalation	7
1.2.2 Diffusion and Permeability	9
1.2.3 Chemical Conversion and Etching	10
1.2.4 Photocatalysis	11
1.2.5 Hydrogen Doping	12
1.2.6 Material Selection	13
1.3 Scope	17
1.3.1 Hydrogen - Tin Sulphides Interaction	18
1.3.2 Hydrogen - Indium Selenide Interaction	18
1.3.3 Gallium Selenide for Photocatalysis	19
Chapter 2 Theoretical Concepts	21
2.1 Electronic and Phonon Dispersions of vdW Materials	23
2.1.1 Electronic Band Structure	23
2.1.2 Vibrational Structure	30
2.2 Energy Band Alignment	32
2.3 Thermodynamics and Kinetics	35

2.3.1	Thermodynamics	35
2.3.2	Kinetics	37
Chapter 3	Materials and Methods	40
3.1	Materials	42
3.1.1	Material Growth	42
3.1.2	Sample Preparation	44
3.2	Experimental Methods	45
3.2.1	Sieverts	46
3.2.2	Kaufman Ion Source	48
3.2.3	Optical Spectroscopy	50
3.2.4	Electron Spectroscopy	54
3.2.5	Additional Techniques	62
Chapter 4	Hydrogen - Tin Sulphides Interaction	66
4.1	Chemical Interaction with H ₂	69
4.2	SnS ₂ thin films exposed to H ₂ and H-ions	71
4.3	Chemical Conversion of SnS ₂ by H ₂ and H-ions	74
4.4	Formation of an SnS/SnS ₂ Heterostructure	77
4.5	Optical Characteristics of SnS/SnS ₂ Heterostructure	81
4.6	Computational Results	88
4.7	Carrier Effective Mass in SnS ₂	89
4.8	Summary	93
Chapter 5	Hydrogen - Indium Selenide Interaction	95
5.1	Proposed Sites of Hydrogen Incorporation	97
5.2	Interaction with Hydrogen-Ions	99
5.2.1	Electron Spectroscopy Studies	100
5.2.2	Raman Studies	101
5.2.3	Photoluminescence	104
5.3	Interaction with Molecular Hydrogen	108

5.3.1	Pressure Studies	109
5.3.2	Photoluminescence and Raman Studies	110
5.3.3	Computational Studies	113
5.4	Summary	118
Chapter 6	Gallium Selenide for Photocatalysis	120
6.1	GaSe for Solar Water Splitting	122
6.2	XPS Studies of the Interaction Between Water and GaSe . .	126
6.3	Surface of GaSe	132
6.4	The Optical and Electronic Properties of GaSe	135
6.5	Summary	145
Chapter 7	Summary, Open Questions & Outlook	147
7.1	Summary of Results	148
7.1.1	SnS/SnS ₂	148
7.1.2	γ -InSe	149
7.1.3	ϵ -GaSe	151
7.2	Unanswered Questions	152
7.2.1	SnS/SnS ₂	152
7.2.2	γ -InSe	153
7.2.3	ϵ -GaSe	153
7.3	Prospects and Outlook	154
7.4	Conclusions	155
	Bibliography	156

List of Publications

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Zhuo Yang, Xueting Wang, James Felton, Zakhar Kudrynskiy, Masaki Gen, Toshihiro Nomura, Xinjiang Wang, Laurence Eaves, Zakhar D Kovalyuk, Yoshimitsu Kohama, Lijun Zhang, Amalia Patanè “Heavy carrier effective masses in van der Waals semiconductor Sn(SeS) revealed by high magnetic fields up to 150 T. ” *Physical Review B* 104, no. 8 (2021): 085206.

James Felton, Elena Blundo, Zakhar Kudrynskiy, Sanliang Ling, Jonathan Bradford, Giorgio Pettinari, Timothy Cooper, Matthew Wadge, Zakhar Kovalyuk, Antonio Polimeni, Peter Beton, David Grant, Gavin Walker, Amalia Patanè. “Hydrogen-Induced Conversion of SnS₂ into SnS or Sn: A Route to Create SnS₂/SnS Heterostructures.” *Small*, Jul no. 4 (2022): 2202661.

Chapter 1

Introduction: Motivation, Literature & Scope

This chapter provides the context in which the PhD was conducted. Specifically, the significance of hydrogen and layered van der Waals (vdW) materials, the rationale behind investigating their interactions and previous studies on the topic. As such, this chapter is divided into three sections. The first section describes the motivation for the work, addressing the fundamental and applied interest in the topic. The second section considers the literature on previous theoretical and experimental works in this field. The third section discusses the scope of the investigations for each of the considered vdW materials and introduces the thesis structure.

Contents

1.1	Motivation	3
1.2	Literature Review	6
1.2.1	Modes of interaction: Physisorption, Chemisorp- tion and Intercalation	7
1.2.2	Diffusion and Permeability	9
1.2.3	Chemical Conversion and Etching	10
1.2.4	Photocatalysis	11
1.2.5	Hydrogen Doping	12
1.2.6	Material Selection	13
1.3	Scope	17
1.3.1	Hydrogen - Tin Sulphides Interaction	18
1.3.2	Hydrogen - Indium Selenide Interaction	18
1.3.3	Gallium Selenide for Photocatalysis	19

1.1 Motivation

The establishment of a hydrogen economy is one response to the need to decarbonise the sectors of energy, transportation, steel production and ammonia production, together contributing to 58.8 % of global greenhouse gas emissions (Change (2014); Levi et al. (2020); David (2020)). These emissions can be averted by the introduction of green hydrogen as an energy vector in the energy and transportation sectors, as a feedstock for the reduction of iron ore and by the substitution of green hydrogen for grey hydrogen in the Haber-Bosch process (IEA (2019)). However, realising these potential applications requires technological innovations in: fuel cells, hydrogen storage, hydrogen purification, hydrogen production and hydrogen sensing (Tashie-Lewis and Nnabuife (2021); Buttner et al. (2017); El-Shafie et al. (2019)).

Targets have been set for many of the required technologies, including some of the key technologies listed below. Commercially available fuel cells currently have efficiencies of 35-40 % (Badwal et al. (2014)), short of the 60 % target proposed by the United States Department of Energy (DOE (2016)). Hydrogen storage for mobile applications can currently achieve 4.4 wt.% with compressed storage, with targets set at 7.5 wt.% (DOE (2016)). In the field of hydrogen purification, pressure swing adsorption is the dominant technology, accounting for 85 % of global supply (Schorer et al. (2019)). However, for high purity applications, such as in fuel cells, its efficiency is poor, recovering only 65-90% of the input hydrogen (Peramanu et al. (1999)). In hydrogen production, electrolyser efficiencies need to be improved from 67 % to 75 % (DOE (2016)). Finally, the field of hydrogen sensing requires improvement in response times and hydrogen specific sensitivity (Buttner et al. (2017)).

28 Just as hydrogen-based technologies seek to supplant mature technologies
29 due to their incompatibility with the goal of global emissions reduction, a
30 similar trend is occurring in the semiconductor industry. Mature silicon-
31 based technology is approaching its physical limit and new semiconducting
32 materials must be sought (Hassan et al. (2010)). One family of materials
33 that has come to offer great promise in addressing this challenge are the van
34 der Waals (vdW) materials and their corresponding quantum confined two-
35 dimensional (2D) counterparts. The first exfoliation of graphene in 2004
36 demonstrated a simple method for the preparation of these materials and
37 has spurred the experimental research in this field (Novoselov et al. (2004)).
38 The quantum confinement resulting from the reduced dimensionality of 2D
39 materials radically modifies their optical and electronic properties, giving
40 access to a wide range of new quantum phenomena of both fundamental
41 and applied interest, including low-power electronics, broad-band photo-
42 detection and nanophotonics (Bernardi et al. (2017); Zhang et al. (2017);
43 Hong et al. (2017); Kang et al. (2020)). These properties exist alongside
44 the good flexibility and strength inherent to 2D materials (Gao (2017); Zou
45 et al. (2018); Liu et al. (2017)), with tuneability possible through strain
46 engineering, alloying, and surface modification (Kudrynskyi et al. (2020);
47 Weng et al. (2018); Deng et al. (2018); Guo et al. (2015)). Given these
48 properties, it is unsurprising that researchers are investigating 2D and 3D
49 vdW materials for a wide range of applications.

50 Even before its first experimental exfoliation in 2004, theoretical papers
51 emerged predicting the hydrogen adsorption capability of graphene (Arel-
52 lano et al. (2000)). This was followed by experimental results quantifying
53 its hydrogen adsorption capacity (Srinivas et al. (2010)). The short delay
54 between the first exfoliation of graphene and papers describing its suit-
55 ability for hydrogen storage is hardly surprising; carbon nano-tubes had

56 previously been investigated for their hydrogen storage potential and the
57 properties of vdW materials lend themselves to this application (Cheng
58 et al. (2001)). vdW materials don't only have advantageous properties in
59 hydrogen storage applications. Their large surface areas, electronic prop-
60 erties tuneable through alloying and exfoliation, excellent opto-electronic
61 properties and functionalisation ability through surface modification make
62 the vdW materials excellent candidates when considering improvements to
63 the applications of purification, sensing and hydrogen production (Aleks-
64 seeva et al. (2020); Blackstone and Ignaszak (2021)).

65 There is a two-way advantage to studying the interaction between hydrogen
66 and vdW materials as not only are they promising to hydrogen technolo-
67 gies, hydrogen also offers promising options for vdW material modification.
68 It is desirable to use hydrogen in this application due to its ubiquity in the
69 semiconductor industry and environmentally minimal impacts. Addition-
70 ally, the small size of the hydrogen molecule opens up the prospect of
71 modifying vdW materials in ways not attainable by other means.

72 For either the hydrogen technology or semiconductor processing applica-
73 tions of vdW materials to be evaluated and realised, their fundamental
74 interactions with hydrogen must first be understood. This work has been
75 undertaken for many of the most popular vdW materials (graphene, MoS₂,
76 hBN and MXenes), but the family of vdW materials is incredibly diverse
77 and an understanding of this interaction for more of them would be greatly
78 beneficial. It is for this reason that the interaction between hydrogen and
79 the vdW materials InSe, GaSe and SnS₂ was explored.

80 1.2 Literature Review

81 Scientific knowledge of both vdW materials and hydrogen stretches back
82 centuries with the first isolation of hydrogen made in 1766 and the first
83 demonstration of the planar structure of graphite taking place in 1859
84 (Cavendish (1766); Brodie (1859)). Investigations of interactions between
85 the two are also not new, with the reaction between graphite and hydro-
86 gen reported in 1965 (Gulbransen et al. (1965)). It might therefore seem
87 strange that these two areas are currently seeing a renewed interest both
88 individually and in conjunction. This renewed interest has been driven by
89 independent developments in both fields. Enthusiasm has grown for hy-
90 drogen research as technological solutions are sought to reduce greenhouse
91 gas emissions, and vdW materials have gained new attention since the
92 first experimental demonstration of the mechanical exfoliation of graphene
93 (Novoselov et al. (2004)). This second achievement opened up investiga-
94 tion into a class of materials with unique properties and has motivated
95 researchers in a variety of fields, including those interested in their interac-
96 tions with hydrogen.

97 This section covers the literature of investigations into the interactions
98 between vdW materials and hydrogen and is divided into the following
99 sections: physisorption, chemisorption and intercalation of hydrogen, the
100 diffusion and permeability of hydrogen in vdW materials, the chemical
101 conversion and etching of vdW materials by hydrogen, vdW materials for
102 photocatalysis, and hydrogen as a dopant. It then goes on to discuss the
103 specific vdW materials of GaSe, InSe and SnS₂, and previous studies of
104 their interaction with hydrogen.

105 **1.2.1 Modes of interaction: Physisorption, Chemisorp-** 106 **tion and Intercalation**

107 Physisorption is the adsorption of molecules or atoms on a surface due to
108 non-bonding dispersive forces. Chemisorption is the adsorption of molecules
109 or atoms on a surface due to bond formation. These processes have rel-
110 evance to the field of hydrogen storage. Hydrogen storage in mobile ap-
111 plications requires a high hydrogen wt.% for the entire storage system. In
112 mobile applications, pressurised storage alone utilises high pressures of 700
113 bar to reach the volumetric densities required. This necessitates the use of
114 heavy pressure vessels and safety equipment and results in up to 4.4 wt.%
115 hydrogen storage (DOE (2016)). By placing an adsorbate material into
116 a pressure vessel, the volumetric density is increased without requiring a
117 corresponding increase in the pressure, as would be the case for compressed
118 storage. For activated carbon materials, the volumetric density is increased
119 by 23 % over compressed storage at the same pressure and achieves a ma-
120 terial gravimetric density of 5.8 wt.% (Ramirez-Vidal et al. (2021)). By
121 finding materials with sufficient volumetric and gravimetric hydrogen ad-
122 sorption densities, the performance of the hydrogen storage system can be
123 further improved to meet targets.

124 Carbon-based structures have long been considered as potential materi-
125 als for hydrogen storage (Cheng et al. (2001)). As such, it was natural
126 for researchers to begin with graphene when investigating the properties
127 of hydrogen adsorption on bulk and 2D vdW materials. In fact, before
128 even the first exfoliation of graphite to form graphene in 2004, theoreti-
129 cal predictions of the hydrogen adsorption abilities of graphene were made
130 (Arellano et al. (2000)). In this prediction, hydrogen was found to pref-
131 erentially locate above the centre of the hexagon in the graphene lattice

132 with the hydrogen molecule lying parallel to the basal plane of the mate-
133 rial. When considered experimentally, graphene is found to achieve a 1.2
134 wt.% hydrogen adsorption at 77 K and 10 bar (Srinivas et al. (2010)). This
135 value is below the value obtained by pressured storage but can be improved
136 further via the functionalisation of graphene, either to increase the number
137 of available adsorption sites or their occupation. For example, mesoporous
138 graphene oxide has achieved a 4.65 wt.% hydrogen adsorption at 40 bar at
139 room temperature (Kim et al. (2016)).

140 The nature of the investigations into graphene offers a template by which
141 the hydrogen adsorption properties of other materials can be explored.
142 Theoretical studies have indicated hydrogen storage capabilities in other
143 2D materials greater than that of graphene. For example, reversible storage
144 of 7.2 wt.% in Sc_2C (Le et al. (2020)). However, the literature on the wider
145 range of vdW materials is far more limited than with graphene and is
146 typically restricted to well known materials families like MXenes (Kumar
147 et al. (2021)).

148 Chemisorption studies present a more complicated picture. It is not imme-
149 diately obvious whether a material can successfully chemisorb hydrogen as
150 chemisorption is often achieved only with hydrogen exposure under more
151 reactive conditions (higher temperature or with atomic hydrogen). Under
152 more reactive conditions, other alternative methods for interaction such as
153 etching also become more favourable. In some materials, both chemiso-
154 rtion and etching are possible under different conditions. For example,
155 graphene will be etched in the presence of H_2 gas at 1000 °C and undergo
156 chemisorption at 27 °C in the presence of H-atoms dissociated from hydro-
157 gen silsesquioxane by an e-beam (Papon et al. (2015); Ryu et al. (2008)).

158 One unique mode of interaction between vdW materials and hydrogen is

159 intercalation, the process by which chemical species are introduced to the
160 vdW interlayer space. This was first demonstrated for graphite in 1840
161 when it was successfully intercalated electrochemically from a solution of
162 sulphuric acid (Schafhaeutl (1840)). Intercalation of graphene has also
163 been demonstrated under hydrogen gas exposure at <140 K (Grånäs et al.
164 (2016)). Hydrogen intercalation has been demonstrated in other vdW ma-
165 terials including GaSe, In_2Se_3 and InSe, typically via electrochemical means
166 (Kaminskii et al. (2005); Boledzyuk et al. (2011); Zhirko et al. (2007)).

167 More complicated behaviour can also be observed. For example, when
168 exposed to H-ions it might be expected that a 2D material can interact
169 via chemisorption, physisorption, intercalation or perhaps exhibit no in-
170 teraction altogether. However, for the material MoS_2 , it was shown that
171 hydrogen ions can penetrate into the inter-layer vdW gap and form molec-
172 ular hydrogen. This hydrogen then diffuses through the inter-layer space
173 to form hydrogen filled bubbles under the surface of the material (Tedeschi
174 et al. (2019)). This phenomenology demonstrates the complexity of inter-
175 actions possible between hydrogen and vdW materials.

176 **1.2.2 Diffusion and Permeability**

177 The roles played by diffusion and permeability must be considered when
178 investigating the interaction phenomenologies of hydrogen with vdW ma-
179 terials. In this instance, diffusion refers to the ability for species to move
180 within the layer planes of a material, whilst permeability refers to the abil-
181 ity for the species to move between them.

182 The permeability of hydrogen across atomic membranes is assessed via the
183 sealing of a small volume of gas by the membrane. The gas outside the

184 volume is then evacuated and the deflection in the membrane is probed
185 via atomic force microscopy. This process has been used to demonstrate
186 that graphene is impermeable to the majority of gases, including helium
187 but is slightly permeable to hydrogen (Bunch et al. (2008); Sun et al.
188 (2020)). However, hBN and MoS₂ are not permeable to hydrogen (Sun
189 et al. (2020)). The picture is different for protons and atomic hydrogen to
190 which graphene and hBN are both permeable (Hu et al. (2014); Lozada-
191 Hidalgo et al. (2016)). This is not true for all vdW materials. Notably,
192 MoS₂ is impermeable to thermal protons (Hu et al. (2014)). When suf-
193 ficient kinetic energy is imparted to the protons, it is possible for them
194 to cross the vdW layers, as in the case for MoS₂, where bubble formation
195 after proton beam exposure is only possible due to protons penetrating the
196 uppermost MoS₂ layer (Tedeschi et al. (2019)).

197 Diffusion within the vdW gap is far more favourable than the permeation
198 of hydrogen across vdW layers. In this instance, the diffusion of atomic
199 hydrogen within the layers has been demonstrated for graphite, hBN and
200 MoS₂ (Hu et al. (2018); An et al. (2019)), where atomic hydrogen is intro-
201 duced into the material from palladium and exhibits differential diffusion
202 rates for hydrogen and deuterium species.

203 **1.2.3 Chemical Conversion and Etching**

204 The chemical reactivity of hydrogen must be considered as part of any
205 interaction. In addition to the chemisorption of hydrogen, more transfor-
206 mative interactions are possible whereby the oxidation state, structure or
207 composition of the vdW material are modified. Graphite can react with
208 hydrogen to form methane when held at elevated temperatures (>1200 °C)
209 and when the products are continually removed (Gulbransen et al. (1965)).

210 When properly utilised, this reaction can be used to anisotropically etch
211 graphene (Yang et al. (2010)).

212 Reactions with vdW materials that produce stable hydrogen compounds
213 can be particularly pronounced. This is most notable with selenide and
214 sulphide compounds with which hydrogen can react to form the relatively
215 stable molecules H_2S and H_2Se . For these materials the presence of hydro-
216 gen has proved particularly useful in controlling material growth. Hydrogen
217 assisted chemical vapour deposition processes for MoS_2 , WS_2 , WSe_2 and
218 In_2Se_3 exhibit strong morphological and stoichiometric hydrogen depen-
219 dencies (Li et al. (2015); Sheng et al. (2017); DeGregorio et al. (2020);
220 Chang et al. (2006)).

221 **1.2.4 Photocatalysis**

222 Photocatalysis describes a process of using the energy of an incoming pho-
223 ton to overcome a kinetic barrier to a reaction and thus catalysing it. In
224 the instance of solar water splitting, the energy carried by the photon
225 also provides some or all of the thermodynamic impetus for the reaction.
226 The first demonstration of solar water splitting was made in 1972 utilising
227 TiO_2 connected to a platinum electrode and illuminated by ultraviolet light
228 (Fujishima and Honda (1972)). Whilst successfully generating hydrogen,
229 this process produces a low solar to hydrogen efficiency owing to the wide
230 band-gap of TiO_2 at 3.2 eV, meaning that 97 % of solar radiation energy
231 is unused (Eidsvåg et al. (2021)). Recent motivation to increase the effi-
232 ciency of green hydrogen production has seen renewed interest in this field
233 with the primary interest in finding materials capable of greater solar to
234 hydrogen efficiencies. Currently, the highest efficiencies have been achieved
235 for Rubidium decorated TiO_2 in a tandem architecture with an efficiency

236 of 19 % (Cheng et al. (2018)).

237 In this application, vdW materials show promise. This is due to their high
238 surface areas, good opto-electronic properties and tuneable band edges. As
239 such, research on vdW materials for solar water splitting has seen consider-
240 able interest. Currently, MoSe₂ holds the record for hydrogen production at
241 62,000 $\mu\text{mol h}^{-1} \text{g}^{-1}$ (Li et al. (2017b)). Additionally, theory predicts po-
242 tential efficiencies of 15 % in a single junction MoS₂/WSe₂ heterostructure
243 (Dalla Valle and Cavassilas (2022)).

244 1.2.5 Hydrogen Doping

245 Atomic hydrogen has long been used as a dopant in semiconducting mate-
246 rials for the modification of optoelectronic properties. Typically introduced
247 via implantation from a beam of hydrogen ions or from a hydrogen plasma.
248 The incorporation of hydrogen can introduce hydrogen associated states
249 into the material or passivate already existing states. In the case of the
250 traditional semiconductor Si, the introduction of hydrogen has been shown
251 to suppress the contribution of existing impurities due to its ability to act
252 as either a donor or acceptor (Van de Walle and Neugebauer (2006)).

253 In vdW materials the effect of hydrogen on the doping of a semiconductor
254 has also been investigated. In MoS₂, the exposure to hydrogen has been
255 demonstrated to reduce the n-type doping due to sulphur vacancies be-
256 coming occupied by hydrogen (Pierucci et al. (2017)). Unlike in traditional
257 semiconductors, for 2D vdW materials the substrate response to hydro-
258 gen treatment must also be considered. For example, the passivation of
259 Si dangling bonds by hydrogen greatly improves the carrier mobility of
260 graphene (Pallecchi et al. (2014)).

261 **1.2.6 Material Selection**

262 The vdW materials γ -InSe, ϵ -GaSe and SnS₂ were selected for investigation.
263 They were chosen for a number of factors, some of which were common to
264 all three, such as ready availability, and others specific to each material, as
265 detailed in the review of the literature for each material below.

266 **γ -InSe**

267 γ -InSe is a layered group III-VI semiconductor, which crystallises in the
268 R3m space-group with lattice constants $a = b = 4.002 \text{ \AA}$ and $c = 24.946 \text{ \AA}$
269 (Rushchanskii (2004)). The structure of γ -InSe is shown in Figure (1.1).
270 A number of attributes make γ -InSe an interesting material for hydrogen
271 interactions. The first is the nature of the vdW gap, which is large (3.6
272 \AA) and comprises approximately 40 % of the internal crystal volume be-
273 tween the centre of neighbouring Se planes (Zhirko et al. (2007)). This
274 large internal volume has previously been exploited in electrochemical in-
275 tercalation studies, which introduced hydrogen into the vdW gap up to x
276 $= 5$, where x is the number of hydrogen atoms per stoichiometric formula
277 unit (Zhirko et al. (2007)). It was suggested that this hydrogen is incorpo-
278 rated as a monolayer of molecular hydrogen within the vdW gap. There is
279 also significant scope for the modification of the optoelectronic properties
280 of γ -InSe via hydrogen incorporation due to the high interlayer electron
281 density in γ -InSe owing to the projection of P_z orbitals from the Se atoms
282 into the vdW gap (Li et al. (2019); Sun et al. (2018)). Experiments on hy-
283 drogen intercalated γ -InSe demonstrate this with an intercalation induced
284 modification to the exciton absorption spectra (Zhirko et al. (2007)).

285 The demonstration of successful electrochemical hydrogen intercalation of

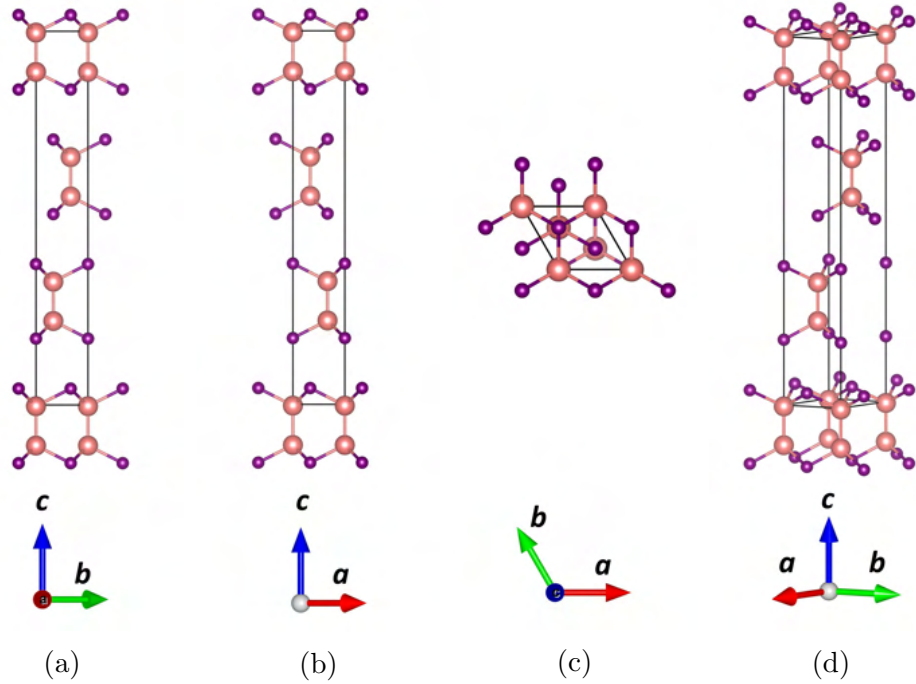


Figure 1.1: Unit cell of γ -InSe along the (a) a -axis, (b) b -axis, (c) c -axis and (d) at a slight angle. The pink and purple atoms are indium and selenium, respectively. The structure was generated using literature results (Rushchanskii (2004)).

286 γ -InSe raises the possibility of the stability of intercalated hydrogen from
 287 the gas phase and from accelerated hydrogen ions. This, coupled with
 288 the low Young's modulus and interlayer adhesion energy of γ -InSe (Zhao
 289 et al. (2019)), points to γ -InSe as being relatively stable to molecular hy-
 290 drogen incorporation within the vdW gap. The presence of Se in γ -InSe
 291 is important here and the ability for hydrogen to bond to Se must also be
 292 considered.

293 ϵ -GaSe

294 Much like γ -InSe, ϵ -GaSe is a layered group III-VI semiconductor. ϵ -GaSe
 295 crystallises in a $P\bar{6}m2$ space-group with unit cell parameters of $a = b =$
 296 3.749 \AA and $c = 15.907 \text{ \AA}$ (Wang et al. (2018)). The structure of ϵ -GaSe
 297 is shown in Figure (1.2). Much like γ -InSe, successful electrochemical interca-

298 lation of hydrogen into ϵ -GaSe has been demonstrated previously (Kamin-
 299 skii et al. (2005)). This intercalation modifies the adsorption spectra and
 300 dielectric properties of the material (Kaminskii et al. (2005, 2007)). As
 301 with γ -InSe, the successful intercalation of ϵ -GaSe raises the possibility of
 302 stable intercalation via molecular and atomic hydrogen.

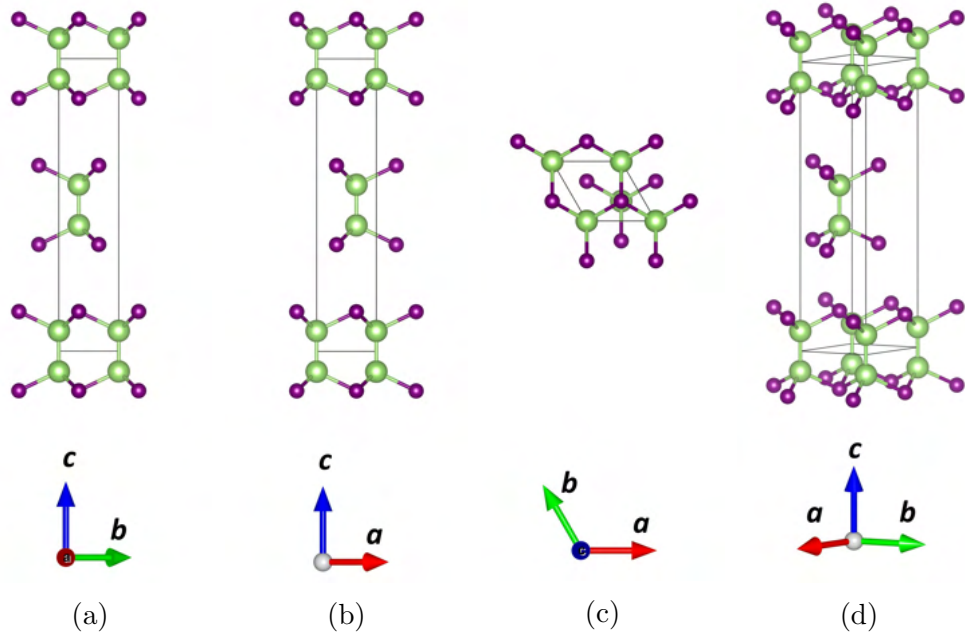


Figure 1.2: Unit cell of ϵ -GaSe along the (a) a -axis, (b) b -axis, (c) c -axis and (d) at a slight angle. The green and purple atoms are gallium and selenium, respectively. The structure was generated using literature results (Wang et al. (2018)).

303 The primary interest in ϵ -GaSe in this PhD arises from its photocatalytic
 304 properties. Namely, the size of its band gap at 2.02 eV and the optimal
 305 position of its band edges for hydrogen and oxygen evolution (Ferrer-Roca
 306 et al. (1999)). These properties of ϵ -GaSe have led to multiple demonstra-
 307 tions of GaSe as a phtotocatalytic material (Zappia et al. (2020); Meng
 308 et al. (2022)). The improvement in phtotocatalytic performance of ϵ -GaSe
 309 has also been demonstrated via modification by oxidation and the creation
 310 of local catalytic centres (D'Olimpio et al. (2020)).

311 The band structure of ϵ -GaSe grown by molecular beam epitaxy has been

312 reported previously via angle resolved photoemission electron spectroscopy
 313 (Eremeev et al. (2020)). These measurements demonstrate the Mexican
 314 hat like valence band in single tetralayer GaSe (Chen et al. (2018b)). This
 315 is of interest as ring shaped valence band maxima are expected to produce
 316 a singularity in the electronic density of states. These singularities have the
 317 potential to for wide application such as in thermoelectrics (Wickramaratne
 318 et al. (2014)). The measurements also indicate the valence band structure
 319 of bulk GaSe with a hole effective mass of $0.9 m_e$ (Eremeev et al. (2020)).

320 SnS_2

321 SnS_2 is a IV-VI semiconductor with a structure notably different to that of
 322 InSe and GaSe. SnS_2 has a structure resembling MoS_2 and crystallises in a
 323 P-3m1 space-group with lattice constants $a = b = 3.64 \text{ \AA}$ and $c = 5.92 \text{ \AA}$
 324 (Yang et al. (2002)). The structure of SnS_2 is shown in Figure (1.3). Unlike
 325 InSe and GaSe, the unit cell of SnS_2 only extends over one vdW layer and
 326 within each layer all of the Sn atoms lie in the same plane.

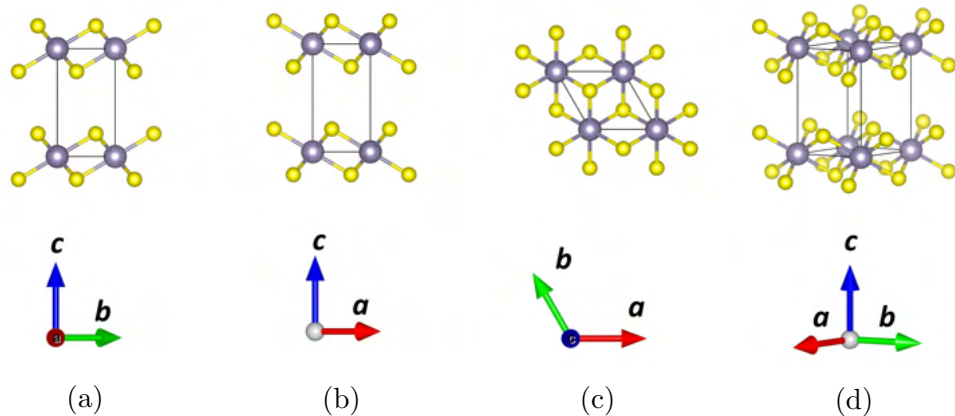


Figure 1.3: Unit cell of SnS_2 along the (a) a -axis, (b) b -axis, (c) c -axis and (d) at a slight angle. The purple and yellow atoms are tin and sulphur, respectively. The structure was generated using literature results (Yang et al. (2002)).

327 The chemical reactivity of hydrogen with sulphur is important in the case of

328 SnS₂. The ability for Sn to exist in multiple different stable oxidation states
329 means that multiple vdW systems are present in the tin-sulphur system.
330 This includes SnS, a vdW material which forms in the Pnma space-group.
331 This quality of the tin-sulphur system has been used to produce SnS/SnS₂
332 heterostructures via a variety of different methods. One method involves sul-
333 phurisation whereby sulphur is introduced to SnS to convert it into SnS₂
334 (Li et al. (2021)). Alternatively, the reverse is also possible, whereby sul-
335 phur is removed from SnS₂ to convert it into SnS (Kim et al. (2018)).
336 The SnS/SnS₂ heterostructures resulting from these conversions have seen
337 successful application as heterojunction diodes (Kim et al. (2018)), NO₂
338 detectors (Sun et al. (2019)), and as other opto-electronic devices (Li et al.
339 (2018)).

340 Hydrogen has been shown to modify the electronic properties of SnS. When
341 treated with H-plasma, there is a marked reduction in the hole carrier
342 density of SnS and an increase in hole mobility (Xiao et al. (2018)). This
343 change is a result of H atoms compensating for Sn vacancies.

344 **1.3 Scope**

345 The Motivation and Literature Review sections discuss the context of hy-
346 drogen vdW materials interactions both in fundamental and applied con-
347 texts. The scope section covers the new results gained over the course of
348 this PhD and describes the thesis structure as follows. Chapters 2 and 3
349 describe the relevant theoretical concepts and experimental methods, re-
350 spectively. The results of the conducted research are then described in
351 Chapters 4, 5 and 6, and briefly summarised in sections 1.3.1 (Chapter 4),
352 1.3.2 (Chapter 5) and 1.3.3 (Chapter 6). A summary of the results and

353 future prospects are then provided in Chapter 7.

354 **1.3.1 Hydrogen - Tin Sulphides Interaction**

355 It is known that hydrogen has the ability to reduce the vdW material
356 SnS to Sn, altering the oxidation state of Sn and decreasing the S content
357 (Sneed and Brasted (1958)). This raises the prospect of utilising hydrogen
358 to modify the stoichiometry of other Sn-S materials. Notably, the vdW
359 semiconductors SnS₂ and SnS.

360 To assess whether hydrogen can modify the properties of SnS₂ and SnS,
361 samples of SnS₂ were exposed to both H₂ and H-ions. The resulting inter-
362 actions were found to modify the crystal stoichiometry and the oxidation
363 state of Sn. In the instance of H-ion exposure, SnS₂ was reduced to both
364 SnS and Sn. With H₂ exposure, only SnS was produced.

365 Remarkably, the conversion of SnS₂ to SnS by H₂ resulted in the formation
366 of a well ordered SnS/SnS₂ heterostructure. The SnS and SnS₂ layers are
367 well aligned, continuous, and have a uniformity stretching across ~ 10
368 μm , whilst retaining a strong optical response. This presents a new and
369 highly scalable approach to producing SnS/SnS₂ heterostructures and was
370 reported in Felton et al. (2022).

371 **1.3.2 Hydrogen - Indium Selenide Interaction**

372 The high flexibility, low interlayer adhesion energy, and high electron den-
373 sity in the vdW gap of γ -InSe suggests it should be notably modified by
374 hydrogen intercalation. To investigate this and overcome barriers to hydro-
375 gen entering the vdW gap, InSe was exposed to hydrogen from a Kaufman

376 ion source. The resulting samples were found to contain atomic hydro-
377 gen bonded to the Se in InSe, which induced a corresponding change in its
378 phonon modes. Molecular hydrogen exposure of InSe was also conducted to
379 test for hydrogen intercalation from the gas phase. In bulk InSe samples,
380 no hydrogen uptake was observed. However, in powdered InSe samples
381 hydrogen uptake of up to 0.2 wt% was measured.

382 Theoretical investigations describe the extent to which the InSe inter-layer
383 space would have to expand in the case of hydrogen incorporation and
384 the resulting phonon modifications. In the case of molecular hydrogen
385 incorporation, the vdW gap would need to expand by 2.5 Å. The increased
386 interlayer separation reduces the strength of the interlayer coupling and as
387 such the phonon modes take on a more monolayer like character, suggesting
388 an exciting means to modify the properties of γ -InSe. The work regarding
389 the H-ion exposure and theoretical results is reported in Felton et al. (2020).

390 **1.3.3 Gallium Selenide for Photocatalysis**

391 Preliminary experiments of the interaction between GaSe and both atomic
392 and molecular hydrogen yielded no pronounced changes. Instead, given the
393 favourable band gap and band edge positions of GaSe for photocatalysis,
394 investigations into its photocatalytic ability for solar water splitting were
395 conducted. Namely, water exposure of GaSe induces its oxidation. This
396 has been shown to improve its photocatalytic performance but without
397 consideration on how the electronic band structure of GaSe is modified by
398 the oxidation.

399 The oxidation of GaSe was observed by near ambient pressure X-ray pho-
400 toelectron spectroscopy and atomic force microscopy. The valence band

401 structure of oxidised GaSe was then observed in both thick and thin flakes
402 using angle resolved photoemission spectroscopy. Experiments to-date have
403 established the carrier effective masses in both bulk and 6-layer thick GaSe.
404 Additionally, 3 relatively flat bands were observed near the valence band
405 maximum in 6-layer thick GaSe, an observation relevant to the application
406 of photocatalysis.

Chapter 2

Theoretical Concepts

This chapter covers the theoretical concepts relevant to the phenomena investigated in the course of this PhD. These concepts include: The origin of the electronic and phonon dispersions in semiconducting materials, the rules governing the electronic band alignment in heterostructures and photocatalytic systems, and key thermodynamic and kinetic theories.

Contents

2.1	Electronic and Phonon Dispersions of vdW Materials	23
2.1.1	Electronic Band Structure	23
2.1.2	Vibrational Structure	30
2.2	Energy Band Alignment	32
2.3	Thermodynamics and Kinetics	35
2.3.1	Thermodynamics	35
2.3.2	Kinetics	37

1 **2.1 Electronic and Phonon Dispersions of** 2 **vdW Materials**

3 The opto-electronic properties of a semiconductor are governed by its elec-
4 tronic band structure and phonon dispersion. The first of these describes
5 the electronic energy-momentum relation for a material and is relevant
6 when considering its effective carrier masses, the size of its band gap and
7 its electronic density of states. The phonon dispersion of a material instead
8 describes its structural vibrational modes, as determined by the crystal lat-
9 tice and its symmetries. This section describes the origin of both of these
10 dispersions and describes their behaviour in vdW materials.

11 **2.1.1 Electronic Band Structure**

12 A neutral atom held in isolation contains an equal number of protons and
13 electrons. The protons are concentrated in the atom's nucleus and the
14 electrons are distributed in concentric shells around it. As fermions, the
15 electrons cannot all occupy the same lowest energy state and instead they
16 fill up, in sequence, the concentric shells, following the Aufbau principle
17 (Atkins et al. (2014)). The electronic orbitals are spherical harmonic so-
18 lutions of the Schrödinger equation, modified by the interaction with the
19 other atomic orbitals (Elliott (1998)).

20 The atomic picture of electrons doesn't hold for solid materials as it confines
21 the electrons to an individual atom and as such fails to account for macro-
22 scopic properties, such as the electrical conductivity. One approximation
23 to the behaviour of electrons in bulk material is the free electron model.
24 This model considers the electrons as existing in a uniform potential with

25 a parabolic electronic energy dispersion given by

$$E(\mathbf{k}) = \frac{\hbar^2 \mathbf{k}^2}{2m^*}, \quad (2.1)$$

26 where $E(\mathbf{k})$ is the energy of an electron with wavevector \mathbf{k} , \hbar is the reduced
 27 Planck's constant and m^* is the electron effective mass (Klingshirn (2012)).
 28 This model is successful in describing some of the behaviours of electrons
 29 within a material, especially for metals. However, it fails to explain the
 30 conductivity behaviour of non-metallic materials such a silicon, or to take
 31 into account the influence of the crystallographic lattice on electronic prop-
 32 erties.

33 A more accurate description of semiconductors is given by the Bloch ap-
 34 proach. In this model, the electrons experience a periodic spatially-varying
 35 potential due to the presence of a crystallographic lattice. The electronic
 36 wavefunction is then given by the product of a plane wave and a func-
 37 tion with the same periodicity as the lattice (Elliott (1998)). The Bloch
 38 approach considers a periodic lattice with atoms positioned at $\mathbf{R} = u\mathbf{a}$,
 39 where u is an integer. A translation from point \mathbf{r} to $\mathbf{r} + \mathbf{a}$ is then given by

$$\psi_{\mathbf{k}}(\mathbf{r} + \mathbf{a}) = e^{i\mathbf{k}\cdot\mathbf{a}}\psi_{\mathbf{k}}(\mathbf{r}), \quad (2.2)$$

40 where $\psi(\mathbf{r})$ is the wavefunction and \mathbf{k} describes the reciprocal space vector.
 41 For this translational relation to hold, the wavefunction must share a peri-
 42 odicity with the underlying lattice. The wavefunction at point \mathbf{r} is then
 43 given by

$$\psi_{\mathbf{k}}(\mathbf{r}) = e^{i\mathbf{k}\cdot\mathbf{r}}u_{\mathbf{k}}(\mathbf{r}), \quad (2.3)$$

44 where $u_k(\mathbf{r})$ is a function with the same periodicity as the underlying lattice
 45 (Elliott (1998)).

46 In the nearly free electron model, the interaction between the electrons and
 47 atoms is assumed very weak. In this instance, the free electron model is
 48 modified so that the solutions are consistent with the Bloch description.
 49 At the edge of the Brillouin zone, solving for the electron wavefunction at
 50 position x gives two solutions,

$$\psi^+ \propto (e^{iGx/2} + e^{-Gx/2}) \propto \cos(Gx/2), \quad (2.4)$$

$$\psi^- \propto (e^{iGx/2} - e^{-Gx/2}) \propto \sin(Gx/2), \quad (2.5)$$

51 where G is the reciprocal lattice vector. In a periodic potential, which
 52 shares periodicity with the wavefunction, these two solutions are separated
 53 in energy. Physically this is due to one having a greater electron density
 54 positioned on the atoms, whilst the other has a greater electron density
 55 between them. The separation in energy of the two wavefunctions cor-
 56 responds to a band gap within the material. The size of the band gap
 57 is composition and temperature dependent. The temperature dependence
 58 arises due to the changing atomic separations with temperature. At lower
 59 temperatures the material contracts, the inter-atomic space reduces and
 60 the band gap increases. Additionally, the reduced thermal fluctuations of
 61 the lattice at lower temperatures modifies the band gap.

62 Generally, in bulk vdW materials there is a significant structural anisotropy
 63 with covalent bonds directed along the a and b axes whilst vdW interactions
 64 dominate along the c -axis. Correspondingly, the unit cell along the c -axis

65 is typically larger than along either the a or b axes. This is reflected in both
66 an anisotropy in the electrical conductivity and in the Brillouin zone. Upon
67 exfoliation to produce 2D vdW materials, the lattice periodicity is broken
68 once the dimensions of the crystal are of a comparable scale to the coherent
69 electron wavefunction. By analogy to an infinite quantum well, the energy
70 gaps between allowed standing waves of the electron increases as the well
71 thickness decreases. In a real vdW system, the reduction in electronic
72 screening also plays a role in the band gap energy and the stability of
73 phenomena such as excitons. These effects combine to increase the band
74 gap energy with reducing thickness.

75 The real-space symmetry of a crystal lattice determines the properties of
76 its electronic band structure. The reciprocal image of the primitive unit
77 cell is termed the 1st Brillouin zone. The edges of the 1st Brillouin zone
78 are then high symmetry directions, i.e. lie at points at which the electron
79 wavevector is commensurate with the real-space lattice. As the wavevector
80 of an electron relates to its momentum via $\mathbf{p} = \hbar\mathbf{k}$, and all wavevectors
81 outside the 1st Brillouin zone are degenerate with states inside it, the elec-
82 tron momentum-energy dispersion of a material can be defined fully inside
83 the 1st Brillouin zone.

84 The presence of bands in solid materials can be understood as a conse-
85 quence of orbital hybridisation. When two atoms, each with one electron,
86 are brought together their electronic energy levels will be modified. The
87 original electron orbital is split into two levels associated with the bond-
88 ing and antibonding configurations. When a third atom is introduced a
89 third level will appear. In fact, with N atoms in the system, N levels
90 will be produced from the single initial energy level (Atkins et al. (2014)).
91 These energy levels are distributed over a finite energy window and in the
92 case of a typical solid material where N is very large (1 mole = 6×10^{23}),

93 the separation between the energy levels becomes sufficiently small to be
94 described as a continuous function. This function, the density of states
95 ($D(E)$), then gives the number of states $N(E)$ between E and $E + \delta E$ as
96 $N(E) = D(E)\delta E$.

97 **Density Functional Theory**

98 In real materials, the calculations based on the nearly free electron model
99 or by the linear combination of atomic orbitals fall short of providing an
100 accurate quantitative description of the electronic band structure. In-
101 stead, what is required are highly accurate computational models which
102 consider the electronic behaviour in the real crystal structure. However,
103 the computational cost of performing the full quantum mechanical calcu-
104 lation is prohibitively expensive, with the coupled cluster single double
105 (triple) (CCSD(T)) method, being one of the most accurate, scaling as N^7
106 (Harrison (2003)). This limits its use to small systems of extremely high
107 scientific interest. To overcome this issue, a way to approximate the full
108 quantum mechanical solution is utilised. The most common approach to
109 this is density functional theory (DFT), which reduces the problem to 6
110 dimensions (Harrison (2003)).

111 DFT is based on a result proved by Hohenberg and Kohn that instead of
112 solving for the wavefunctions of all the individual electrons, a generalised
113 electronic density is used which then provides the correct solution to the
114 Hamiltonian with an additive constant (Hohenberg and Kohn (1964)). This
115 results in the expression

$$\delta \left[E[\rho] - \mu \left(\int \rho(\mathbf{r}) d\mathbf{r} - N \right) \right] = 0, \quad (2.6)$$

116 where $E[\rho]$ is the energy functional of the trial electron density (ρ), μ is
 117 the chemical potential, \mathbf{r} is the position and N is the number of electrons
 118 in the considered volume. The energy functional is then given by

$$E[\rho] = T[\rho] + V_{ext}[\rho] + V_{ee}[\rho], \quad (2.7)$$

119 where $T[\rho]$ is the kinetic energy functional, $V_{ext}[\rho]$ is the external potential
 120 functional, and $V_{ee}[\rho]$ is the electron-electron interaction functional (Harri-
 121 son (2003)). The exact forms of these functionals are unknown, but several
 122 approximate solutions are commonly used allowing for the application of
 123 DFT to real systems (LDA, GGA, Meta-GGA, Hybrid functionals...). The
 124 different functionals vary in their ability to successfully predict ρ and lend
 125 themselves to different systems. The selection of the correct functionals
 126 is then determined by the agreement with experimental results from the
 127 same or similar systems.

128 Shown in Figure (2.1a) is the DFT generated electronic band structure of ϵ -
 129 GaSe. The changes in band structure due to the reducing of dimensionality
 130 are apparent upon comparison to the monolayer band structure shown in
 131 Figure (2.1b). Evident is the increased size of the band gap and the emer-
 132 gence of an inverted Mexican hat-like valence band maximum. The size
 133 of the band gap is underestimated at 1.21 eV compared to experimentally
 134 measured 2.02 eV (Ferrer-Roca et al. (1999)).

135 As ARPES does not conserve the k_z momentum component, but instead
 136 produces a sum over that vector, the experimental data displayed in Fig-
 137 ure (2.1) shows the dispersion's along the $\bar{\Gamma}\bar{K}$ and $\bar{\Gamma}\bar{M}$ directions. The bar
 138 notation denotes that this data is a projection over the Brillouin zone. In
 139 Figures (2.1e) and (2.1f) the Brillouin zone and projected Brillouin zone

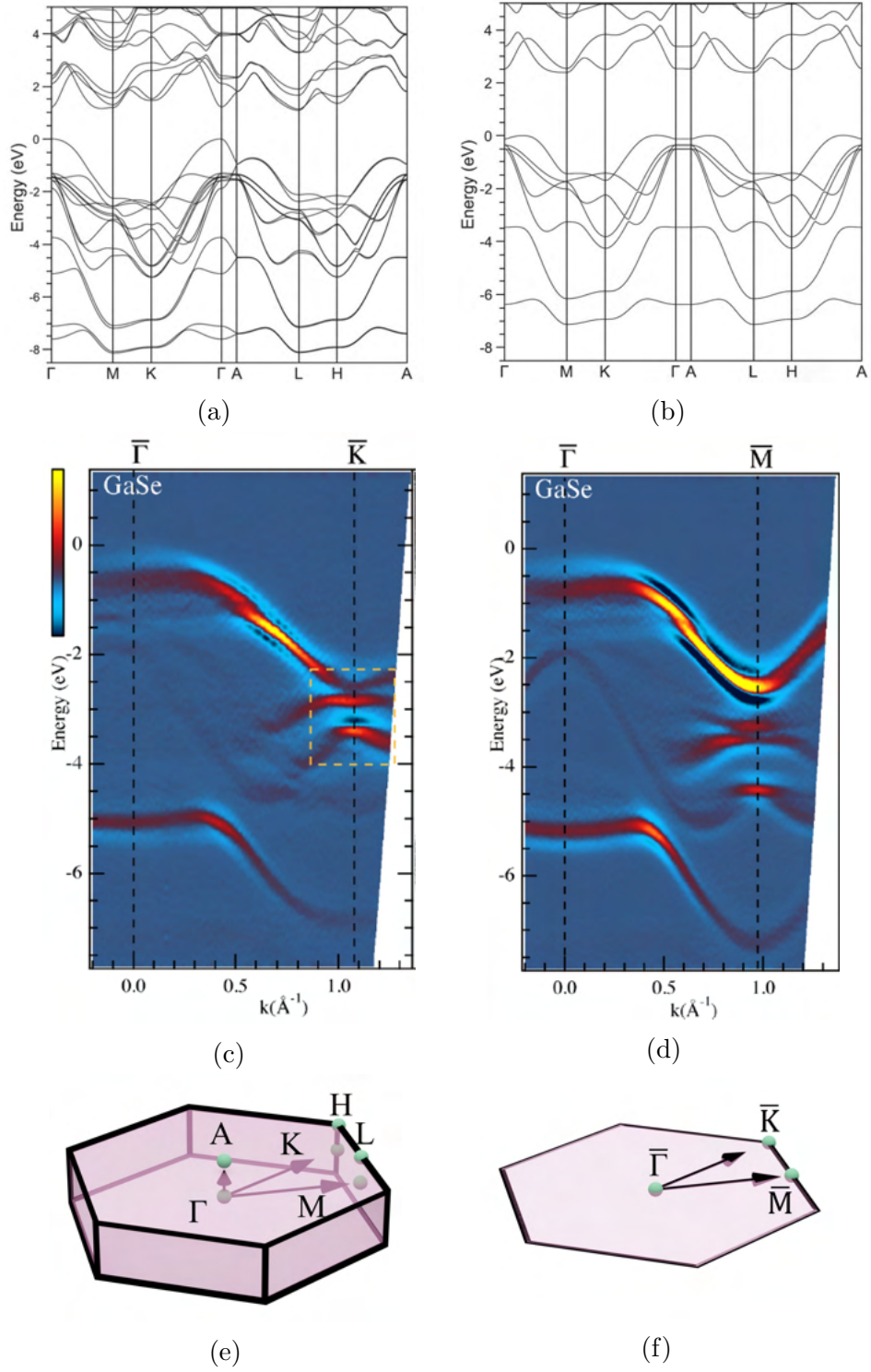


Figure 2.1: DFT generated electronic band dispersions of (a) bulk and (b) monolayer ϵ -GaSe, reproduced from Rybkovskiy et al. (2011). Valence band dispersions of bulk ϵ -GaSe determined via ARPES along the (c) $\bar{\Gamma}\bar{K}$ and (d) $\bar{\Gamma}\bar{M}$ directions, reproduced from Eremeev et al. (2020). The (e) full and (f) project Brillouin zone of ϵ -GaSe.

140 of ϵ -GaSe are shown, respectively. Demonstrated is the use of the bar no-
 141 tation when applied to ϵ -GaSe. As ARPES does not conserve the the k_z
 142 momentum component, the dispersion along k_z must be considered when
 143 making comparisons between an experimentally and theoretically deter-
 144 mined dispersion.

145 **2.1.2 Vibrational Structure**

146 As is the case for electronic band structures, the symmetry of a crystal lat-
 147 tice has pronounced effects on the coherent vibrational modes of a material.
 148 The lattice restricts the allowed vibrational modes to specific frequencies
 149 for a given wavevector, described by the materials phonon dispersion. In
 150 the long wavelength limit, the dispersion relation for longitudinal acoustic
 151 modes on a 1D diatomic chain is given by

$$\omega_k^2 \simeq \frac{K a^2 k^2}{2(M + m)}, \quad (2.8)$$

152 where ω_k is the frequency, K is the interatomic spring constant, a is the
 153 lattice constant and M and m are the masses of the two atoms (Elliott
 154 (1998)). For optical longitudinal modes the dispersion relation in the long
 155 wavelength limit is given by

$$\omega_k^2 \simeq \frac{2K(M + m)}{Mm}. \quad (2.9)$$

156 These modes have a non-zero frequency at a wavevector of zero. By con-
 157 trast, for the acoustic modes, the frequency tends to zero with the wavevec-
 158 tor. By comparison with Equation (2.1) for the free electron dispersion
 159 relation, the vibrational modes have a lower energy for a given wavevector.

160 As such, generated phonons can transfer significant momentum for a small
161 amount of energy.

162 The full quantum mechanical description of vibrations in a solid results
163 in the quantisation of the vibrational modes. These quantised modes are
164 known as phonons. When a crystal interacts with external fields, such as
165 via photons, its vibrational properties (e.g. Raman Spectra) are modi-
166 fied/probed via an interaction with quantised phonons. As such, the en-
167 ergy difference in the incoming and outgoing energy of a photon during
168 Raman spectroscopy is modified by a well defined energy, determined by
169 the phonon. Photons can transfer only a little momentum to a crystal
170 due to their dispersion relation, $E = pc$, where the momentum p of the
171 photon is small due to the speed of light c being large. As phonons can
172 transfer significant momentum and their energies are relatively small, the
173 modification to the photon energy is small, even if the photon is scattered
174 by 180° .

175 In vdW materials the interlayer vdW forces are much weaker than then
176 intralayer covalent ones. As such, the spring constant, K , is lesser for the
177 interlayer vibrations. Consequently, the interlayer phonon modes would
178 be expected to have a flatter dispersion than their intralayer counterparts.
179 The structure of vdW materials results in a high thermal anisotropy. For
180 example, the thermal conductivity of graphite is $100\times$ greater along the
181 basal plane than normal to it (Balandin (2011)).

182 As with the determination of electronic band structure in real materials,
183 the determination of the vibrational dispersion for a material requires com-
184 putational methods. DFT is popular for this purpose (Mohr et al. (2007)).

185 **2.2 Energy Band Alignment**

186 When two semiconducting materials are placed into contact with one an-
 187 other, the electronic band structure of each is modified at the interface.
 188 The exact nature of this modification is dependent on the relative posi-
 189 tions of the valence and conduction bands of the materials, the position of
 190 their Fermi levels, the dielectric permittivity in each of the materials and
 191 the charge carrier density.

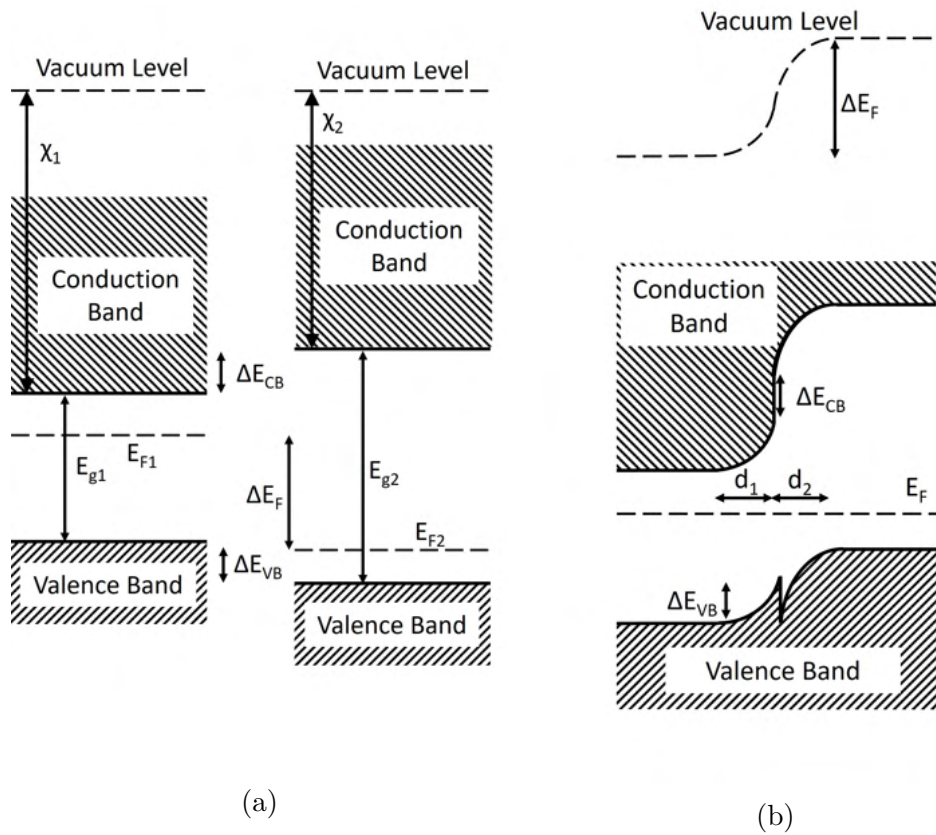


Figure 2.2: Sketches of (a) the vacuum level aligned valence and conduction bands in two separate semiconducting materials and (b) the same materials brought into contact, illustrating the band bending at a heterostructure interface.

192 For two semiconducting materials with known band alignments, the An-
 193 derson rule can be used to determine their behaviour at the interface. The
 194 Anderson rule states that the vacuum level of the two materials must be
 195 aligned. The electron affinities and band gaps are then used to determine

196 the band offsets at the interface. Figure (2.2a) shows the band edge posi-
 197 tions of two materials aligned to the vacuum level. Utilising the electron
 198 affinities (χ_1, χ_2) and the band gap energies (E_{g1}, E_{g2}), the offsets in the con-
 199 duction (ΔE_{CB}) and valence (ΔE_{VB}) bands can be determined. When the
 200 materials are brought together, a bending of the bands of both materials
 201 occurs. The difference in the Fermi levels of the two materials (ΔE_F) deter-
 202 mines the extent of this bending and correspondingly the size of the built
 203 in potential of the heterostructure. The direction of the bending will act
 204 to align the Fermi levels of the two materials across the interface, with the
 205 spatial distribution of the bending determined by the charge carrier den-
 206 sity in each material and their dielectric permittivities. This exact band
 207 distribution is determined via the Poisson equation

$$\nabla^2 \phi = -\frac{\rho}{\epsilon}, \quad (2.10)$$

208 where ϕ is the electric potential, ρ is the charge density and ϵ is the permit-
 209 tivity of the material. The displacement of charge between the materials
 210 should be sufficient to produce a voltage, which aligns the two Fermi lev-
 211 els, whilst retaining overall charge neutrality. Far from the junction, the
 212 two materials should behave the same as before they were brought to-
 213 gether. The conduction and valence band offsets present before bringing
 214 the materials together are present at the heterostructure interface as band
 215 discontinuities (Klingshirn (2012)).

216 A similar change can occur at the surface of a semiconductor when exposed
 217 to water. When held separately, the water species contain filled and unfilled
 218 electronic orbitals. The highest occupied molecular orbital (HOMO) and
 219 the lowest unoccupied molecular orbital (LUMO) have well defined energies
 220 relative to the vacuum level. The alignment of the vacuum level across

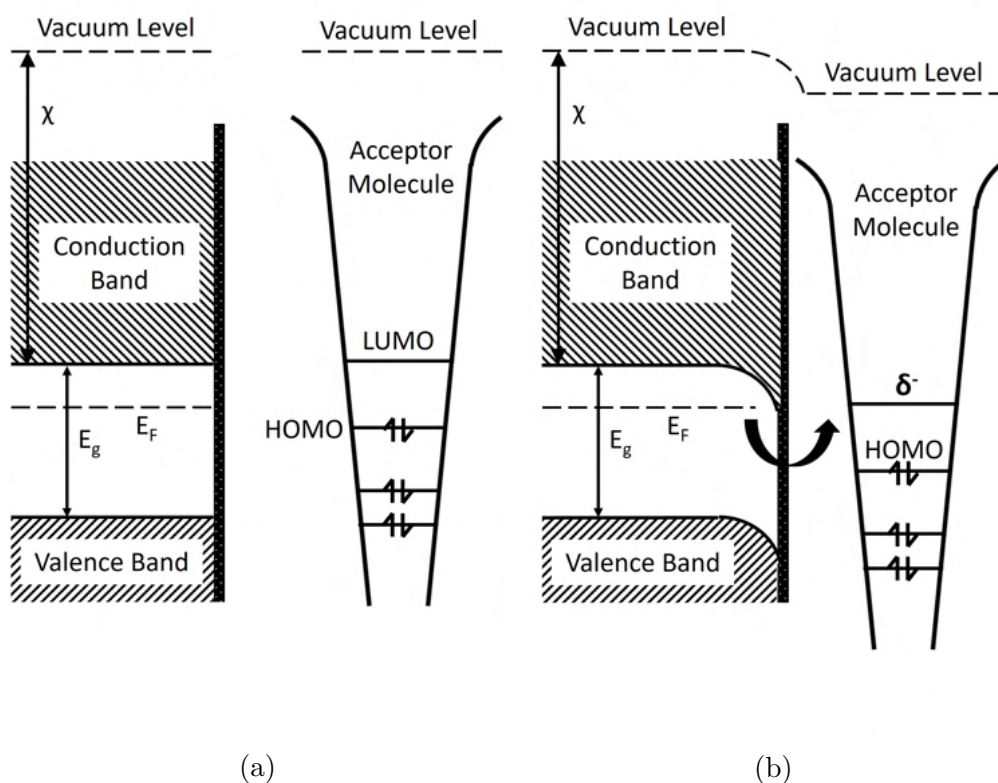


Figure 2.3: Sketches of the band alignment of an n-type semiconductor and a small acceptor molecule (a) when held apart and (b) when the acceptor molecule is adsorbed on the semiconductor.

221 the semiconductor and molecule then determines the offset between the
 222 semiconductor bands and the molecular orbitals (Figure (2.3a)). When
 223 a molecule of water is adsorbed onto the surface of a semiconductor, a
 224 small transfer of charge to or from the molecule can take place (Jiang et al.
 225 (2017)). The direction of this transfer is dependent on the conductivity
 226 type of the semiconductor and the position of its Fermi level relative to
 227 the either the H^+/H_2 or H_2O/O_2 redox potentials. In an n-type conductor,
 228 the Fermi level aligns to the LUMO of the slightly positive water species
 229 (Figure (2.3b)). The same occurs in p-type conductors, but with the Fermi
 230 level aligning to the HOMO of the negative species. The alignment induces
 231 a bending of the bands in the semiconductor and the establishment of a
 232 Helmholtz layer in the adsorbed water. The depletion layer established

233 in the semiconductor is typically much larger than the thickness of the
234 Helmholtz layer due to enhanced screening in the semiconductor (Jiang
235 et al. (2017)).

236 **2.3 Thermodynamics and Kinetics**

237 The chemical changes in vdW materials induced by hydrogen or the pho-
238 tocatalytic splitting of water by a vdW material are dependant on both
239 thermodynamic and kinetic factors. These factors are typically material
240 specific but follow general laws, patterns and principles, as detailed below.

241 **2.3.1 Thermodynamics**

242 The chemical conversion or modification of a material by hydrogen can
243 only proceed if thermodynamically favourable. Ascertaining whether a
244 particular process meets this requirement can be accomplished via an un-
245 derstanding of thermodynamic laws and their application to a particular
246 system. In particular, it is compatibility with the second law which details
247 the requirement for the entropy of an isolated system to increase or remain
248 constant. When a system is in contact with an environment at a constant
249 temperature, this can be expressed mathematically as

$$0 \geq Q - \Delta S_s T = \Delta G, \quad (2.11)$$

250 where Q is the heat energy flowing from the environment to the system,
251 ΔS_s is the entropy change of the system, T is the temperature and ΔG is
252 the change in the Gibbs free energy. Based on the inequality statement of

253 the Second Law, when ΔG is negative a process can proceed; when ΔG is
254 equal to zero, the process is reversible; and when ΔG is positive the process
255 cannot proceed spontaneously.

256 The size of ΔG determines the thermodynamic impetus of a process and its
257 relation to Q , ΔS_s and T indicates the effect each of these variables have on
258 its favourability. A negative value of Q , i.e. the process is exothermic and
259 releases energy, increases the favourability. When T is equal to 0 K, only
260 Q determines the favourability of the process and it is the same as ΔG .
261 When the temperature is increased, the entropy of the process increases in
262 importance relative to Q . As such, if ΔS_s is positive, then increasing the
263 temperature will decrease ΔG and make the process more favourable. The
264 reverse is true if ΔS_s is negative.

265 There are four possible combinations of ΔS_s and Q . In the first, ΔS_s is
266 negative and Q is positive; in this instance the process is unfavourable
267 at all temperatures. In the second, ΔS_s is positive and Q is negative
268 and the process is favourable at all temperatures. In the third, ΔS_s and
269 Q are positive. In this case, below a critical temperature the process is
270 unfavourable and above the critical temperature the process is favourable.
271 In the fourth combination, ΔS_s and Q are negative. In this instance, the
272 process is favourable below the critical temperature and unfavourable above
273 it. Adsorption type processes generally fall into the fourth category, whilst
274 decomposition type processes tend to fall into the third category.

275 Both bulk and 2D vdW layers can exist in a stable configuration when
276 held under the same conditions. This is owing the relatively small adhesive
277 energies between layers due to vdW forces. If vdW layers were held together
278 by covalent forces, the adhesion energies would be of the order of $\sim 100\times$
279 times greater (Richardson (1977); Brenner et al. (2002)). The 2D material

280 is also expected to have a greater entropy than its bulk counterpart as flakes
281 can be arranged in random distributions. As such, the value of the Gibbs
282 free energy in the vdW system is far lower than for that of covalent systems.
283 This lower thermodynamic penalty to exfoliation explains the stability of
284 exfoliated vdW materials. The ability for both bulk and 2D vdW material
285 to coexist is then explained by the presence of kinetic barriers between the
286 two.

287 Present in real crystals are defects. The creation of these defects are inher-
288 ently energetically unfavourable as they push a structure away from the en-
289 ergetically ideal configuration. Their presence is therefore made favourable
290 by their entropic contribution, pushing the crystal away from a uniform
291 configuration and as such increasing its entropy. The entropic contribution
292 of a single vacancy decreases with increasing vacancy density, whereas the
293 energy of their creation is more constant. As such, there is a thermodynam-
294 ically favourable concentration of vacancies in a crystal associated with a
295 minimum in the Gibb's free energy. This preferred concentration increases
296 with temperature (Elliott (1998)).

297 **2.3.2 Kinetics**

298 Although the thermodynamic description of a process yields information
299 on its feasibility and spontaneity, it often won't predict whether the pro-
300 cess will take place. For example, despite graphite being the most stable
301 form of carbon and the transition between diamond and graphite having a
302 negative ΔG , diamond will not spontaneously transform into graphite at
303 room temperature. The transition is prevented by kinetic barriers (Popov
304 et al. (2019)).

305 Kinetic limitations are due to the need for a system to pass through a
306 transition state or states in order to rearrange the material into the con-
307 figuration found in the end product. These transition states will typically
308 have a greater energy than either the initial or final state and as such suffi-
309 cient energy is required to overcome the barrier presented by the transition
310 state. This energy is typically provided in the form of thermal energy but
311 can also be provided in other forms, e.g. light. There may be more than
312 one possible transition state, with the most favourable path from initial
313 to final state depending on conditions or the presence of a catalyst. This
314 is true for Z-scheme solar water splitting which lowers the barrier to the
315 water evolution reaction over the single step process by aligning the va-
316 lence and conduction bands of two materials in such a way to maximise
317 the thermodynamic potential of photogenerated holes and electrons. This
318 is achieved by utilising electrons/holes photogenerated in the cathode/an-
319 ode for hydrogen/oxygen evolution and allowing the recombination of holes
320 in the cathode with electrons in the anode. This comes with the benefit of
321 increasing the number of electrons in the cathode and holes in the anode
322 with sufficient energy for the reaction. This effectively lowers the energetic
323 barriers for hydrogen and oxygen evolution, catalysing the reaction (Ng
324 et al. (2020)).

325 Catalysts act to lower the kinetic energy barriers to a reaction. As such,
326 they increase the rate of the reaction by increasing the proportion of par-
327 ticles (electrons/holes/reactants) with sufficient energy to overcome the
328 kinetic barrier. Given that the energetic distribution of particles follows
329 an exponential Boltzman-like distribution, even small changes to the re-
330 action kinetic barrier can significantly modify the reaction rate. At room
331 temperature the decreasing of the activation barrier from 76 kJ mol^{-1} to
332 57 kJ mol^{-1} for the decomposition of hydrogen peroxide in the presence

333 of an iodine catalyst results in a ~ 2000 fold increase in the reaction rate
334 (Atkins et al. (2014)).

335 Defects on the surface of a material can be engineered to act as catalytic
336 centres for a reaction. This is often the case for reactions where the surface
337 adsorption or desorption of species acts as the rate limiting step such as
338 catalytic water splitting (Laursen et al. (2012)). By introducing sites with
339 different adsorption energies, the rates of these processes can be modified.
340 The lifetime (τ) of a molecule on surface is given by

$$\tau = \tau_0 \exp(-E_a/RT), \quad (2.12)$$

341 where τ_0 is a constant, E_a is the adsorption energy per mole, R is the
342 gas constant and T is temperature (Atkins et al. (2014)). By introducing
343 sites which optimise the adsorption/desorption rates of reactants and/or
344 products, the overall rate can be optimised.

Chapter 3

Materials and Methods

This chapter discusses the materials and methods used over the course of this PhD. The materials section describes the growth methods used to produce the vdW materials and the techniques used to prepare the materials in a state suitable for experimentation. The methods section covers the techniques utilised for hydrogen exposure and the means by which hydrogen-induced changes were determined and assessed.

Contents

3.1	Materials	42
3.1.1	Material Growth	42
3.1.2	Sample Preparation	44
3.2	Experimental Methods	45
3.2.1	Sieverts	46
3.2.2	Kaufman Ion Source	48
3.2.3	Optical Spectroscopy	50
3.2.4	Electron Spectroscopy	54
3.2.5	Additional Techniques	62

1 **3.1 Materials**

2 The materials used to gather the results presented in this thesis are primar-
3 ily the III-VI layered vdW semiconductors InSe and GaSe and the IV-VI
4 layered semiconductor SnS₂. This section covers the growth methods used
5 to produce these materials. This section then goes on to describe the meth-
6 ods used to prepare the samples for investigations of their interactions with
7 hydrogen.

8 **3.1.1 Material Growth**

9 The vdW materials used were grown via two primary methods, the Bridg-
10 man method and physical vapour transport (PVT). The Bridgman growth
11 was conducted by Prof. Zakhar Kovalyuk at the Institute for Problems of
12 Materials Science, part of the National Academy of Sciences of Ukraine.
13 The PVT growth was also conducted by the same institute with the quality
14 of the produced material evaluated in Nottingham and reported in Kudryn-
15 skyi et al. (2020).

16 A schematic depiction of the Bridgman method is shown in Figure (3.1a).
17 The apparatus consists of a sealed ampule with the ability to move freely
18 between two temperature controlled ovens separated by a baffle. The am-
19 pule is loaded with feedstock material in the desired stoichiometric ratios.
20 The ampule is then positioned in the hotter of the two ovens (upper) where
21 the temperature is sufficient to melt the feedstock material. Once a melt
22 is achieved, the ampule is slowly lowered through the baffle into the cooler
23 (lower) oven. This oven is at sufficiently low temperature to crystallise
24 the desired material. The crystallisation front, in a well controlled system,
25 aligns with the baffle and can be controlled by varying the rate at which the

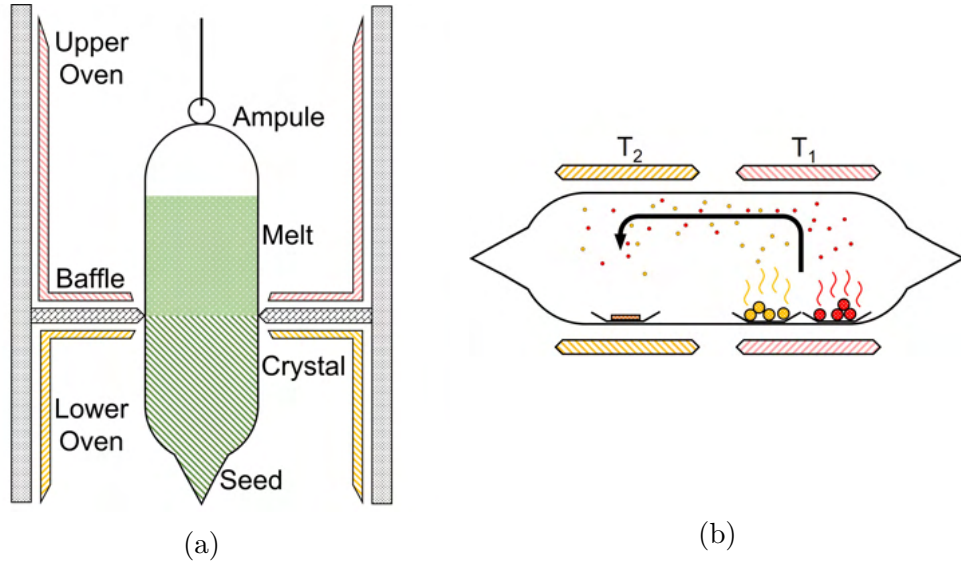


Figure 3.1: Schematic representations of vdW material growth using (a) the Bridgman method and (b) physical vapour transport.

26 ampule is lowered. A seed at the bottom of the ampule is used to initiate
 27 growth and set the crystallographic orientation. This method of growth
 28 can be used to produce large samples of a single crystal domain with well
 29 defined crystallographic orientations and stoichiometry.

30 The second growth method is PVT. This refers to growth methods where
 31 the feedstock material is first vaporised before being allowed to adsorb onto
 32 a substrate where the atoms can migrate and rearrange to form the desired
 33 material. Shown in Figure (3.1b) is a schematic representation of PVT
 34 growth in a sealed ampule. Other methods of PVT where a free-flowing
 35 carrier gas is present are also possible. In the sealed ampule configuration,
 36 the feedstock materials are loaded into one end of the ampule and heated
 37 until a vapour of atomic material is produced at temperature T_1 . This
 38 material can then diffuse to the other end of the ampule where it adsorbs
 39 onto a prepared substrate held at temperature T_2 where $T_2 < T_1$. T_2 is
 40 at sufficient temperature to allow the migration of the atomic species such
 41 that they can rearrange into the preferred crystallographic positions. The
 42 SnS_2 used in Chapter 4 was grown with $T_1 = 650 \text{ }^\circ\text{C}$ and $T_2 = 500 \text{ }^\circ\text{C}$

43 (Kudrynskyi et al. (2020)). This growth method results in a product on
44 top of a substrate or, if grown in sufficient quantities, large flakes which
45 can be free standing once removed from the ampule.

46 3.1.2 Sample Preparation

47 For the reliable study of vdW materials, it is desirable to transfer the as-
48 grown bulk material to a suitable substrate. This enables the easy handling
49 and identification of samples as well as producing a distribution of flakes
50 from which different thicknesses can be sampled. The transferring of flakes
51 to a suitable substrate is also desirable for certain techniques, such as XPS,
52 the analysis of which benefits from a conductive substrate.

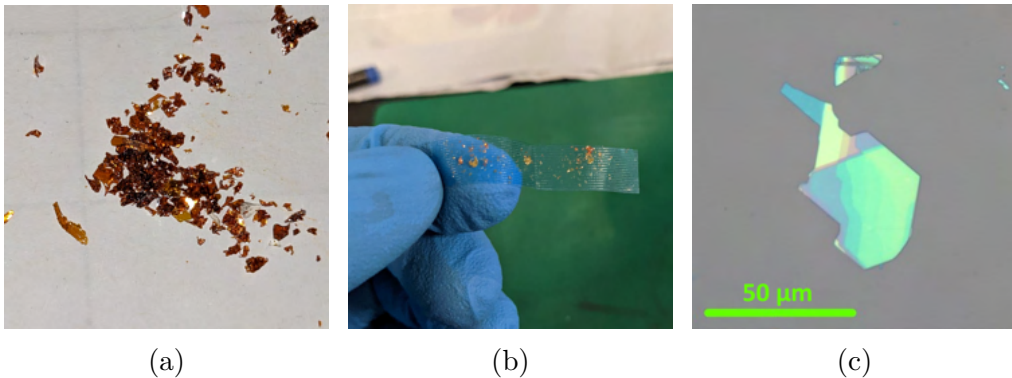


Figure 3.2: Stages of thin flake sample preparation via the exfoliation method. (a) Bulk SnS_2 material as grown via PVT. (b) SnS_2 material exfoliated on blue tape. (c) Thin Flake of SnS_2 stamped onto an SiO_2/Si substrate.

53 The flakes are first exfoliated from bulk material like that shown in Figure
54 (3.2a) using tape, as shown in Figure (3.2b). Once on the tape, the flakes
55 are then directly stamped onto a substrate by pressing the tape down onto
56 the substrate before removing it. This leaves a distribution of flakes on the
57 surface of different thicknesses and lateral sizes. Shown in Figure (3.2c) is
58 an optical microscope image of a typical stamped flake of SnS_2 . Variation in
59 colour across the surface of the flake is associated with thickness-induced

60 optical interference. In instances where precise positioning of a flake on
61 the substrate is required, the flake can be transferred from the tape to
62 polydimethylsiloxane (pdms), which is a transparent polymer. As pdms is
63 transparent, it allows for the precise positioning of a flake with the aid of
64 micro-manipulators under an optical microscope.

65 One substrate used for the studies was commercially acquired Si/SiO₂
66 wafers, with a nominal SiO₂ thickness of 300 nm. Alternatively, when a
67 conductive or reference substrate is required, an Si/SiO₂/Ti/Au substrate
68 is used. For this, an Si/SiO₂ wafer was commercially obtained and the ~10
69 nm Ti and ~40 nm Au layers were deposited via thermal evaporation.

70 An additional method of stamping was conducted by Anna Casey, a stu-
71 dent of Dr. Fumin Huang at Queen's University Belfast to produce large
72 area GaSe flakes on a gold substrate. This method relies on producing
73 an extremely flat gold substrate (RMS roughness <1 nm) to increase the
74 adhesion between the substrate and the vdW flakes. This resulted in a
75 sample with flakes of 2 layers thick and with lateral sizes of 100s μm .

76 **3.2 Experimental Methods**

77 This section discusses the experimental methods used for exposing vdW
78 materials to hydrogen in both the gas phase and in the form of H-ions, us-
79 ing a Sieverts apparatus and Kaufman ion source, respectively. This section
80 then goes on to describe the methods used to characterise the samples be-
81 fore and after hydrogenation. These methods include: photoluminescence
82 spectroscopy, Raman spectroscopy, X-ray photoelectron spectroscopy, ul-
83 traviolet photoelectron spectroscopy, angle resolved photoemission spec-
84 troscopy, atomic force microscopy, scanning electron microscopy, energy

85 dispersive X-ray spectroscopy and transmission electron microscopy.

86 **3.2.1 Sieverts**

87 In order to expose vdW materials to hydrogen at pressures of between 1
88 bar and 60 bar and to quantify the resulting hydrogen uptake, a device
89 known as a Sieverts was used. A Sieverts utilises pressure measurements
90 to determine the quantity of a gas in a known volume. By determining its
91 deviation from an expected value, it can quantify gas uptake. This requires
92 the ability to convert the measured pressures into molar quantities. At low
93 pressures, the ideal gas equation is suitable for this purpose. The ideal gas
94 equation is as follows:

$$PV = nRT, \quad (3.1)$$

95 where P is pressure, V is volume, n is the molar quantity of the gas,
96 R is the ideal gas constant, and T is the temperature. This equation is
97 appropriate at low pressures where inter-molecular forces can be ignored.
98 At higher pressures, inter-molecular forces become significant. As such,
99 when examining pressures of up to 60 bar, a non-idealised expression must
100 be used. A virial expansion of the ideal gas equation provides such an
101 expression,

$$PV = nRT \left[1 + B \left(\frac{n}{V} \right) + C \left(\frac{n}{V} \right)^2 + \dots \right], \quad (3.2)$$

102 where B and C are the first and second virial coefficient of the gas, respec-
103 tively. For hydrogen B and C have values of $14.38 \text{ cm}^{-3}\text{mol}^{-1}$ and 370
104 $\text{cm}^{-6}\text{mol}^{-2}$, respectively (Goodwin et al. (1964)).

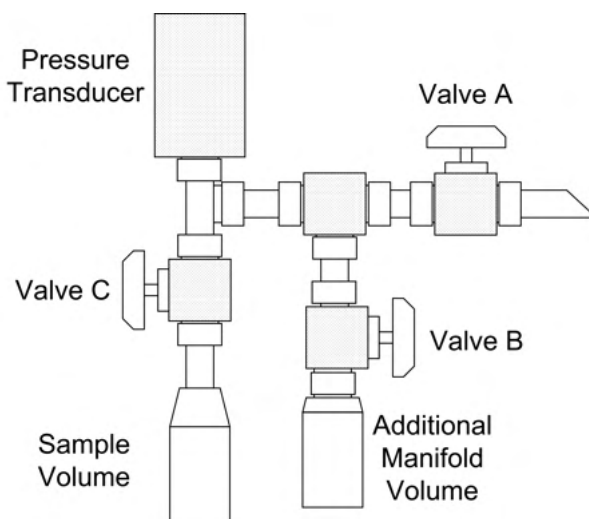


Figure 3.3: Schematic view of the Sieverts apparatus used for H_2 pressure based studies.

105 Figure (3.3) shows a schematic representation of a Sieverts, detailing the
106 relative positions of its volumes and their separating valves. The sample is
107 loaded into the sample volume and the whole system is then pumped down
108 to a vacuum ($<10^{-3}$ mbar) through valve A. The system is then flushed
109 with helium several times through valve A to remove trace gases. It is vital
110 to the operation of the Sieverts that its volumes are precisely known. The
111 manifold consists of the volume between valves A and C and its volume
112 is known via calibration with ball bearings of a known size. The sample
113 volume must be calibrated for each new sample. This is achieved using
114 helium. First, the system is pumped down to a vacuum and valve C is
115 closed. Helium is then allowed into the manifold through valve A, which is
116 then closed. Valve C is then opened and the transducer records the pressure
117 drop as the volume increases. This pressure drop is then used alongside the
118 non-ideal gas equation to determine the sample volume. This is repeated
119 over multiple pressures for the purpose of accuracy.

120 Once the sample space has been calibrated, quantitative uptake measure-
121 ments can be made. All the volumes are first evacuated through valve A.
122 Once evacuated, valve C is then closed and hydrogen is allowed into the

123 manifold. Valve A is then closed and the pressure in the manifold noted.
124 Using the non-ideal gas equation, the quantity of material in the manifold
125 is then calculated. Valve C is opened to allow hydrogen into the sample
126 space. After opening the valve the pressure is once again used to calculate
127 the quantity of hydrogen in the new volume. Any discrepancy in the quan-
128 tity of gas before and after the opening of valve C can then be attributed
129 to hydrogen adsorption/absorption in the sample.

130 **3.2.2 Kaufman Ion Source**

131 In order to explore more reactive and potentially more penetrating forms
132 of hydrogen, exposures using hydrogen-ions were also conducted. These
133 exposures were accomplished using a Kaufman ion source, a system origi-
134 nally developed as a high efficiency rocket engine but with qualities which
135 make it well suited to producing controlled exposures of H-ions (Kaufman
136 (1961)). These qualities are: a controllable mono-energetic beam of ions,
137 controllable and measurable ion flux, and a high ratio of H⁺ ions to H₂⁺
138 ions of 0.0291 (Bauer and Beach (1947)).

139 Shown in Figure (3.4) is a schematic representation of the Kaufman ion
140 source illustrating the key components of its operation. Hydrogen gas is
141 fed into the chamber on the right where it is ionised via collisions with
142 electrons emitted by a thermionic element. A magnetic field generated
143 in the chamber confines electrons to magnetic flux lines extending their
144 path lengths and increasing the efficiency of the source. Ionised hydrogen
145 species then diffuse in the chamber towards a set of accelerating grids, set
146 at a predefined voltage to produce the mono-energetic ion beam. This
147 beam is oriented towards the sample. The sample is grounded so that ions
148 upon reaching the surface can acquire an electron and become neutral.

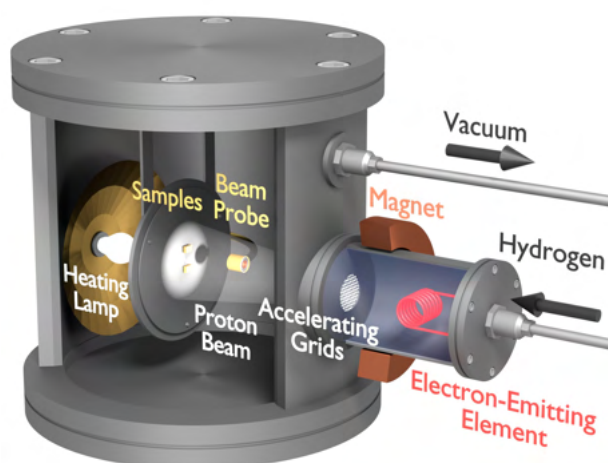


Figure 3.4: Schematic view of the Kaufman ion source used for exposures to H-ions and for some low pressure H₂ exposures.

149 The depth to which ions are implanted in the sample depends on sample
150 composition and the beam energy. The behaviour of the hydrogen once
151 in the sample will then depend on the nature of the interaction with the
152 sample. The beam flux is determined via a probe in the path of the beam,
153 which measures the current incident on a known area. Heating is achieved
154 via an infra-red heat lamp positioned behind the sample mounting plate.
155 When in operation the primary chamber is under continuous pumping to
156 remove any H₂ gas.

157 This chamber was also used for some H₂ exposures with the Kaufman ion
158 source switched off and H₂ allowed to enter the main chamber through the
159 accelerating grids. This was done to leverage the pressure gauges available
160 in this system which operate at a lower range than those used for the
161 Sieverts.

162 **3.2.3 Optical Spectroscopy**

163 Photoluminescence (PL) spectroscopy and Raman spectroscopy were used
164 for the non-invasive and non-destructive probing of optical and vibrational
165 properties. The PL and Raman measurements were conducted using a
166 Horiba LabRAM HR spectrometer equipped with a confocal microscope,
167 motorised XYZ stage, two excitation sources at $\lambda = 532$ nm and $\lambda = 632.8$
168 nm, and diffraction gratings of 150 g/mm and 1200 g/mm. The operation
169 for both PL and Raman spectroscopy is described here.

170 **Photoluminescence Spectroscopy**

171 PL spectroscopy works on a principle of exciting electrons in a material
172 from the valence band to the conduction band using light. This generates
173 an electron-hole pair which may then thermalise, diffuse, migrate or any
174 combination of all three. After some time, characterised by the lifetime of
175 the carriers, an electron hole pair can recombine and in doing so emit a
176 photon. It is this photon which PL spectroscopy aims to detect. A simple
177 picture of the PL process is shown in Figure (3.5a).

178 There can be variations on the process depicted in Figure (3.5a). For exam-
179 ple, in 2D materials strongly bound electron-hole pairs known as excitons
180 can be formed as shown in Figure (3.5b). The binding energy of the exciton
181 lowers the energy of the system and consequently reduces the energy of the
182 emitted photon. Another modification is via defect levels introduced to the
183 band gap by defects in the material. This is shown in Figure (3.5c). The re-
184 combination of carriers from these levels can be radiative or non-radiative,
185 and act to reduce the energy of the emitted photon and/or decrease the
186 overall PL intensity.

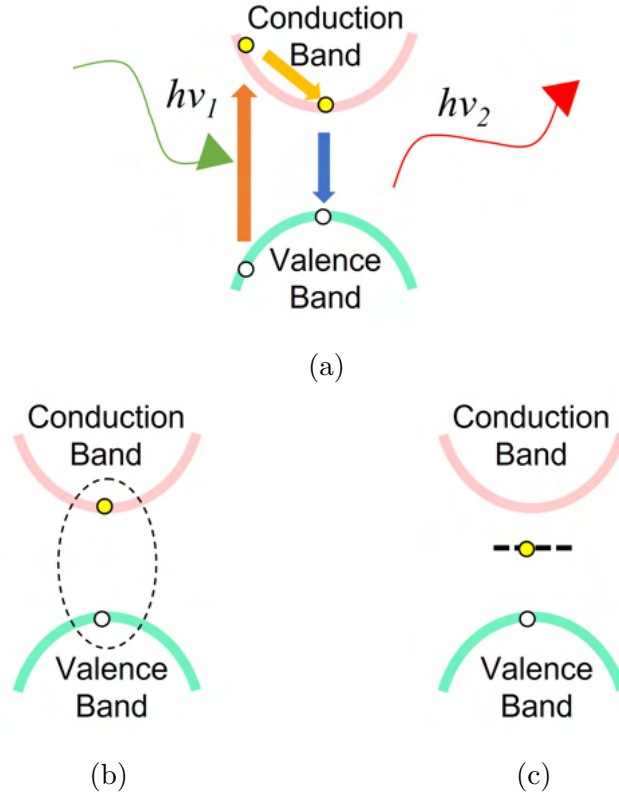


Figure 3.5: Sketches illustrating the origin of photoluminescence in a semiconductor, showing: (a) the excitation, relaxation and recombination processes, (b) an exciton and (c) position of an in-band gap defect state.

187 A schematic representation of a PL set-up is shown in Figure (3.6), illus-
 188 trating its key components. First, is the excitation source, typically a laser.
 189 In this instance either a green frequency doubled Nd:YVO₄ ($\lambda = 532$ nm)
 190 or a red He-Ne ($\lambda = 632.8$ nm) laser can be selected. This laser beam then
 191 passes through a filter to adjust its intensity before being focused onto the
 192 sample via a microscope objective lens. This lens focuses the beam down
 193 to an area of $\sim 1 \mu\text{m}^2$, increasing its intensity and allowing for highly se-
 194 lective sampling of the sample surface. The same objective lens is used
 195 to collect the photons emitted from the sample and passes them through
 196 to the edge filter. The emitted photons can pass through the edge filter,
 197 which is selected to block passage of the laser to the spectrometer, as their
 198 energy is less than that of the laser. They then pass through a confocal
 199 hole which allows for the probing to different depths within the sample.

200 Finally, the emitted photons arrive at the diffraction grating, splitting the
 201 light into its spectral components where they are then recorded via a linear
 202 detector array. This detector can either be a charge coupled device or an
 203 InGaAs array, depending on the spectral regions of interest.

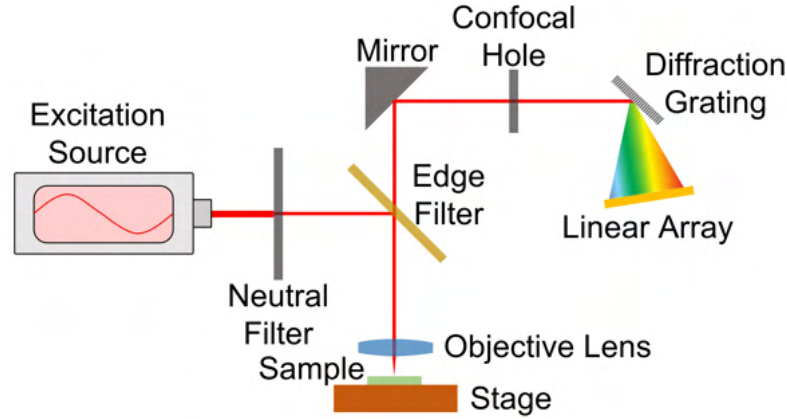


Figure 3.6: Schematic representation of a spectrometer suitable for PL or Raman spectroscopy.

204 The PL response can be mapped across the surface of the sample by utilis-
 205 ing an X-Y motorised stage. In this mode, spectra are recorded sequentially
 206 in a grid pattern across the sample. The intensity of specific spectral re-
 207 gions or the position of specific peaks can then be displayed as a heatmap
 208 or as individual spectra.

209 A helium cold finger cryostat can also be incorporated into the system.
 210 For this, the sample is loaded into the cryostat and fixed to a copper slug.
 211 When sealed, the cryostat is then pumped down to a vacuum ($<10^{-6}$ mbar).
 212 A stream of helium vapour from a liquid helium dewar is then passed
 213 through copper pipes in contact with the underside of the slug, cooling it
 214 and consequently the sample. Through the presence of a heater and by
 215 controlling the flow of helium, the temperature in the cryostat can then
 216 be varied from temperatures as low as 4 K up to room temperature. A
 217 window in the lid of the cryostat allows for optical measurements of the
 218 sample.

219 **Raman Spectroscopy**

220 Raman spectroscopy relies on the creation or annihilation of a phonon to
221 modify the energy of the incident photon. This creation or annihilation
222 conserves both energy and momentum as per the following equations:

$$\hbar\omega_e = \hbar\omega_i \pm \hbar\omega_q \quad (3.3)$$

and

$$\hbar\mathbf{k}_e = \hbar\mathbf{k}_i \pm \hbar\mathbf{q}, \quad (3.4)$$

223 where $\hbar\omega_e$ is the energy of the emitted photon, $\hbar\omega_i$ is the energy of the
224 incident photon, $\hbar\omega_q$ is the energy of the phonon, \mathbf{k}_e is the wave vector
225 of the emitted photon, \mathbf{k}_i is the wave vector of the incident photon and
226 \mathbf{q} is the wave vector of the phonon. The \pm here refers to the two differ-
227 ent configurations of phonon annihilation and creation, which correspond
228 to the anti-Stokes and Stokes processes, respectively. The Raman results
229 presented as part of this thesis were conducted in the Stokes configuration.

230 Despite the differences between Raman and PL processes, the experimental
231 setup is very similar, to the extent that the same system can be used
232 for both. The most significant change is the requirement to change the
233 diffraction grating used for the dispersion of the re-emitted light. For the
234 PL studies a grating of 150 g/mm was used whereas for Raman studies
235 a grating of 1200 g/mm was used. This results in a greater dispersion of
236 the light and consequently allows for the viewing of the much narrower
237 Raman features. However, using a more dispersive grating comes with the
238 drawback of reducing the signal intensity incident on the detector.

239 3.2.4 Electron Spectroscopy

240 Electron spectroscopy techniques probe the properties of a material utilis-
241 ing the photoelectric effect. They include X-ray photoelectron spectroscopy
242 (XPS), ultraviolet photoelectron spectroscopy (UPS) and angle resolved
243 photoemission spectroscopy (ARPES). These techniques all probe the elec-
244 tronic properties near the surface of a material, with differences in their
245 equipment/operation making each one more or less suited to studying spe-
246 cific features.

247 XPS

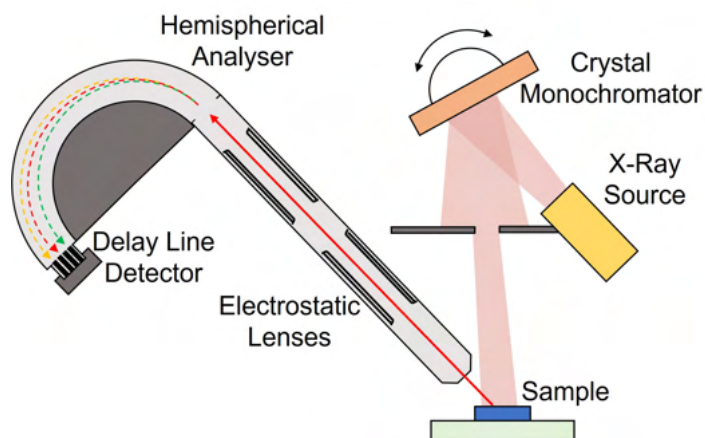


Figure 3.7: Generalised XPS schematic showing the common components utilised in most XPS systems.

248 The most common of the three techniques is XPS. The equipment used in
249 XPS also the simplest of the three and most of the features present in an
250 XPS system are also present for UPS and ARPES. Figure (3.7) shows a
251 schematic description of an XPS system. The X-rays are first generated by
252 an X-ray anode which emits X-rays upon electron bombardment from an
253 electron emitting source. The material used for the X-ray anode determines
254 the energy of the emitted X-rays, with energies between $h\nu = 132.3$ eV and
255 $h\nu = 5417.0$ eV available. The most commonly used material is aluminium

256 with the strong Al $k\alpha$ line at $h\nu = 1486.6$ eV (Watts and Wolstenholme
 257 (2019)). The X-rays are then monochromated by a quartz crystal utilising
 258 Bragg reflections from the crystallographic planes to disperse the X-rays.
 259 An aperture is then used to select for the correct Bragg reflected beam. The
 260 monochromated beam of X-rays is then directed onto the sample under
 261 investigation. The sample is mounted on a motorised stage to allow for
 262 precise positioning and for the investigation of specific regions of interest.
 263 When illuminated with X-rays the sample will begin to emit electrons with
 264 energies defined by selection rule allowed transitions. The resulting kinetic
 265 energy of the electrons is then described by the equation,

$$E_k = h\nu - E_B - W \quad (3.5)$$

266 where E_k is the kinetic energy of the electron, $h\nu$ is the photon energy, E_B
 267 is the binding energy of the electron in the material and W is the work
 268 function of the material. The emitted electrons then pass through a series
 269 of electrostatic lenses. These serve two purposes, to focus the electron beam
 270 and thus maximise its intensity, and to retard the electrons to an energy
 271 appropriate for the hemispherical analyser. When the analyser is operated
 272 in fixed energy mode, it is the variation in the retardation potential which
 273 controls the electron energies being sampled. The hemispherical analyser
 274 comes after the electrostatic lenses and consists of two concentric hemi-
 275 spheres held at different potentials, with the inner sphere held at a positive
 276 potential relative to the outer sphere. The electric field between the two
 277 spheres bends the path of the electrons around the analyser. The bend-
 278 ing of the electrons is dependent of their kinetic energy and at the exit of
 279 the analyser the electrons are dispersed with lower kinetic energy electrons
 280 closer to the inner sphere and higher kinetic energy electrons closer to the

281 outer sphere. The energy of the electrons which pass through the centre of
 282 the analyser is known as the pass energy and is given by the equation:

$$E = e\Delta V \frac{R_1 R_2}{R_2^2 - R_1^2}, \quad (3.6)$$

283 where E is the pass energy, e is the charge on the electron, ΔV is the voltage
 284 difference between the two hemispheres, R_1 is the radius of the inner sphere
 285 and R_2 is the radius of the outer sphere (Watts and Wolstenholme (2019)).
 286 This pass energy determines the extent to which the electrons are dispersed
 287 with a lower pass energy corresponding to a higher dispersion. With the
 288 electrons dispersed at the exit of the analyser, a multichannel delay line
 289 detector is used to sample the spatial variation in electron flux and convert
 290 it to an electrical signal to be read out by an analogue to digital converter.
 291 XPS systems are often operated in a swept mode whereby the retardation
 292 voltage is varied over the energetic region of interest to overcome data
 293 artefacts associated with the transmission function of the analyser and
 294 with variation across the delay line detector.

295 Typically, XPS requires strict vacuum conditions ($<10^{-8}$ mbar) for the
 296 electrons to have a sufficient mean free path for passage from the sample
 297 through the electrostatic lenses and analyser to reach the detector. How-
 298 ever, it is often desirable to understand the chemical state of a surface whilst
 299 being exposed to a gas or vapour. For this to be achieved, a method for
 300 exposing the sample at higher pressures while maintaining the long mean
 301 free path through the electrostatic lenses and analyser is required. This is
 302 achieved in near ambient pressure XPS (NAP-XPS) with the use of a NAP
 303 cell and several differential pumping stages. Shown in Figure (3.8) is a NAP
 304 cell. The sample in the centre of the image is approached by a cone with
 305 a small hole at its tip. On the sample side of the cone the pressure can be

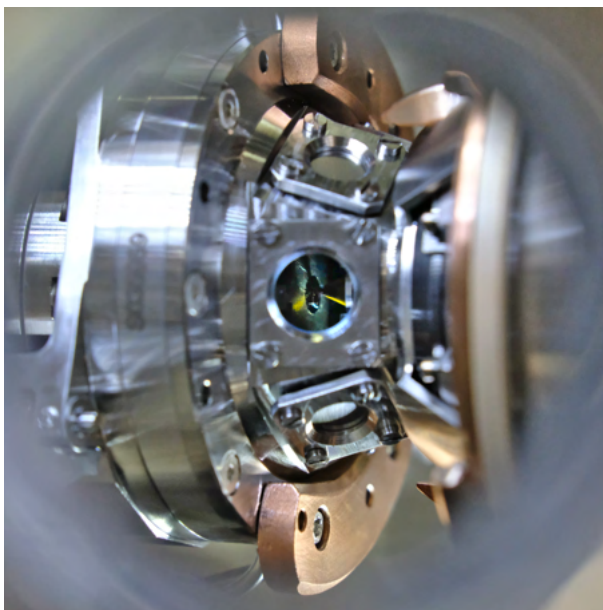


Figure 3.8: Image of the NAP cell in the SPECS Devi Sim NAP XPS at the University of Nottingham containing a GaSe sample on an Au/Ti/SiO₂/Si substrate for NAP-XPS. This image was taken through the optical port used for sample illumination with the Sciencetech A1 Light Line solar simulator.

306 of several mbar whilst on the other side of the cone the pressure is several
307 orders of magnitude lower. By minimising the distance between the sample
308 and cone, the distance travelled by the electrons in the cell is minimised
309 thus allowing for XPS in environments where the mean free path would
310 traditionally be considered too short. The window through which the sam-
311 ple is imaged in Figure (3.8) allows for the illumination of the sample via
312 a solar simulator. A 1.5 global solar air mass solar simulator replicates the
313 conditions used for standardised solar photovoltaic measurements.

314 Two separate XPS systems were used as part of this PhD. The first was
315 a Kratos AXIS ULTRA equipped with a monochromated Al $k\alpha$ source.
316 This system was operated with the use of a charge neutraliser filament, a
317 hybrid aperture, a $300\times 700\ \mu\text{m}$ spot size, and scans were performed with
318 a 20 eV pass energy. This first system was employed for the study of SnS₂
319 and InSe in Chapter 4 and Chapter 5. The second system was a SPECS

320 Devi Sim near ambient pressure XPS equipped with a Phoibos 150 near
 321 ambient pressure hemispherical analyser, an Al $\kappa\alpha$ source and a Sciencetech
 322 A1 Light Line solar simulator. This system was used to conduct NAP and
 323 vacuum measurements XPS on the GaSe sample in Chapter 6.

324 UPS

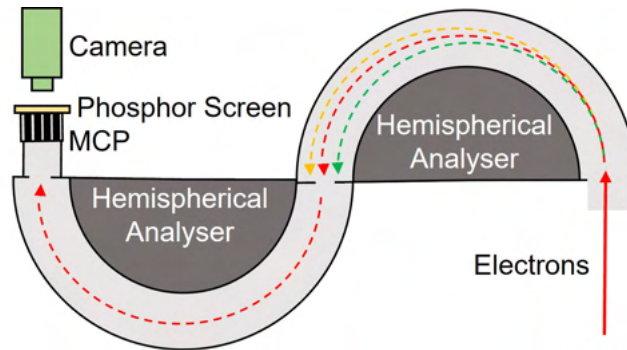


Figure 3.9: Sketch of a dual hemispherical analyser used for energy dispersion and spherical aberration correction in UPS and ARPES experiments.

325 Much like XPS, ultraviolet photoelectron spectroscopy (UPS) samples the
 326 electron flux from a sample due to the photoelectric effect. The difference
 327 between XPS and UPS lies in the energy of the exciting photons. In UPS
 328 the photon energy is much lower ($\sim 100x$) than in XPS. The advantage of
 329 using lower energy photons in UPS is the increased sensitivity to states
 330 closer to the vacuum level as a result of an increased interaction cross-
 331 section for transitions with energies closer to that of the incident photon.
 332 The nano electron spectroscopy for chemical analysis (Nano-ESCA) equip-
 333 ment used for the UPS studies in this thesis use photons of energy $h\nu =$
 334 21.219 eV, corresponding to the He I α emission line from a helium dis-
 335 charge lamp. After sample irradiation, electrons emitted from the sample
 336 are then extracted by a large electric field ($67,000 \text{ Vcm}^{-1}$), which ensures
 337 the efficient sampling of electrons and allows for the capture of electrons
 338 with zero kinetic energy. This element of the system is known as the ex-

339 tractor and acts as the first lens element for the system. After this first
340 element, a series of electrostatic lenses are used to form either a real space
341 or reciprocal space image (detailed in the next section) and for retarding
342 the kinetic energy of the electrons. This image is then transferred through
343 two hemispherical analysers, as shown in Figure (3.9). A slit located in-
344 between the two analysers selects for electrons of a given energy whilst the
345 second hemisphere corrects for aberrations introduced by the first. The
346 image is then focused onto a screen to allow for real space or reciprocal
347 space imaging. A real space or reciprocal space UPS spectrum can then be
348 constructed by changing the energy of electrons which pass through the slit
349 between the two analysers. For the results presented as part of this thesis,
350 UPS was conducted utilising the same equipment as described for ARPES.

351 **ARPES**

352 Angle resolved photoemission spectroscopy adds to the functionality of UPS
353 by preserving the in-plane momentum components of the electrons emitted
354 from the sample. It does this by measuring the emission angle and kinetic
355 energy of the photoelectrons. The in-plane k-vector (\mathbf{k}_{\parallel}) of the electrons is
356 related to the emission angle (θ) relative to the surface by

$$|\mathbf{k}_{\parallel}| = \frac{1}{\hbar} |\mathbf{P}_{\parallel}| = \frac{1}{\hbar} \sqrt{2m_e E_k} \sin \theta, \quad (3.7)$$

357 where \mathbf{P}_{\parallel} is the free electron momentum, m_e is the electron mass, and E_k
358 is the electron kinetic energy (Damascelli (2004)). As the in-plane momen-
359 tum component is conserved, the electron momentum can be inferred from
360 the emission angle and electron kinetic energy. The out of plane momen-
361 tum component is not conserved however due to the breaking of crystal

362 periodicity at the surface. Instead, ARPES probes a section of the Brill-
 363 louin zone as set by the photon energy. The selected momentum (k_z), in a
 364 free electron model, is described by

$$k_z = \sqrt{\frac{2m(E_k \cos^2 \theta + V_0)}{\hbar^2}}, \quad (3.8)$$

365 where m is the electron mass, E_k is the electron kinetic energy, θ is the
 366 emission angle and V_0 is the inner potential (Plucinski et al. (2003)). Addi-
 367 tionally, the out of plane component contributes a broadening to spectrum.
 368 This broadening is of the order

$$\Delta k_{\perp} \sim \lambda_{fe}^{-1}, \quad (3.9)$$

369 where Δk_{\perp} is the uncertainty along the out of plane direction and λ_{fe} is the
 370 mean free electron path (Mitsuhashi et al. (2016); Stroscov (2003)). With
 371 reference to a universal electron curve describing the mean free path of
 372 electrons in solids and a photon energy of 21.219 eV, the uncertainty for
 373 the Nano-ESCA can be said to be of the order $\Delta k_{\perp} = 0.1 \text{ \AA}^{-1}$ (Chusuei
 374 and Goodman (2013)),

375 The work of the Nano-ESCA optics is to determine the emission angle
 376 and kinetic energy of the photoelectron such that their momentum's can
 377 be determined. A sketch of the electron trajectories is shown in Figure
 378 (3.10). The first part of this process is the same as for UPS with the
 379 emission of electrons resulting from the illumination of the sample with
 380 photons of energy $h\nu = 21.219 \text{ eV}$. The electrons are then extracted from
 381 the surface by the extractor which forms the first lens element of the system.
 382 A contrast aperture can then be used to restrict the angular distribution
 383 of the electrons. The first transfer lens then focuses the electrons into the

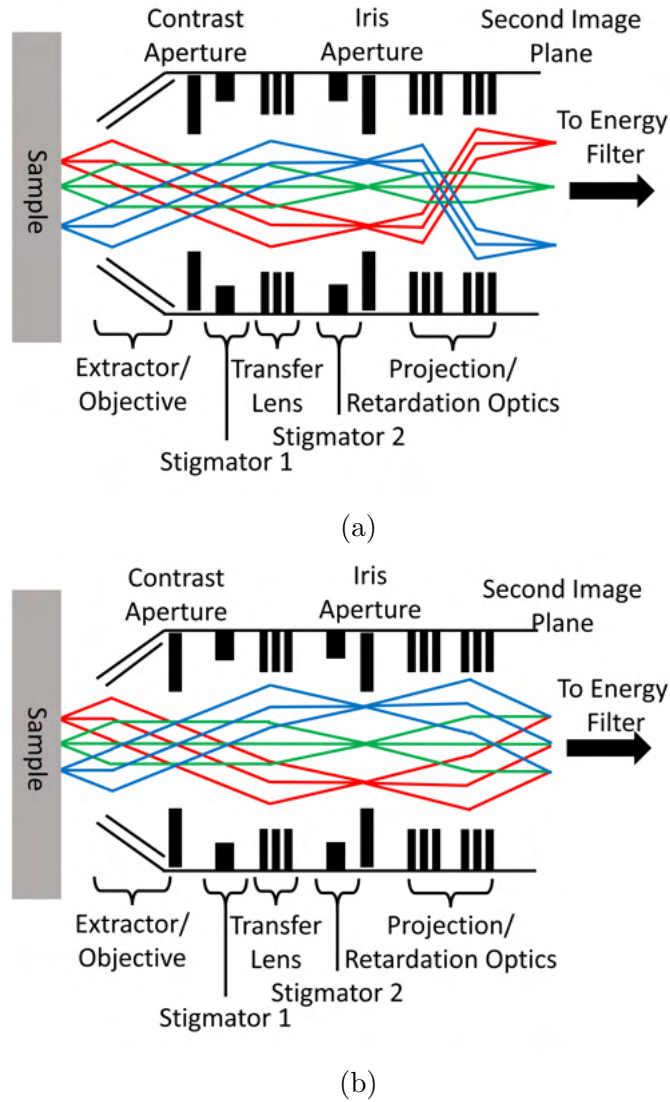


Figure 3.10: Ray traced diagram indicating the path of electrons through the Nano-ESCA optics in both (a) real space and (b) reciprocal space. After passing through these optics, the electrons enter the energy filter shown in Figure (3.9).

384 first image plane and the two stigmators can be used to correct the electron
 385 trajectories through the optical system. In the first image plane sits a iris
 386 which is used to select for electrons emitted from a given portion of the
 387 sample in real space. The projection/retardation optics have two functions,
 388 the first is to project either a real space or reciprocal space image into the
 389 second image plane, and the second is to reduce the electron kinetic energies
 390 such that the correct energies pass through the slit in the energy filter. A

391 series of transfer lenses are then used to pass the electrons to and between
392 the two hemispherical analysers. The first hemisphere serves the purpose
393 of dispersing the electrons by energy, as with XPS. An aperture positioned
394 at the exit of the first hemisphere then selects for electrons in a specific
395 energy range, and determines the energy resolution of the measurement.
396 The first hemispherical analyser introduces spherical aberrations into the
397 system. The purpose of the second analyser is then to correct for these
398 aberrations. With the same dimensions and with the pass energy set to the
399 same value as the first analyser, the second analyser allows for the electrons
400 to complete their Kepler orbits and reverses the aberrations introduced by
401 their passage through the first hemisphere. The reciprocal space or real
402 space image is then projected onto a multi channel plate (MCP), which
403 amplifies the electron flux before being accelerated onto a phosphor screen
404 for the conversion into photons. These are then detected by a camera.

405 Both ARPES and UPS were conducted at the University of Nottingham
406 utilising a Scienta Omicron Nano-ESCA II equipped with a Hg discharge
407 lamp for sample positioning and optical corrections. ARPES and UPS
408 measurements were conducted using photons generated by a Focus HIS 14
409 HD helium discharge lamp equipped with a focusing mirror to achieve a
410 170 FWHM spot size and a photon flux of 2×10^{12} photons/second/mm².

411 **3.2.5 Additional Techniques**

412 This section considers the techniques utilised in this PhD which were pri-
413 marily conducted by another individual and from which relatively straight-
414 forward results and analysis were gained. As such, a brief description of
415 their operation is provided alongside references to detailed resources de-
416 scribing their operation.

417 **Atomic Force Microscopy**

418 Properties of and changes in the surface morphology of a material can
419 provide powerful insights into the behaviour of a material and its interac-
420 tions with hydrogen. Atomic force microscopy (AFM) is one of the most
421 straightforward methods for characterising this morphology due to its abil-
422 ity to image areas of 100s μm in size whilst also retaining the ability to
423 resolve features on the scale of the crystallographic lattice. This is achieved
424 by monitoring the deflections and changing oscillations in a cantilever with
425 an atomically sharp tip at one end induce by sample-tip interactions. AFM
426 also provides additional utilities in the form of: compositional sensitivity
427 (phase data), electrical conductivity characteristics and work function mea-
428 surements (Kelvin probe force microscopy). A detailed description of the
429 operating principles of AFM can be found in Johnson et al. (2009).

430 The AFM used for the study of SnS_2 in Chapter 4 and GaSe in Chap-
431 ter 6 was conducted using an Asylum Research Cypher-S. This system is
432 equipped with an optical microscope for the location of flakes and was op-
433 erated in either non-contact tapping or contact mode. The NuNano Scout
434 70 Si AFM tip with a radius of < 10 nm was used in non-contact mode and
435 a NuNano Spark 70 Pt tip with a radius of < 30 nm was used in contact
436 mode.

437 **Scanning Electron Microscopy and Energy Dispersive X-ray Spec-**
438 **troscopy**

439 SEM is a common technique used to image the surface of a samples with
440 spatial resolution better than that achievable using traditional optical mi-
441 croscopes. This is due to the comparatively shorter wavelengths of electrons

442 (0.1 Å at 10 keV) than that of visible light (450 nm for blue light), dra-
443 matically improving the diffraction limited resolution. SEM requires the
444 focusing of an electron beam at a given energy onto the sample. The elec-
445 trons can then impart sufficient energy to electrons within the sample to
446 eject them from their atomic orbitals in an inelastic process. These elec-
447 trons are known as secondary electrons. Alternatively, the electrons can be
448 elastically back-scattered towards the incoming electron beam. A detailed
449 description of the principles of SEM can be found in Akhtar et al. (2018).

450 EDX utilises much of the same equipment as SEM, to the extent that
451 they are often integrated into the same device. As with SEM, a beam of
452 electrons is accelerated and focused onto the sample. Electrons incident
453 on the sample dissipate their energy into it. As such, electrons are ejected
454 from their atomic orbitals and leave behind empty electronic states. With
455 the atoms in an excited state, electrons from a higher energy shell can
456 relax into the empty level and emit a corresponding X-ray. The emitted
457 X-rays have well-defined energies associated with energy transitions within
458 an atom allowing for their identification. A detailed description of the
459 principles of EDX can be found in Abd Mutalib et al. (2017).

460 SEM and EDX was conducted using an JEOL 7000F FEG-SEM equipped
461 with a field emission electron gun and the facility to image both secondary
462 and backscattered electrons and equipped with an Oxford Instruments
463 INCA Wave 700 WDS System for high resolution elemental mapping.

464 **Transmission Electron Microscopy**

465 TEM considers the electrons transmitted through a sample of interest. As
466 such, it requires a different experimental arrangement with the electron
467 beam directed towards one side of the sample and an electron detector

468 positioned on the other side to detect the transmitted electrons.. Due to the
469 requirement for transmission of electrons, the sample must be suspended
470 to allow the free passage of electrons. The TEM images in Chapter 4 were
471 conducted using high angle annular dark field scanning TEM (HAADF
472 STEM), whereby the scanning beam is detected when deflected away from
473 the original trajectory preferentially by atoms with a high atomic number.
474 A detailed description of the principles of TEM can be found in Egerton
475 et al. (2005).

476 Samples were first ion milled in a Zeiss Crossbeam 550 (HR-CAT-SEM)
477 after being capped with Pt. The TEM analysis was then conducted using
478 a JEOL 2100F FEG-TEM equipped with an Oxford Instruments INCA
479 EDX system.

Chapter 4

Hydrogen - Tin Sulphides Interaction

Discussed in this chapter are the interactions between hydrogen and tin monosulphide and tin disulphide. The ability to produce a heterostructure based on these interactions is demonstrated. This chapter follows the reporting of results in (Felton et al. (2022)), with implications ranging from the chemical conversion of SnS_2 into SnS to the formation of SnS_2/SnS heterostructures with atomically flat interfaces and tunable electronic, vibrational and optical properties. The interaction of SnS_2 with H-ions leads instead to the conversion of SnS_2 to $\beta\text{-Sn}$. Density functional theory (DFT) is used to provide a theoretical basis for the experimental results and a fundamental understanding of the interaction of hydrogen in Sn-S compounds. These findings offer a route for engineering physical properties at the nanoscale for semiconductor technologies based on earth-abundant elements, such as Sn and S, and facilitate their use across a wide range of emerging technologies. Experimental work was contributed by Elena Blundo (University of Rome) and myself, with theoretical input

from Dr. Sanliang Ling (University of Nottingham). The TEM and SEM studies were conducted in collaboration with the Nanoscale and Microscale Research Centre (University of Nottingham).

Contents

4.1	Chemical Interaction with H_2	69
4.2	SnS_2 thin films exposed to H_2 and H-ions	71
4.3	Chemical Conversion of SnS_2 by H_2 and H-ions	74
4.4	Formation of an SnS/SnS_2 Heterostructure	77
4.5	Optical Characteristics of SnS/SnS_2 Heterostructure	81
4.6	Computational Results	88
4.7	Carrier Effective Mass in SnS_2	89
4.8	Summary	93

4.1 Chemical Interaction with H₂

Amongst 2D materials, vdW crystals based on Sn and S offer an interesting platform for hydrogen studies. They can exist in a variety of stoichiometries, lattice structures, and with Sn-atoms in the Sn⁴⁺, Sn²⁺ and Sn⁰ oxidation states. Shown in Figure (4.1) is a selection of materials from the Sn-S family, illustrating their diverse structural properties. Contained within the tin-sulphur materials family, are a number of 2D materials including the elemental-Sn material stanene, alongside mixed Sn-S compounds such as SnS (*Pnma*) and SnS₂ (*P-3m1*); the latter two of which are of particular interest as they represent the most stable phases for their respective stoichiometries (Burton and Walsh (2012)). This opens up the possibility that by altering the stoichiometry of these materials and the oxidation state of the Sn atoms that one vdW material might be converted into another.

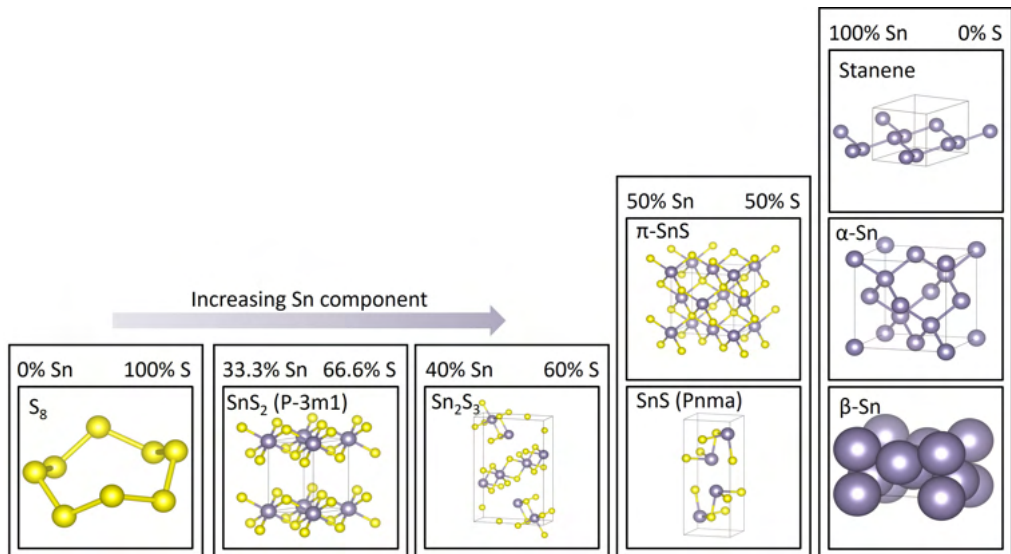
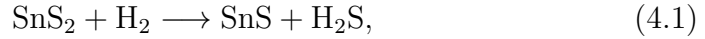


Figure 4.1: The structures of a sample of Sn and S containing materials. Materials further to the right have an increased Sn component and materials closer to the bottom are more stable.

One candidate for accessing the stoichiometric and oxidation degrees of freedom of the Sn-S system is hydrogen. Hydrogen is an excellent candidate for facilitating this conversion as it form strong bonds with sulphur atoms,

17 and forms the relatively stable H₂S molecule. Given these preconceptions,
18 the following expression describing a possible reaction of SnS₂ with H₂ can
19 be proposed:



20 where H₂S is in the gas phase, allowing for its removal and leaving behind
21 the newly formed SnS. This is just one potential reaction between H₂ and
22 SnS₂, others can also be suggested, including: the complete reduction of
23 SnS₂ to elemental Sn and H₂S, the partial reduction of SnS₂ to Sn₂S₃,
24 the formation of hydride complexes, and some combination of some/all of
25 these.

26 To better understand the interactions between hydrogen and the materi-
27 als SnS₂ and SnS, samples of SnS₂ were prepared on a combination of Au
28 and SiO₂ substrates. These samples were then exposed to a continually
29 refreshed supply of H₂ at pressures from 5×10^{-4} to 6×10^{-3} mbar and tem-
30 peratures between 150 and 300 °C for anywhere from 3.5 to 8 hours. These
31 samples were then analysed utilising the techniques of X-ray photoelectron
32 spectroscopy (XPS), scanning electron microscopy (SEM), energy disper-
33 sive X-ray spectroscopy (EDX), atomic force microscopy (AFM), transmis-
34 sion electron microscopy (TEM), Raman spectroscopy and photolumines-
35 cence (PL) spectroscopy, with additional theoretical input in the form of
36 density functional theory (DFT) calculations. A further set of samples were
37 exposed to H⁺ via a Kaufman ion source at 150 °C with a beam energy of
38 between 8 and 12 eV for total doses of between 8×10^{15} and 6×10^{16} ions
39 cm⁻² in order to assess the effect of highly reducing H-ion species on SnS₂
40 samples.

4.2 SnS₂ thin films exposed to H₂ and H-ions

The exposure of SnS₂ flakes to either H₂ or H-ions induces a visible change in their colour and contrast. Figures (4.2a) and (4.2b) illustrate a typical transformation in SnS₂ flake colour. It can be seen that the shape of the flake remains unchanged by the exposure, but the flake undergoes a colour shift. In this instance, the originally green colour (center of flake Figure (4.2a)) region is transformed into a light-orange tone (center of Figure (4.2b)), whilst an originally light red region takes on a yellow-orange colour. The exact nature of the shift is dependent on the original, interference-induced, colour of the flake. Similar effects were observed on several samples exposed at temperatures of up to 250 °C. However, at temperatures of 250 °C a strong etching of SnS₂ is observed alongside the appearance of dark-spots on the flake surface. When the exposure temperature is increased to 300 °C, the flakes are entirely etched away.

Flakes of SnS₂ exposed to H-ions from a Kaufman ion source behave in a different way to those exposed to H₂. Figures (4.2c) and (4.2d) show SnS₂ flakes before and after exposure to H-ions, respectively. A typical response is shown with discolouration of the exposed flakes alongside the formation of black micron-sized plateau features associated with a disordered and rough surface. Additionally, flakes which appear visually thin in microscope images undergo a significant etching and occurs over a wide range of temperatures, hydrogen doses and for flakes on both Au/Si and SiO₂/Si substrates.

SEM provides a higher spatial resolution than optical images and when used in conjunction with EDX can correlate surface features with compositional variations. Figures (4.3a), (4.3b) and (4.3c) show SEM images of control, H₂ exposed and H⁺ exposed SnS₂ with the S/Sn atomic ratios,

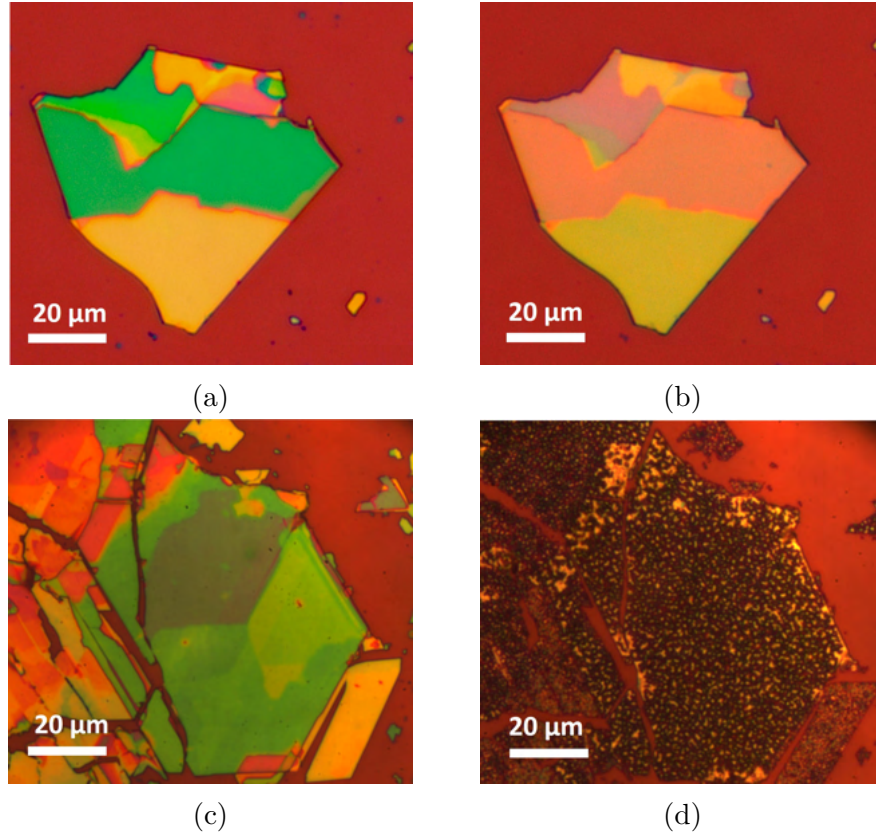


Figure 4.2: Optical images of SnS_2 flakes which have been mechanically exfoliated onto Au/Si substrates: (a) before exposure to H_2 , (b) after exposure to H_2 (7×10^{-4} mbar, 150°C , 7.5 hours), (c) before exposure to H -ions and (d) after exposure to H -ions (12 eV, 6×10^{16} ions cm^{-2} , 150°C , 3.5 hours).

68 as determined via EDX, labelled for specific sites. The trend in the SEM
 69 images is much like that in the optical images with no obvious changes be-
 70 tween the surface morphologies of either the control or H_2 exposed samples,
 71 whilst there is a significant roughening of the H^+ exposed samples with the
 72 plateau features once again visible. The EDX ratios reveals more about
 73 the changes. In the control sample (treated at the same temperature under
 74 vacuum in the absence of hydrogen) the S/Sn ratio sits at between 1.83
 75 and 1.92, close to the expected value of 2 for SnS_2 . The deviation from the
 76 expected value is attributed to the overlap of EDX peaks with those from
 77 the substrate. In the H_2 exposed sample the ratio varies between 1.55 and
 78 1.75. Importantly, this value is always greater than the 1 expected in SnS .

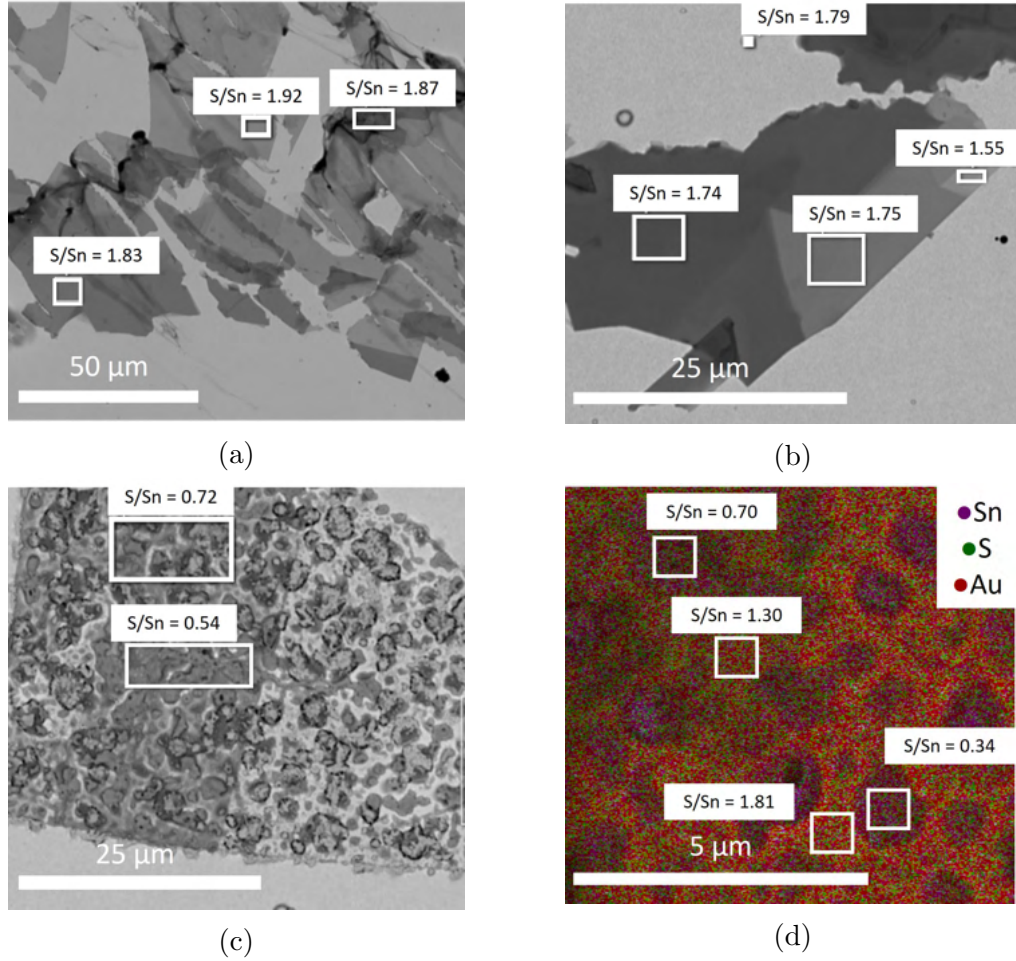


Figure 4.3: SEM images of, (a) a control SnS_2 sample, (b) SnS_2 sample exposed to H_2 (7×10^{-4} mbar, 150°C , 7.5 hours) and (c) an SnS_2 sample exposed to a H -ion beam (12 eV, 6×10^{16} ions cm^{-2} , 150°C , 3.5 hours), with insets corresponding to the S/Sn atomic ratio determined by EDX. (d) EDX map of SnS_2 exposed to a H -ion beam (8 eV, 8×10^{15} ions cm^{-2} , 150°C , 1.5 hours).

79 EDX samples a vertical volume extending into the substrate meaning any
 80 underlying SnS_2 would skew the ratio towards 2. This also explains the
 81 decreasing value of the ratio with decreasing flake thickness (AFM of flake
 82 in Figure (4.3b) shown in Figure (4.8)). For the H^+ exposed sample the
 83 ratio is seen to drop below 1 to between 0.54 and 0.72. Unlike the other
 84 two samples, the H -ion exposed flake also exhibits significant spatial vari-
 85 ation which is not associated with changes in thickness. EDX mapping of
 86 a H -ion exposed sample, shown in Figure (4.3d), shows how the variation
 87 in composition maps onto the morphology. The plateau features exhibit a

88 very low S/Sn ratio of <1 whilst the inter-plateau regions produce much
89 higher ratios of >1 and in one instance close to that of the control sample.
90 The low sulphur content of the plateaus is inconsistent with SnS and is
91 instead indicative of elemental Sn as the ratio is sufficiently below 1 to be
92 unexplained fully by substrate overlap in the EDX spectrum which slightly
93 underestimates the S/Sn ratio.

94 **4.3 Chemical Conversion of SnS₂ by H₂ and** 95 **H-ions**

96 It is clear from the optical images (Figure (4.2)) and the SEM/EDX data
97 (Figure (4.3)) that the exposure of SnS₂ to either H₂ or H-ions induces a
98 chemical change in the material which decreases its sulphur content. To
99 further probe this change XPS was employed to give a better understanding
100 of the chemical state of the constituent atoms. The ability for the Sn atom
101 to exist in the Sn⁴⁺, the Sn²⁺ and the Sn⁰ oxidation states present in SnS₂,
102 SnS and elemental-Sn, respectively, was exploited here.

103 Present in the XPS spectra of the samples are peaks associated with the
104 core levels of Sn and S from the samples and Au from the substrates. Au can
105 be used to calibrate the positions of the other peaks owing to its relatively
106 high intensity and well defined peak positions. As already discussed, the
107 Sn peaks are sensitive to changes in the chemical environment owing to
108 its multiple oxidation states. Sulphur, however would be less sensitive to
109 changes in the local environment, possesses a lower XPS cross-section and
110 owing to its small spin-orbit splitting is harder to interpret. As such, the
111 XPS studies of the samples focus on the changes to the Sn peaks.

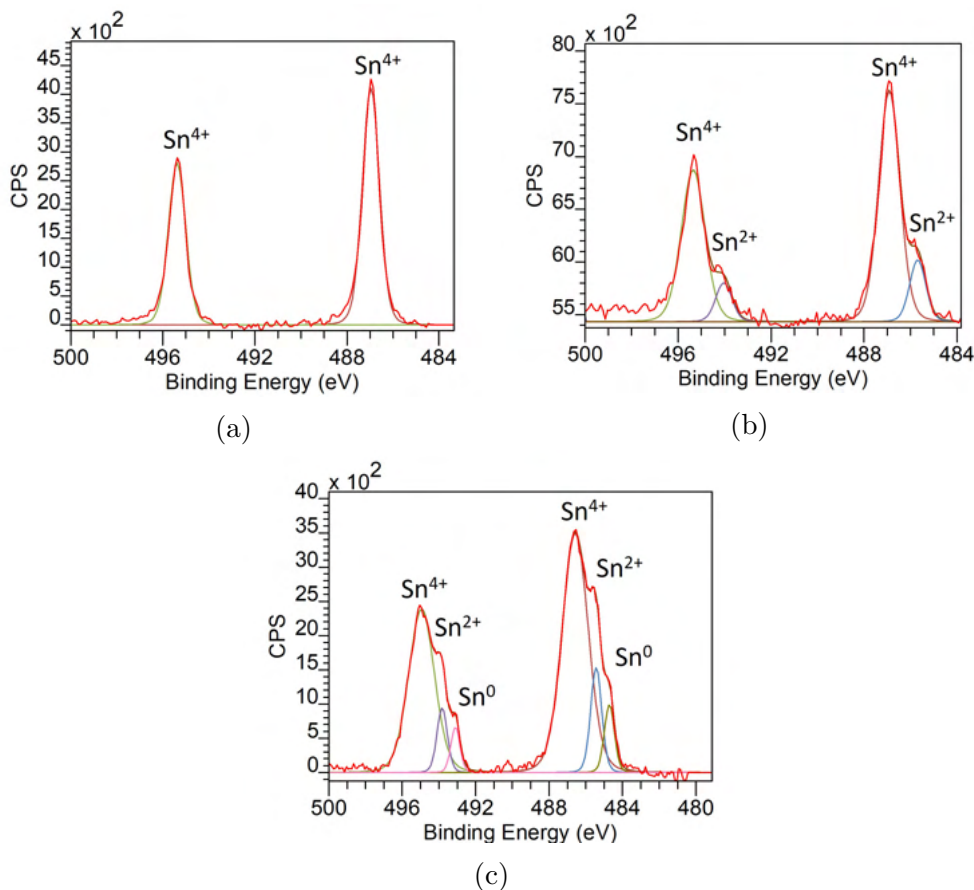


Figure 4.4: Peak fitting to the Sn 3d spectra of the (a) control sample, (b) H_2 exposed sample, and H^+ exposed sample. Labelled are the Sn oxidation states corresponding to each component. A Tougaard background and 50/50 Lorentzian Gaussian blend was used for the fitting.

112 Figure (4.4) shows the XPS spectra of the Sn 3d regions of the control SnS_2 ,
 113 H_2 -exposed SnS_2 , and H^- -ion exposed SnS_2 samples. In the control sample,
 114 the Sn 3d doublet is clearly visible: two well-resolved single lines can be
 115 seen at binding energies of 486.9 eV and 495.3 eV. The principle peak
 116 position at 486.9 eV is in agreement with the value of 486.7 eV for Sn^{4+}
 117 reported for SnS_2 in the literature, as is the 8.4 eV splitting (Reddy et al.
 118 (2015)). In the H_2 exposed sample, the Sn^{4+} doublet remains visible with
 119 its position un-changed. However, additional features appear on the low
 120 energy side of both components of the doublet. Specifically, these features
 121 appear at 1.0 eV and 1.2 eV below the Sn^{4+} low-energy and high-energy
 122 components, respectively (see Sn^{2+} components in Figure (4.4b)). The new

123 features observed in the hydrogenated samples correlate with previous data
124 for the Sn²⁺ peak in SnS where the Sn 3d component has a binding energy
125 of between 0.9 eV and 1.3 eV less than the Sn⁴⁺ peak in SnS₂ (Reddy et al.
126 (2015); Whittles et al. (2016); Moulder et al. (1992)).

127 For SnS₂ exposed to H-ions, the XPS spectra reveal more significant changes:
128 the Sn⁴⁺ High-energy peak shifts to 486.6 eV, 0.3 eV lower than in the con-
129 trol sample, whilst the peak splitting remains at the expected 8.4 eV (Reddy
130 et al. (2015)). Two additional components can also be seen at 485.5 eV
131 and at 484.8 eV, 1.1 eV and 1.8 eV lower than the Sn⁴⁺ peak, respectively
132 (see Sn⁴⁺ components in Figure (4.4c)). These peaks are assigned to the Sn
133 oxidation states of: Sn²⁺ in SnS and the neutral Sn⁰ states of elemental-Sn,
134 in line with previously reported data for the Sn⁰ peak in β -Sn (485.0 eV)
135 and a Sn⁴⁺ - Sn⁰ separation of 2.0 eV (Reddy et al. (2015); Moulder et al.
136 (1992)).

137 Of the multiple flake ensembles examined via XPS, all showed a similar
138 behaviour to those described above. None of the H₂ exposed samples re-
139 vealed the presence of elemental Sn and in neither the H₂ nor the H-ion
140 exposed samples could any traces of tin oxides be resolved. Given the mean
141 free path suggested by the universal electron curve for the Sn 3d electrons
142 of approximately 1 nm, and in conjunction with the later TEM measure-
143 ments, the fact that SnS₂ can be seen in the H₂ exposed samples indicates
144 a non-uniform distribution of SnS between flakes (Chusuei and Goodman
145 (2013)).

4.4 Formation of an SnS/SnS₂ Heterostructure

The reduction of SnS₂ by H₂ and H-ions is clear from the XPS data. However, what is not clear is the phases which SnS₂ has been reduced to. After all, the Sn⁴⁺ and Sn²⁺ oxidation states present in SnS₂ and SnS, respectively, are also present in the mixed oxidation states of Sn₂S₃. Structure sensitive techniques are necessary to better understand the make-up of the newly produced materials. To this end, Raman spectroscopy and cross-sectional TEM were employed.

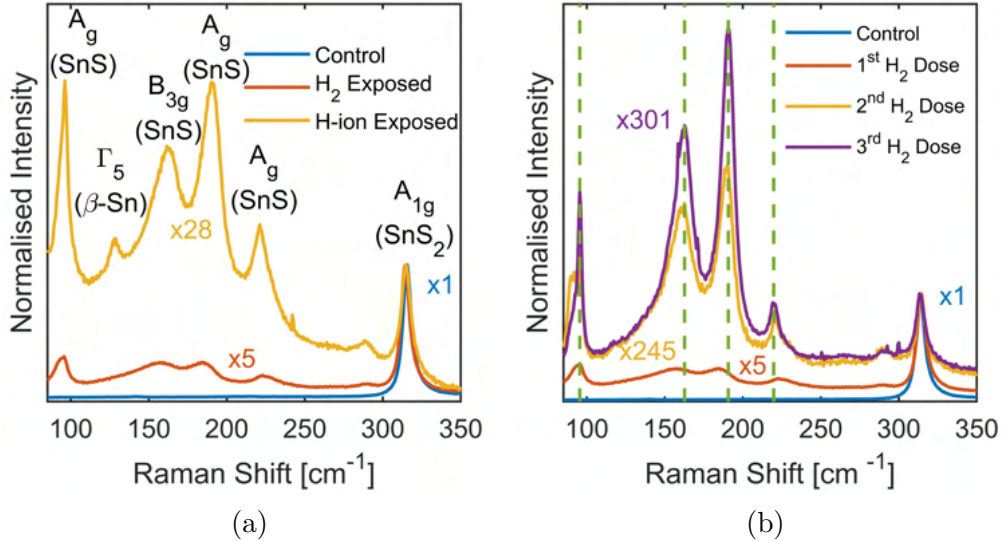


Figure 4.5: (a) Raman spectra of SnS₂ samples (control and hydrogenated samples) at 300 K and $\lambda = 632.8$ nm. (b) Raman spectra of SnS₂ repeatedly exposed to H₂. The green dashed lines indicate the positions of SnS peaks after the third dose.

Raman spectra, shown in Figure (4.5a), reveal structural phases present within the control, H₂ exposed and H-ion exposed samples. In the control sample only one feature is observed, the Raman peak at 314.5 cm⁻¹ which is assigned to the A_{1g} mode of SnS₂. This compares favourably to previous reports of this mode between 314.3 cm⁻¹ and 318 cm⁻¹ (Mead and Irwin (1976); Ding et al. (2020); Sriv et al. (2018)). The A_{1g} mode is also seen

161 in the H₂ exposed sample, although with a lower intensity, together with
162 four additional peaks centred at 95.1 cm⁻¹, 158.2 cm⁻¹, 185.1 cm⁻¹, and
163 224.1 cm⁻¹. These are assigned to the A_g, B_{3g}, A_g, and A_g modes of
164 SnS, respectively. They are in agreement with the modes expected for SnS
165 layers for which the Raman peak positions are thickness dependant (Xia
166 et al. (2016); Li et al. (2017a)). The linewidth of the SnS₂ A_{1g} peak is
167 unchanged by the exposure and the linewidths of the SnS components are
168 in-line with those reported in the literature (Xia et al. (2016); Li et al.
169 (2017a)).

170 For the H-ion exposed sample, all the Raman peaks seen in the H₂ exposed
171 sample are present. However, they are significantly weaker and shifted.
172 In particular, the Raman peaks from SnS are centred at slightly different
173 positions (96.2 cm⁻¹, 161.6 cm⁻¹, 189.1 cm⁻¹, and 221.1 cm⁻¹), in-line with
174 measurements of bulk SnS (Xia et al. (2016); Li et al. (2017a)). Also, an
175 additional Raman feature is observed at 127.5 cm⁻¹, which is assigned to
176 the Γ₅ mode of β-Sn (y Blancá et al. (1993)). Additionally, the possibility
177 of forming either α-Sn or stanene was considered, but none of the associated
178 Raman peaks could be resolved.

179 Figure (4.5b) shows the evolution of the Raman signal for a single SnS₂ film
180 upon repeated exposures to H₂. Here, the Raman spectra are normalized
181 to the A_{1g} peak of SnS₂, revealing that with increasing exposure time, the
182 Raman signal due to SnS becomes stronger relative to that of SnS₂. The
183 positions of the SnS peaks also shift with each exposure in-line with an
184 increase of the SnS layer thickness (Xia et al. (2016); Li et al. (2017a)).
185 Similar Raman experiments on the pristine and control samples confirm
186 that none of the SnS related peaks are present before H₂ exposure.

187 The Raman spectra shown in Figure (4.5) reveal that the H₂ exposed sam-

188 ples consist of SnS₂ and SnS. What they do not reveal is anything about
 189 the distribution of these materials either in the plane or normal to it. To
 190 assess the distribution normal to the plane and provide some information
 191 about the in-plane distribution over sub-100 nm distances, cross-sectional
 192 TEM was used.

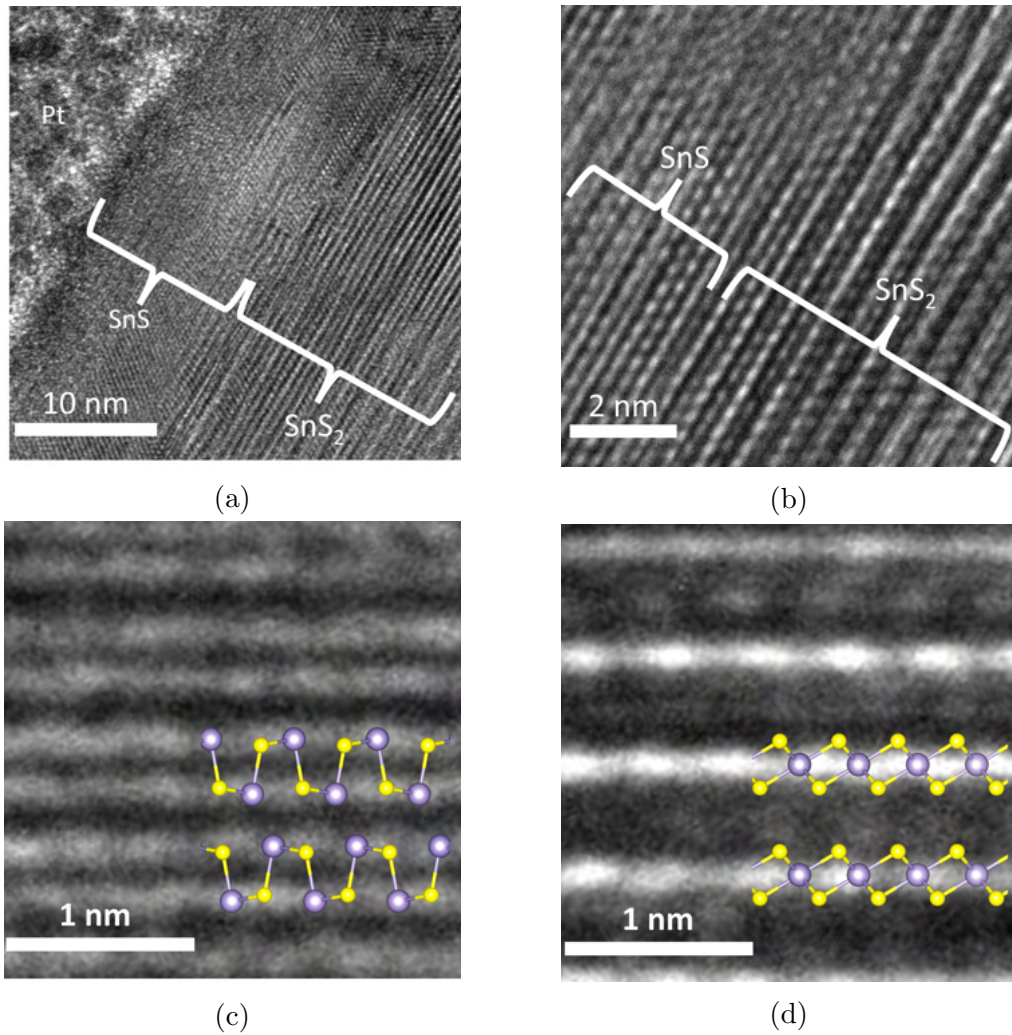


Figure 4.6: (a) Cross-sectional high angle angular dark-field Scanning TEM image of a H₂ exposed sample (5×10^{-4} mbar, 150 °C, 7 hours). (b) Cross-sectional TEM images of a H₂ exposed sample showing the SnS-SnS₂ interface. (c) Overlay of the expected SnS lattice with TEM data. (d) Overlay of the expected SnS₂ lattice with TEM data.

193 Samples of H₂ exposed SnS₂ prepared on gold were reinforced using e-beam
 194 and ion-assisted deposition of platinum. Using an ion-mill, a cross-section
 195 of suitable thickness for TEM was extracted. Shown in Figure (4.6) are

196 a selection of images from the cross-sectional TEM of this sample. Fig-
197 ure (4.6a) reveals the formation of an SnS₂/SnS heterostructure with a
198 well defined interface between the SnS and SnS₂ layers and a SnS layer
199 with a thickness of approximately 10 nm. Figure (4.6b) shows a more
200 detailed view of the interface region: the individual vdW layers can be
201 clearly identified and it is notable that they are continuous. Increasing the
202 magnification further, the characteristic paired-up rows of Sn atoms are
203 visible in the SnS region of Figure (4.6c) in line with the offset Sn atoms
204 in individual vdW layers of SnS unit cell. In contrast, unpaired rows of Sn
205 atoms are visible in the SnS₂ region of Figure (4.6d). In this case, the Sn
206 atoms of an SnS₂ vdW layer all lie in the same plane. The cross-sectional
207 TEM image in Figure (4.6d) shows the SnS₂ region in sufficient detail to
208 resolve the inter-layer vdW gap. An overlay shows the expected crystallo-
209 graphic lattice (Madelung et al. (1998)). Similarly, the SnS interlayer vdW
210 spacing can be seen in Figure (4.6c) overlaid with the corresponding lat-
211 tice (Chattopadhyay et al. (1986)). For SnS₂, the lattice parameter along
212 the c-axis is estimated at 5.9 ± 0.5 Å. This is determined over six unit cells
213 on the TEM image and is close to that (5.90 Å) reported in the literature
214 (Madelung et al. (1998)). Similarly, for SnS a lattice parameter of 11.5 ± 0.5
215 Å is estimated, close to that (11.2 Å) reported in previous studies of SnS
216 (Chattopadhyay et al. (1986)). The c lattice parameter is larger than for
217 SnS₂ as the unit cell of SnS consists of two vdW layers.

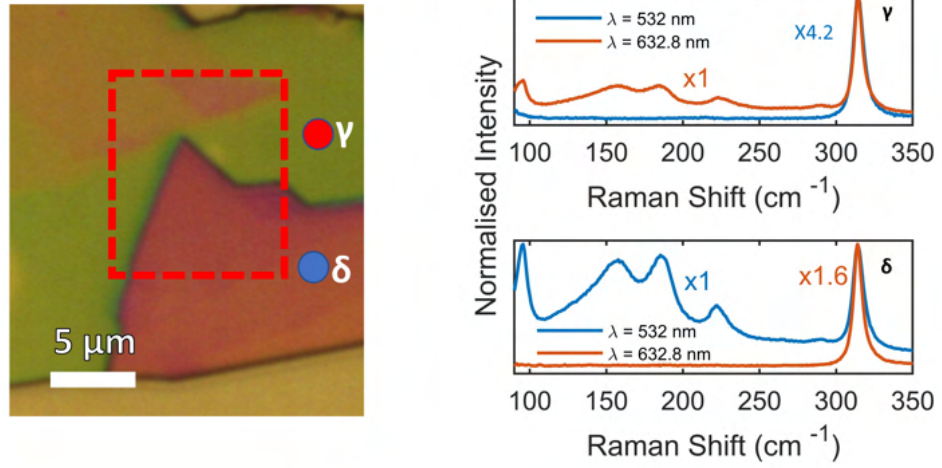
218 4.5 Optical Characteristics of SnS/SnS₂ Het- 219 erostructure

220 Information about the SnS/SnS₂ heterostructure over longer ranges (~ 10 s
221 μm) can be garnered via Raman mapping techniques. As shown previously
222 in Figure (4.5), the SnS/SnS₂ heterostructure exhibits active Raman modes
223 associated with both SnS (A_g , B_{3g} , A_g , and A_g) and SnS₂ (A_{1g}). The ratio
224 can then be taken of the area of the SnS associated peaks to the SnS₂
225 associated peaks and mapped across the surface of a flake. Over regions
226 of constant SnS₂ thickness this ratio then gives a measure of the SnS layer
227 uniformity.

228 Figure (4.7a) is an optical image of the region used for the Raman mapping
229 measurements. The region is seen to cross a discontinuity in the flake
230 associated with differing SnS₂ thickness present before the exposure to H₂.
231 When looking at point spectra, the Raman response is markedly different
232 when utilising the differing excitation wavelengths of $\lambda = 532$ nm and λ
233 $= 632.8$ nm. This is shown in Figure (4.7b), where at location γ the SnS
234 signal is present under excitation for $\lambda = 632.8$ nm but not for $\lambda = 532$
235 nm. The reverse is true for spectra gathered at location δ , with strong SnS
236 Raman features observed with $\lambda = 532$ nm and a suppression for $\lambda = 632.8$
237 nm.

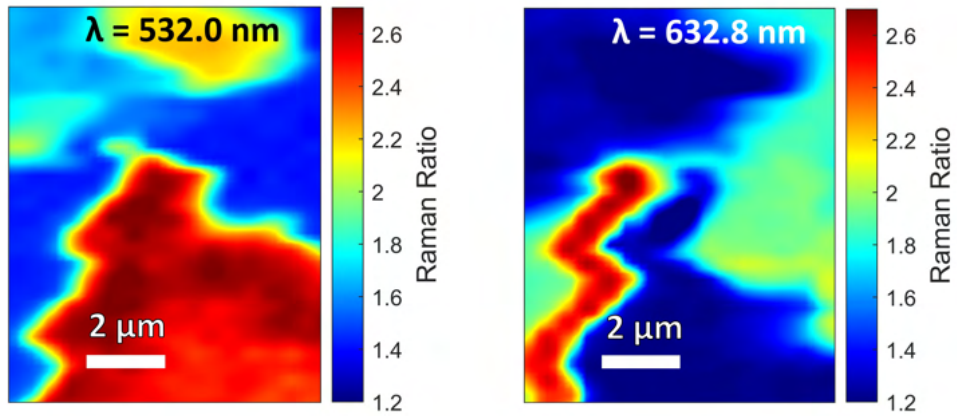
238 Raman mapping of the ratio r of the Raman signal intensity (I) due to SnS
239 and SnS₂, i.e. $r = I(\text{SnS})/I(\text{SnS}_2)$, allows the relation between the optical
240 colour contrast and the Raman signal to be observed. Figures (4.7c) and
241 (4.7d) show the Raman ratio maps of the area highlighted in Figure (4.7a)
242 with $\lambda = 532$ nm and $\lambda = 632.8$ nm, respectively.

243 It can be seen that the value of r is dependent on both the flake colour and



(a)

(b)



(c)

(d)

Figure 4.7: (a) Optical image of the areas investigated in the Raman maps as marked in red. Specific referenced locations of the flake are marked as γ and δ . (b) Raman spectra conducted on spots γ and δ in part (a). (c-d) Raman maps of the ratio of SnS to SnS₂ Raman signal for (c) $\lambda = 532.0$ nm and (d) $\lambda = 632.8$ nm.

244 the excitation wavelength λ . The colour and contrast in the optical image
 245 are determined by the interference of light reflected and transmitted at
 246 the different interfaces of the air/flake/substrate system. Thus, the colour
 247 changes as the thickness of the layers varies in the layer plane. For example,
 248 it is red (position δ , Figure (4.7a)) and green (position γ , Figure (4.7a)),
 249 corresponding to layer thicknesses of 125 nm and 175 nm, respectively,

250 as measured by AFM, shown in Figure (4.8b). As shown in the Raman
 251 map of Figure (4.7c) for $\lambda = 532.0$ nm, the thicker regions of the flake
 252 (position γ) have a stronger contribution from SnS₂ than thinner regions
 253 (position δ). The reverse is observed for $\lambda = 632.8$ nm (Figure (4.7d)).
 254 This dependence and its correlation with the colour of the flake in the
 255 optical image (Figure (4.7a)) can be accounted for by a light interference
 256 effect in which constructive (destructive) interference of light leads to a
 257 corresponding enhanced (reduced) light absorption by the SnS₂ layer and
 258 hence larger (smaller) Raman signal.

259 The Raman interference effect comes about due to the nature of Raman
 260 measurements where $\lambda_{\text{excitation}} \sim \lambda_{\text{measured}}$. Given that the Raman map-
 261 ping is conducted in the vertical orientation then the condition for the
 262 destructive and constructive interference of a thin film is then given by:

$$d = \frac{i \lambda}{2 2n}, \quad (4.2)$$

263 where d is the layer thickness, i is a factor determining the interference, λ
 264 is the laser wavelength and n is the refractive index. When i is even the
 265 interference is constructive and when it is odd the interference is destructive
 266 as there is no phase change at the interface between SnS₂ and Au due to
 267 their refractive indices (2.8 for SnS₂ and 0.2 for Au, (Ermolaev et al. (2021);
 268 Derkachova et al. (2016))). Similarly there is no phase change between the
 269 SnS₂ and SnS interface as the refractive index of SnS is ~ 4 (Diachenko
 270 et al. (2019)). As such, the regions where the conditions for constructive
 271 and destructive interference are met can be mapped onto an AFM height
 272 profile and represented as fractions of λ . This has been done for for $\lambda = 532$
 273 nm and $\lambda = 632.8$ nm in Figures (4.8c) and (4.8d), respectively. Here the
 274 contribution from SnS has been ignored and the SnS layer thickness (10 nm)

275 has been subtracted from the measured AFM height profiles. It is what can
 276 be seen from the interference maps at both excitation wavelengths is how
 277 well the interference conditions map onto both the optical colour contrast
 278 and the Raman ratio r maps of the flake. In both instances, it can be seen
 279 that only when the destructive condition is met in the SnS₂ layer can the
 280 SnS Raman signal be seen.

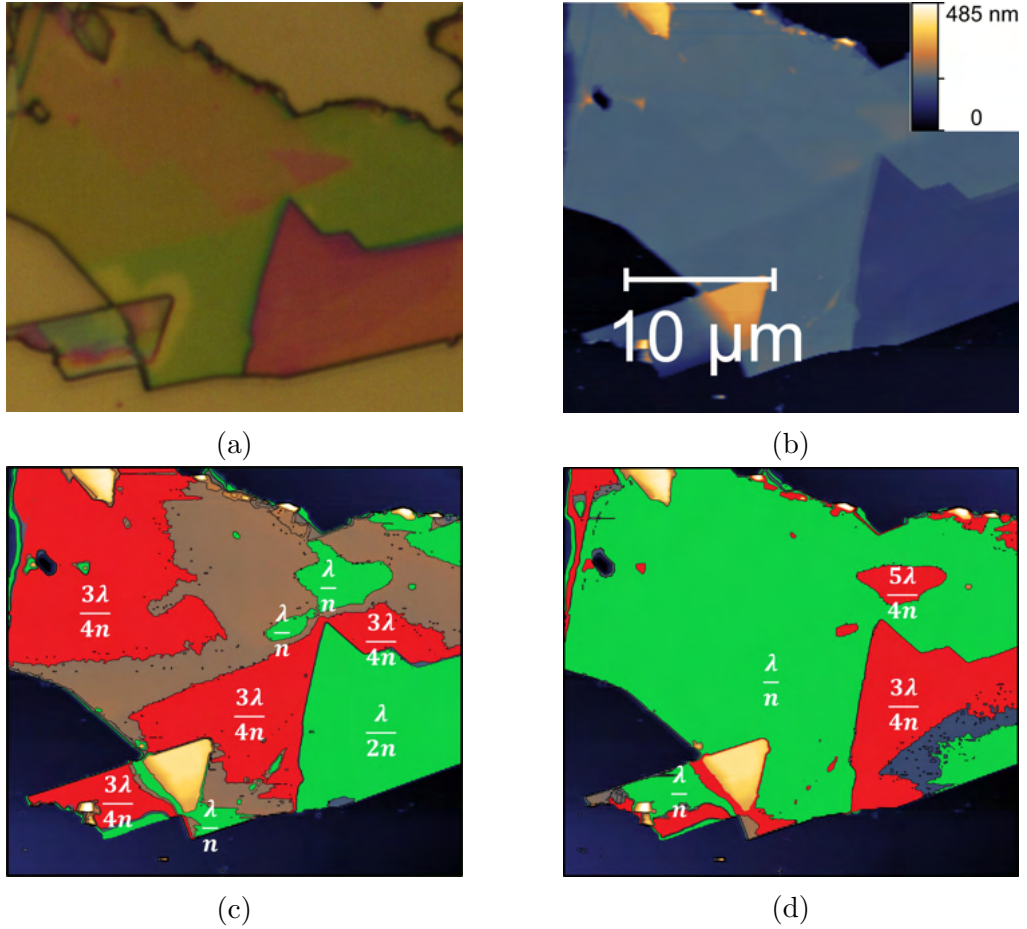


Figure 4.8: (a) Optical image of an SnS₂ flake exposed to H₂ (7×10^{-4} mbar, 150 °C, 7.5 hours). (b) AFM height map of the flake in (a). (c) AFM map as in (b) indicating regions in which the constructive (green) and destructive (red) optical interference conditions are met for $\lambda = 632.8$ nm. (d) AFM map in (b) indicating regions in which the constructive (green) and destructive (red) conditions are met for $\lambda = 532.0$ nm. Here, $n=2.8$ is the refractive index of SnS₂.

281 Given that Raman disparities between regions of different thickness can
 282 be explained via an interference effect, then the variation within regions
 283 of constant thickness is used to estimate the uniformity of the SnS layer

284 over the scale of microns. On the red and green regions of the flake in the
285 optical image, the variation in the Raman ratio (r) is found to be less than
286 8% and 14%, respectively.

287 AFM also provides a means by which the surface quality of the heterostructure
288 can be assessed. Surface studies of the heterostructures by AFM show that
289 the surface SnS layer retains a similar rms roughness to the control sample
290 at low doses (5×10^{-4} mbar, 3.5 hours, 150 °C). With increasing hydrogen
291 dose and/or exposure (greater than 7 hours), the roughness tends to in-
292 crease. Thus, under controlled hydrogen exposure conditions, it is possible
293 to realize SnS₂/SnS heterostructures with high-quality surfaces.

294 An assessment of heterostructure quality beyond the structural properties
295 described by TEM and Raman can be made via PL spectroscopy. This ex-
296 perimental probe is relevant to the potential opto-electronic applications of
297 such a heterostructure. Both bulk SnS₂ and SnS crystals have an indirect
298 band gap and their in-plane lattice constants, interlayer distances and inter-
299 layer binding energies tend to be weakly dependent on the layer thickness.
300 SnS₂ has an indirect band gap energy of 2.25 eV and a direct band-gap
301 energy of 2.38 eV (Burton et al. (2016); Yang et al. (2021)), whilst SnS has
302 an indirect band gap energy of 1.07 eV and a direct band gap energy of
303 approximately 1.4 eV (Vidal et al. (2012)). With these considerations, and
304 with reference to the absorption spectrum of SnS₂ (Yang et al. (2021)), we
305 now consider the optical properties of the flakes by examining their band
306 edge recombination (Figure (4.9b)) under different excitation wavelengths.
307 Figures (4.9c) and (4.9d) show the PL maps for the flake in Figure (4.7a).
308 The corresponding PL spectra are displayed in Figure (4.9a) and are char-
309 acterized by two bands centred at around 1.7 eV and 1.4 eV, whose relative
310 weight changes with the excitation wavelength. The PL band centred at
311 1.7 eV is red-shifted relative to the absorption edge of SnS₂, suggesting a

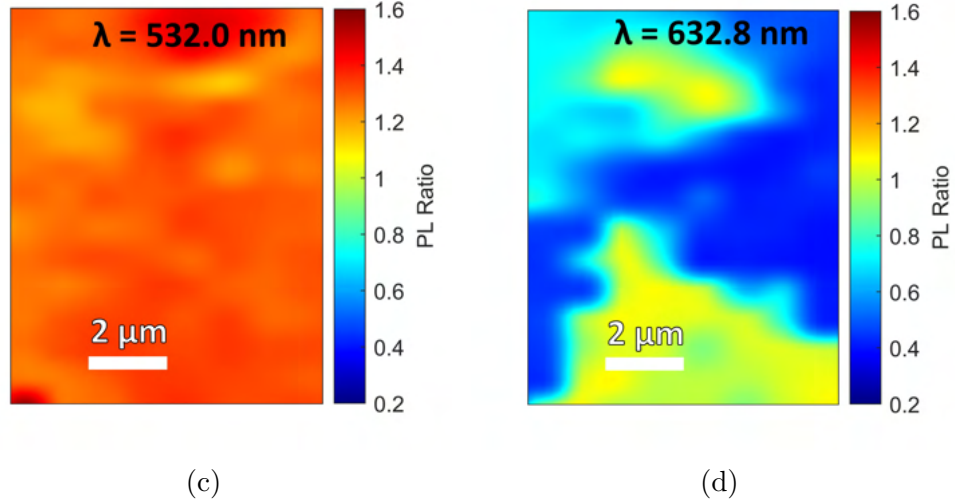
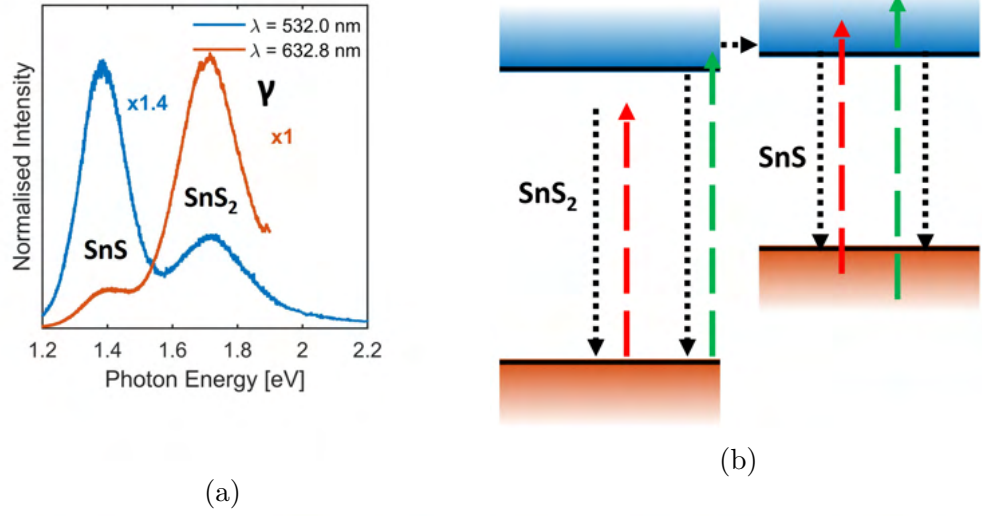


Figure 4.9: (a) PL spectra conducted on spot γ in Figure (4.7a). (b) Type II band alignments of SnS₂ and SnS and optical transitions under laser excitation at 532.0 nm (green 2.33 eV) and 632.8 nm (red 1.96 eV). Dotted and continuous lines sketch relaxation and radiative recombination, respectively. The band alignment as determined experimentally in the literature (Sugiyama et al. (2014)). (c-d) PL maps of the ratio of SnS to SnS₂ PL signal with $\lambda = 532$ nm (c) and $\lambda = 632.8$ nm (d).

312 dominant recombination of carriers from localized states, consistent with
 313 SnS₂ with a slightly reduced S content (Kudrynskyi et al. (2020)). The PL
 314 band centred at 1.4 eV was previously reported in SnS and SnS-inclusions
 315 in SnS₂ (Kudrynskyi et al. (2020); Sutter et al. (2017)). There was also
 316 an absence of the expected sizable optical anisotropy of the PL emission of

317 SnS, as measured from polarisation resolved PL (Chen et al. (2018a); Lin
 318 et al. (2018)), suggesting that the PL emission at 1.4 eV in the structures
 319 arises from the recombination of carriers from localized states (Kudrynskiy
 320 et al. (2020)). Thus, this PL band may not share the same optical
 321 characteristics of the band edge recombination.

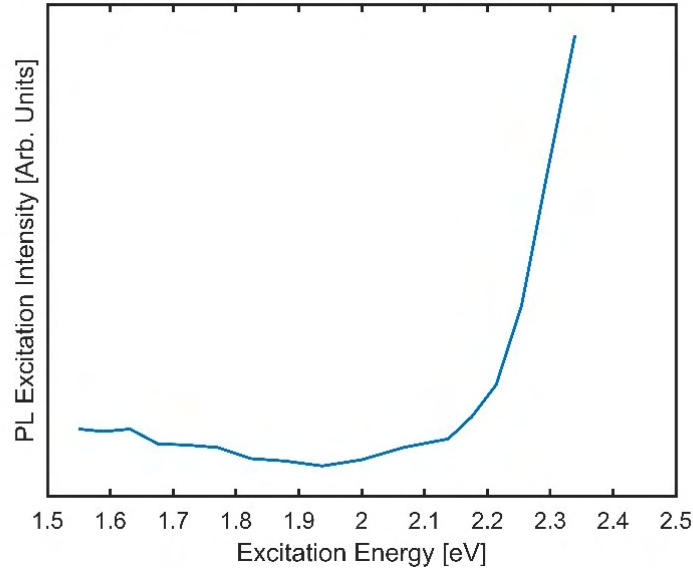


Figure 4.10: Photoluminescence excitation (PLE) spectrum for a SnS/SnS₂ heterostructure. The experiment is conducted at room temperature with a detection energy of $h\nu = 1.4$ eV, corresponding to the low-energy PL peak of the PL spectrum shown in Figure (4.9a).

322 The ratio of the integrated PL intensities, $r = I(1.4 \text{ eV})/I(1.7 \text{ eV})$, is ap-
 323 proximately 1.2 and is uniform in the layer plane for $\lambda = 532$ nm (Figure
 324 (4.9c)). Thus, the emission from SnS tends to dominate the PL emission
 325 and is uniform, suggesting that the hydrogenation leads to a homogeneous
 326 conversion of the SnS₂ surface onto SnS. Furthermore, this indicates a
 327 preferential relaxation of photogenerated carriers from SnS₂ onto SnS. In-
 328 creasing λ from 532.0 nm to 632.8 nm results in a stronger recombination
 329 signal from the defect dominated 1.7 eV band relative to the 1.4 eV band
 330 (Figure (4.9a)). The PL spectra under different excitation wavelengths can
 331 be understood in terms of different relaxation pathways for carriers and

332 by referring to the schematic of Figure (4.9b). Since the SnS/SnS₂ het-
333 erostructure has a type II band alignment with a band offset of 0.10 eV in
334 the conduction band (Sugiyama et al. (2014)), under resonant excitation
335 ($\lambda = 632.8$ nm) of the SnS₂ layer, electrons photogenerated in SnS₂ cannot
336 relax onto SnS, leading to a larger signal from SnS₂ relative to SnS and
337 corresponding decrease of r (Figure (4.9d)). This result is supported by
338 PL excitation (PLE) measurements over an extended energy range (Figure
339 (4.10)) showing that the PL emission centred at 1.4 eV (attributed to SnS)
340 tends to increase for excitation energies approaching the absorption band
341 edge of SnS₂. Finally, the PL spectra show no evidence of an interlayer
342 excitonic recombination. However, this is not unexpected due to the rela-
343 tively thick SnS and SnS₂ layers. It should be noted that in the literature
344 there is a large range of conduction band alignments from 0.1 eV to 0.5
345 eV (Sugiyama et al. (2014); Whittles et al. (2016)). These results are con-
346 sistent with the low end of that range and speak to large differences in
347 the band positioning of SnS as a result of crystal quality, composition and
348 defects (Wang et al. (2017)).

349 4.6 Computational Results

350 Density functional theory calculations were performed to examine the re-
351 action energetics for the conversion of SnS₂ to SnS via H₂. The results
352 are summarised in Table (4.1). It was found the direct conversion of SnS₂
353 to SnS without H₂ (Reaction 1) is endothermic, i.e. the reaction is not
354 energetically favourable. However, in the presence of H₂, the conversion
355 (Reaction 2) becomes exothermic and energetically favourable, with the
356 formation of H₂S as a by-product. Further conversion of SnS to β -Sn,
357 either with (Reaction 6) or without H₂ (Reaction 5), is endothermic. Sim-

Table 4.1: DFT predicted reaction energies (ΔE , in kJ mol⁻¹) of selected reactions. Positive ΔE indicates the reaction is endothermic, and negative ΔE indicates the reaction is exothermic. The symbol in the brackets denotes the phase of the reactants/products, “s” for solid and “g” for gas.

Index	Reaction	ΔE [kJ mol ⁻¹]
1	SnS ₂ (s) \rightarrow SnS(s) + S(s)	+8.6
2	SnS ₂ (s) + H ₂ (g) \rightarrow SnS(s) + H ₂ S(g)	-34.1
3	SnS ₂ (s) \rightarrow Sn(s) + 2S(s)	+114.5
4	SnS ₂ (s) + 2H ₂ (g) \rightarrow Sn(s) + 2H ₂ S(g)	+28.9
5	SnS(s) \rightarrow Sn(s) + S(s)	+105.8
6	SnS(s) + H ₂ (g) \rightarrow Sn(s) + H ₂ S(g)	+63.0

358 ilarly, the conversion of SnS₂ to β -Sn, either with (Reaction 4) or without
 359 H₂ (Reaction 3), is also endothermic. It’s notable that the presence of
 360 H₂ makes the conversion of SnS₂ or SnS to β -Sn (Reactions 4 and 6) less
 361 endothermic, by 85.6 and 42.8 KJ mol⁻¹, respectively. Thus, the DFT
 362 calculated reaction energies explain well the experimental observation on
 363 why H₂ treatment promotes the conversion of SnS₂ to SnS, but further
 364 conversion to β -Sn requires higher temperatures or longer exposure times.
 365 Conversion to β -Sn by H-ions is facilitated by the increased reactivity of
 366 the charged species and the additional 12 eV kinetic energy of the ions
 367 above the energies available to H₂.

368 4.7 Carrier Effective Mass in SnS₂

369 Detailed studies of the electronic properties of SnS₂ were conducted in
 370 collaboration with Dr. Zhuo Yang (Institute for Solid State Physics at the
 371 University of Tokyo). He performed optical transmission measurements of
 372 SnS₂ samples at high magnetic fields (150 T). These results were reported
 373 in Yang et al. (2021). By extracting the electronic band gap energy from
 374 these spectra and recording its dependence on the strength of the magnetic
 375 field, we were able to deduce important information, including the reduced

376 cyclotron exciton mass for comparison to calculated values. The magnetic
 377 field (B) dependence of the indirect band gap energy is given by

$$E(B) = E_g \pm \hbar\omega_0 + (N + \frac{1}{2})\hbar\omega_c^h + (N' + \frac{1}{2})\hbar\omega_c^e, \quad (4.3)$$

378 where $E(B)$ is the band gap energy, E_g is the band gap energy with no
 379 magnetic field, $\hbar\omega_0$ is the phonon energy, N and N' are the hole and electron
 380 Landau level quantum numbers, respectively, and $\hbar\omega_c^h$ and $\hbar\omega_c^e$ are the
 381 cyclotron energies of the holes and electrons respectively (Halpern and Lax
 382 (1965); Roth et al. (1959)). The magnetic field dependence of the cyclotron
 383 energies as given by

$$\omega_c^{e/h} = \frac{eB}{m_{e/h}^*}, \quad (4.4)$$

384 where $m_{e/h}^*$ is the cyclotron mass of electrons/holes. The masses can be
 385 combined into a reduced electron-hole cyclotron mass (μ^*) given by

$$\mu^* = \frac{m_h^* m_e^*}{m_h^* + m_e^*}. \quad (4.5)$$

386 As N and N' were found to be 0 and $\hbar\omega_0$ is assumed to be independent of
 387 B , this allows a rewriting of Equation (4.3) as

$$\Delta E = \frac{\hbar e B}{2\mu^*}, \quad (4.6)$$

388 where ΔE is the magnetically induced change in the band gap energy.

389 To accurately determine the measured band gap in the transmission spec-
 390 tra, a precise fit must be made. This is done via the following equation

$$\alpha = A \frac{(\hbar\omega - E_g - \hbar\omega_0)^2}{1 - e^{-\hbar\omega_0/k_B T}}, \quad (4.7)$$

391 where α is the adsorption coefficient, A is a constant pre-factor, $\hbar\omega$ is the
 392 photon energy, k_B is the Boltzmann constant and T is the temperature
 393 (Lipson et al. (2010)). The adsorption coefficient is then related to the
 394 transmission function (T) via an exponential ($T = e^{-\alpha t}$, where t is the
 395 sample thickness).

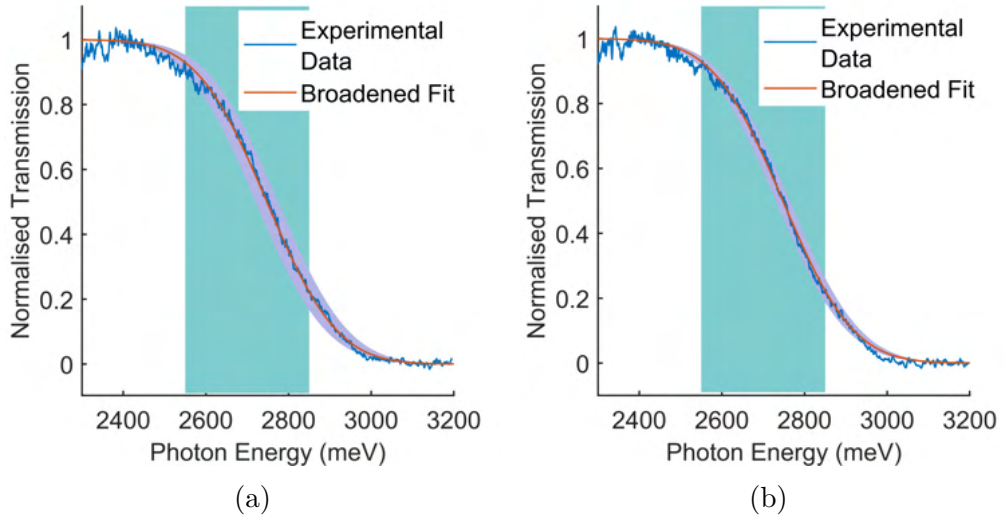


Figure 4.11: Fitting to optical transmission spectra of SnS₂ at 5 K with (a) $B = 0$ T and (b) $B = 150$ T. The teal region defines the portion of curve used to assess the error in E_g . The purple region defines the 2σ uncertainty in E_g .

396 This expression was utilised to perform a fit to the experimental data shown
 397 in Figure (4.11) with a Gaussian broadening applied. A large Gaussian
 398 broadening was required to achieve a good fit at the tails of the spectra.
 399 The values used are $\sigma = 138$ meV and 133 meV in Figures (4.11a) and
 400 (4.11b), respectively. This is much higher than $k_B T$, which is 0.43 meV
 401 at 5 K, indicating some other non-thermal component contributes to the
 402 broadening.

403 The values of E_g determined from the best fits are 2690 meV and 2688

404 meV at 0 T and 150 T at 5 K, respectively. The error was estimated from
 405 the distribution of experimental data about the line of best fit with the 2σ
 406 bound shown in purple in Figure (4.11). The 2σ error on both fits is then
 407 23.9 meV and 17.0 meV at 0 T and 150 T, respectively, in-line with the
 408 experimental spectral linewidth. It is not possible in the case of SnS₂ to
 409 resolve any band gap shift at 150 T. As no shift in the band gap energy
 410 was observed, an inspection of Equation (4.6) reveals that a lower limit can
 411 be determined for the reduced electron-hole cyclotron mass. With $\Delta E \leq$
 412 17.0 meV, this was determined as $\mu^* \geq 0.511 m_e$.

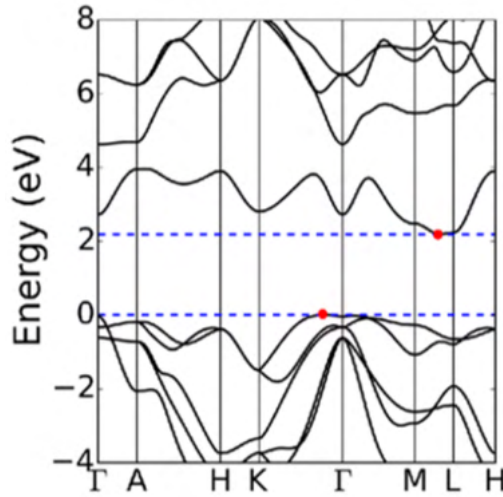


Figure 4.12: Band Structure of bulk SnS₂ computed via DFT and reported
 in Yang et al. (2021). The red dots and dashed blue lines denote the
 positions and energies of the valence band maximum and conduction band
 minimum.

413 This value of μ^* is greater than that predicted via DFT calculations which
 414 put the value of μ^* between $0.307 m_e$ and $0.378 m_e$ (Gonzalez and Oleynik
 415 (2016); Shafique et al. (2017); Yang et al. (2021)). The large value of μ^*
 416 is driven by the hole effective mass in SnS₂, which is predicted as being
 417 between $0.92 m_e$ and $1.169 m_e$, as compared to the electron effective mass
 418 which has a predicted range of between $0.46 m_e$ and $0.559 m_e$ (Shafique
 419 et al. (2017); Yang et al. (2021)). The large hole effective mass is deter-
 420 mined by the relatively flat band dispersion in SnS₂ near the valence band

421 maximum. This is shown in Figure (4.12) where the relatively flat disper-
422 sion extends along the X-K and X- Γ directions, where X is the position of
423 the valence band maximum. Along X-K and X- Γ the hole effective masses
424 are $2.583 m_e$ and $3.196 m_e$ (Yang et al. (2021)).

425 4.8 Summary

426 The results of the Raman, TEM, and XPS studies demonstrate the conver-
427 sion of SnS₂ to SnS through exposure to H₂. Furthermore, cross-sectional
428 TEM images reveal how this conversion produces a heterostructure with a
429 sharp transition from SnS₂ to SnS, indicative of a box-like diffusion. Im-
430 portantly, as with the exfoliation and stamping method frequently used in
431 lab-scale manufacture of vdW heterostructures, the *c*-axes of both SnS₂ and
432 SnS are co-axial and reveal continuous unbroken layers.

433 The uniformity of the heterostructure and its interface, as revealed by
434 TEM, is further confirmed by Raman mapping. These show Raman signals
435 from the heterostructure that are uniform over extended (micron sized)
436 regions. Also, the Raman measurements demonstrate the possibility for
437 controlling the formation and properties of the heterostructure via expo-
438 sure time or repeated exposures, resulting in an increasing Raman intensity
439 ratio $I(\text{SnS})/I(\text{SnS}_2)$ and shift of the Raman modes due to SnS. However,
440 the XPS reveals that the SnS loading may vary significantly between flakes.

441 The further conversion of SnS to β -Sn was also considered using a H-
442 ion beam and confirmed by XPS, EDX, and Raman data. The formation
443 of extended plateau features observed in the optical and SEM images is
444 explained by the increased density of Sn in β -Sn ($35.3 \text{ atoms nm}^{-3}$) than
445 in SnS ($19.6 \text{ atoms nm}^{-3}$) and SnS₂ ($14.7 \text{ atoms nm}^{-3}$), resulting in a

446 contraction of the crystal as SnS is converted to β -Sn. This behaviour is
447 in-line with previous reports of etching of SnS by hydrogen plasma (Xiao
448 et al. (2018)). A similar etching behaviour is observed in samples exposed
449 to H₂ at temperatures greater than 250 °C.

450 The chemical conversion of SnS₂ to SnS could be facilitated by the pres-
451 ence of S-vacancies, a common defect in SnS₂ (Gong et al. (2018)), with
452 a stronger binding energy to H₂, i.e. the reaction may initiate from S-
453 vacancies present on the SnS₂ surface, propagate within the layer, followed
454 by continued reaction into other layers. It is notable that these defects can
455 be induced, for example via an electron beam, and that these defects intro-
456 duce deep states within the band-gap (Sutter et al. (2017); Kumagai et al.
457 (2016)). For SnS₂ exposed to H-ions, the conversion to β -Sn is ascribed to
458 the higher reactivity of H-ions. Note that H₂ has a dissociation energy of
459 432 kJ mol⁻¹ (Herzberg and Monfils (1961)), and this may render reactions
460 4 and 6 in Table (4.1) exothermic if H₂ is replaced by protons as reactants.

461 That the conversion of SnS₂ to SnS via H₂ should produce such a highly or-
462 dered heterostructure is a surprising result. It has clear application in any
463 field where a SnS/SnS₂ heterostructure might be applied, including hetero-
464 junction diodes (Kim et al. (2018)), NO₂ detectors (Sun et al. (2019)), and
465 other opto-electronic devices (Li et al. (2018)).

466 Additionally, a study conducted to determine the reduced electron-hole
467 cyclotron mass in SnS₂ yielded a lower bound of $\mu^* \geq 0.511 m_e$. This is a
468 relatively large value when compared to theory and to other materials such
469 as GaSe, where the value is 0.13 m_e and 0.15 m_e parallel and perpendicular
470 to the c -axis, respectively (Watanabe et al. (2003)). This is relevant to the
471 design of functional devices containing SnS₂.

Chapter 5

Hydrogen - Indium Selenide Interaction

This chapter describes a number of experimental and theoretical studies of the interactions between the vdW crystal γ -InSe and both molecular and atomic hydrogen. The results of which were reported in Felton et al. (2020) authored by myself with experimental input from myself and Elena Blundo (University of Rome), a PhD student of Prof. Antonio Polimeni (University of Rome), and theoretical input from Dr. Sanliang Ling (University of Nottingham) and Joseph Glover (University of Nottingham).

Contents

5.1	Proposed Sites of Hydrogen Incorporation	97
5.2	Interaction with Hydrogen-Ions	99
5.2.1	Electron Spectroscopy Studies	100
5.2.2	Raman Studies	101
5.2.3	Photoluminescence	104
5.3	Interaction with Molecular Hydrogen	108
5.3.1	Pressure Studies	109
5.3.2	Photoluminescence and Raman Studies	110
5.3.3	Computational Studies	113
5.4	Summary	118

1 **5.1 Proposed Sites of Hydrogen Incorporation**

2 **tion**

3 The motivations for studying the interaction of γ -InSe with hydrogen are
4 threefold. Firstly, the desire to understand the ability for hydrogen to be
5 incorporated within the vdW layers of γ -InSe from both molecular and
6 ionic sources. This has relevance to the applications of hydrogen storage,
7 sensing and purification. Secondly, the ability for hydrogen to modify the
8 structural and optical properties of the crystal. The applications of which
9 lie in the desire to find ways to tune the properties of vdW materials. Third,
10 to understand the comparisons to other vdW materials where different
11 modalities of interaction have been observed but remain unexplained. For
12 example, the reasons why some vdW materials such as MoS₂ form H₂
13 filled bubbles when exposed to a H-ion beam whilst others don't remain
14 unknown (Tedeschi et al. (2019)). Intuition might suggest that the layer
15 flexibility is important in this respect. Since γ -InSe has a relatively small
16 Young's modulus (Zhao et al. (2019)), it provides a good check for this
17 intuition.

18 For samples of γ -InSe exposed to hydrogen, we propose five different sites
19 for hydrogen incorporation, four of which are shown in Figure (5.1). In
20 the first (Figure (5.1a)), the presence of H₂ molecules is sufficiently un-
21 favourable in the crystal that any introduced via an ion beam or any in-
22 corporated from the gas phase under high pressure and/or temperature are
23 expelled from the crystal when returned to ambient conditions. In this sce-
24 nario, unmodified γ -InSe remains. In the second, shown in Figure (5.1b),
25 the presence of H₂ molecules within the crystal are sufficiently favourable
26 that when introduced via ion-beam or from the gas phase, they remain in
27 the crystal under ambient conditions. This forms a monolayer in the vdW

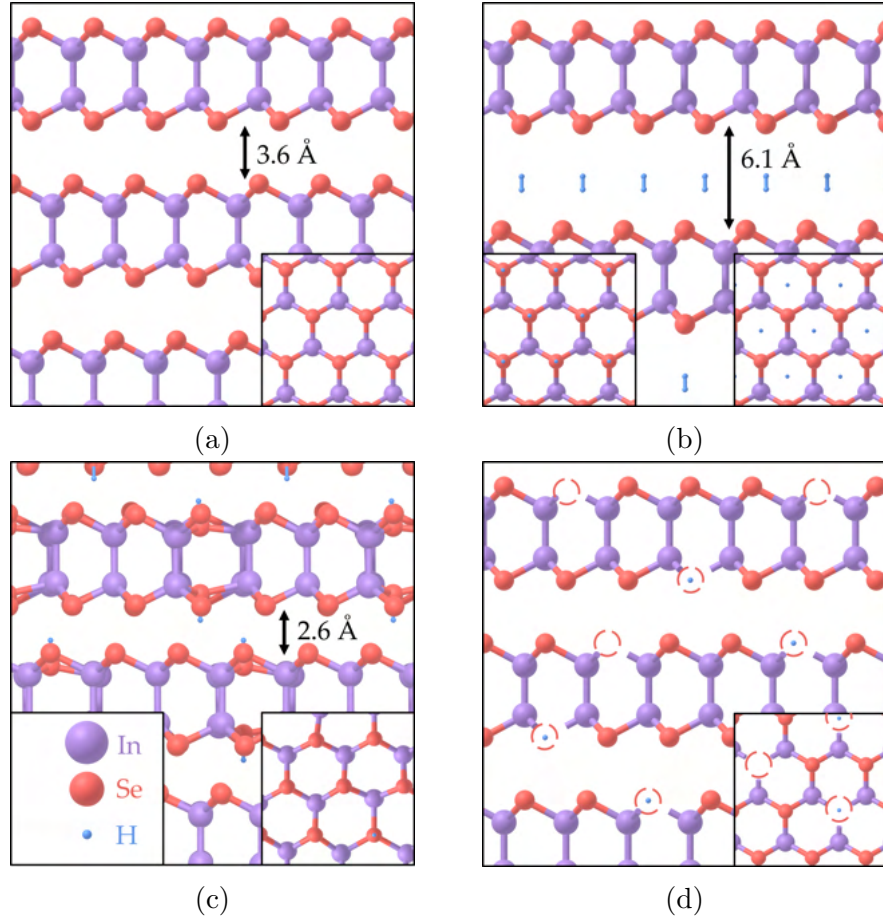


Figure 5.1: Crystallographic structures for: (a) Pristine bulk γ -InSe viewed in plane and (inset) out of plane. (b) Bulk γ -InSe containing H_2 , as computed using DFT, viewed in plane and (inset) out of plane. (c) Bulk γ -InSe with atomic hydrogen bonded to Se, as computed using DFT, viewed in plane (inset) out of plane. (d) Proposed structure of bulk γ -InSe with Se vacancies, some of which contain atomic hydrogen, as viewed in plane and (inset) out of plane.

28 gap which could ultimately lead to the formation of bent layers or domes,
 29 as seen in other layered crystals (Tedeschi et al. (2019)). In the third,
 30 shown in Figure (5.1c), the reactivity of a H-ion beam and/or gas phase
 31 H_2 is sufficiently great to react with the crystal. Shown in Figure (5.1c)
 32 is the case where H atoms bond to Se atoms within the crystal but other
 33 reaction schemes can also be envisaged. For example, a reaction wherein
 34 the crystal is reduced by hydrogen to form $InSe_x$ where $x < 1$ and H_2Se is
 35 released. This is analogous to the reaction scheme considered in chapter
 36 4. In the fourth scenario, shown in Figure (5.1d), Se vacancies present in

37 γ -InSe are occupied by atomic hydrogen. In the fifth case, Se vacancies
38 present in γ -InSe are occupied by molecular H_2 .

39 In the interest of understanding these different possibilities the interac-
40 tion between hydrogen and γ -InSe has been studied both experimentally
41 and theoretically. This was done through a combination of PL, Raman
42 spectroscopy, XPS, gas-uptake measurements, DFT simulations (including
43 phonon mode calculations), and grand canonical Monte Carlo (GCMC)
44 simulations. The interaction with H-ions is discussed first, followed by a
45 discussion on the interaction with H_2 .

46 **5.2 Interaction with Hydrogen-Ions**

47 In order to characterise the interaction between H-ions and γ -InSe, sam-
48 ples of the vdW crystal were mechanically exfoliated and dry-stamped onto
49 Au/SiO₂/Si substrates. These samples of bulk γ -InSe were then exposed
50 to atomic hydrogen using a Kaufman ion source, which produces a mono-
51 energetic beam of H-ions. When these ions implant themselves in the
52 grounded sample, they acquire an electron and become neutralised. A
53 full description of the Kaufman ion source can be found in section 3.2.2.
54 After neutralisation the behaviour of the hydrogen species is dependant on
55 the nature of the hydrogen interaction with the material in question. All
56 results were obtained from samples exposed to low beam energies of either
57 10 eV or 32 eV at temperatures of $T = 25$ °C and 80 °C and with total ion
58 doses of 1×10^{15} ions cm^{-2} and 6×10^{16} ions cm^{-2} , respectively. These sam-
59 ples were compared with pristine γ -InSe or samples covered by a H-opaque
60 mask during the hydrogenation.

5.2.1 Electron Spectroscopy Studies

Important to assessing the interaction of H-ions with γ -InSe is the possibility that the crystal may be chemically modified by the exposure. In particular, the propensity of InSe for forming Se vacancies must be considered. In the instance that Se vacancies are formed in the samples, it would be expected that they would be rapidly oxidised upon exposure to air (Balakrishnan et al. (2017)). If generated in sufficient concentrations this oxidation would be visible to techniques sensitive to the chemical state of the atoms in the sample. Such as XPS.

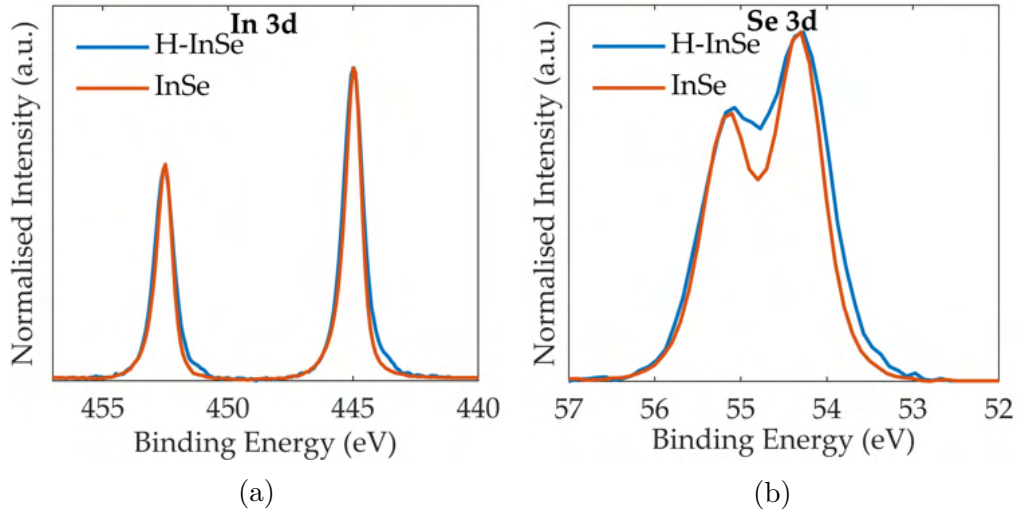


Figure 5.2: Charge corrected and normalised XPS spectra for pristine and hydrogenated (32 eV) γ -InSe. Shown are the regions corresponding to: (a) The In 3d doublet and (b) the Se 3d doublet.

Demonstrated in Figures (5.2a) and (5.2b) are the In 3d and Se 3d peaks of the masked and H⁺ (32 eV) exposed InSe samples. In the masked InSe sample, the In 3d peaks are located at 445 eV and 452.5 eV. The splitting of this doublet is 7.5 eV, in-line with the expected 7.54 eV (Wagner et al. (2003)). The most prominent components of the In 3d peaks remain unchanged by H⁺ exposure in terms of position, relative peak height and magnitude of the doublet splitting. However, in the H⁺ exposed sample

77 there is a slight broadening of both peaks towards lower binding energy,
78 accompanied by the emergence of a new small shoulder. In Figure (5.2b)
79 a similar pattern of behaviour is observed in the Se 3d peak. In the unex-
80 posed sample the Se 3d peaks are found at 54.3 eV and 55.1 eV, with an
81 associated splitting of 0.8 eV, in-line with expectations of 0.86 eV (Moulder
82 et al. (1992)). As with the In 3d peaks, there is a broadening towards lower
83 binding energy of these peaks of approximately 0.1 eV.

84 The modification of both the In and Se 3d peaks is inconsistent with the
85 changes expected from the oxidation of Se vacancies as this would induce a
86 shift of the In 3d peaks to higher binding energy and would produce little
87 change of the Se 3d peaks (Balakrishnan et al. (2017)). It is clear however,
88 that the H-ion beam has induced a chemical change in the sample.

89 **5.2.2 Raman Studies**

90 The small interaction cross-section between X-rays and hydrogen limits the
91 ability for XPS to probe the hydrogen incorporation in a given material.
92 To further assess the mode of hydrogen modification, a structure sensitive
93 technique is instead employed. To this end, a Raman spectroscopic char-
94 acterisation of the unmodified and modified material has been conducted.

95 Raman spectroscopy, being sensitive to the phonon modes of a crystal, does
96 not need to be hydrogen sensitive to be useful in this context. Instead,
97 what is needed is an understanding of the phonon origin of each Raman
98 peak and of how these peaks are modified by the presence of hydrogen in
99 different locations. Figure (5.3a) shows the measured Raman spectra of a
100 masked and H-ion exposed γ -InSe, and the phonon modes attributed to
101 each of the peaks. These modes are: the A_{1g}^1 mode at 118 cm^{-1} , the E_{2g}^1

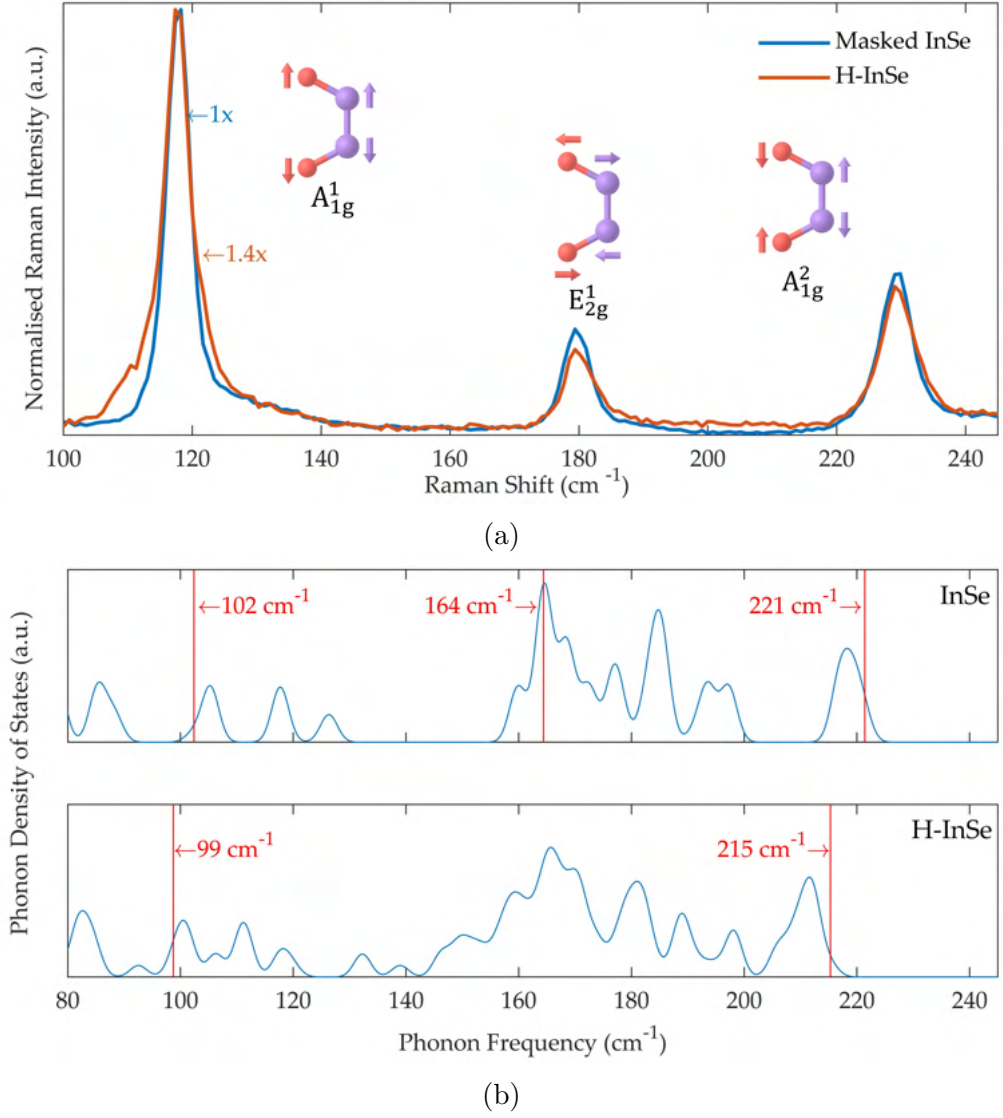


Figure 5.3: (a) Normalised Raman spectra of masked and hydrogenated (32 eV) γ -InSe, measured 12 days after hydrogenation ($\lambda = 532$ nm, $P = 0.2$ mW, $T = 300$ K). The spectra are normalised to the first Raman peak. Insets: vibrational modes responsible for the three peaks. (b) DFT-calculated phonon density of states for a pristine InSe monolayer and atomic hydrogen bonded to an InSe monolayer. These were calculated using a $4 \times 4 \times 1$ supercell. The phonon density of states are Gaussian broadened with $\sigma = 1.5$ cm^{-1} . Vertical red lines in (b) mark the position of Raman active modes, these correspond to the peaks in (a).

102 mode at 180 cm^{-1} , and the A_{1g}^2 mode at 230 cm^{-1} (Sánchez-Royo et al.
 103 (2014)). Upon exposure to the H-ion beam a reduction in the Raman
 104 intensity of $1.4 \times$ is seen. The positions of the three labelled Raman peaks
 105 remain unchanged by exposure of γ -InSe to the H-ion beam. However,

106 there is a sizable modification of the low shift tail of the A_{1g}^1 mode with
 107 a more prominent feature visible for the H-ion exposed sample. Fitting
 108 to the component allowed it to be located to 110.2 cm^{-1} . The size of
 109 the feature and the absence of similar features on the E_{2g}^1 and A_{1g}^2 modes
 110 indicates that this change is real and not associated with a change in the
 111 background signal. Also, it was noted that Raman spectra recorded in an
 112 extended range up to 4200 cm^{-1} did not yield any features consistent with
 113 the presence of H_2 (Stoicheff (1957); Leitch et al. (1998)).

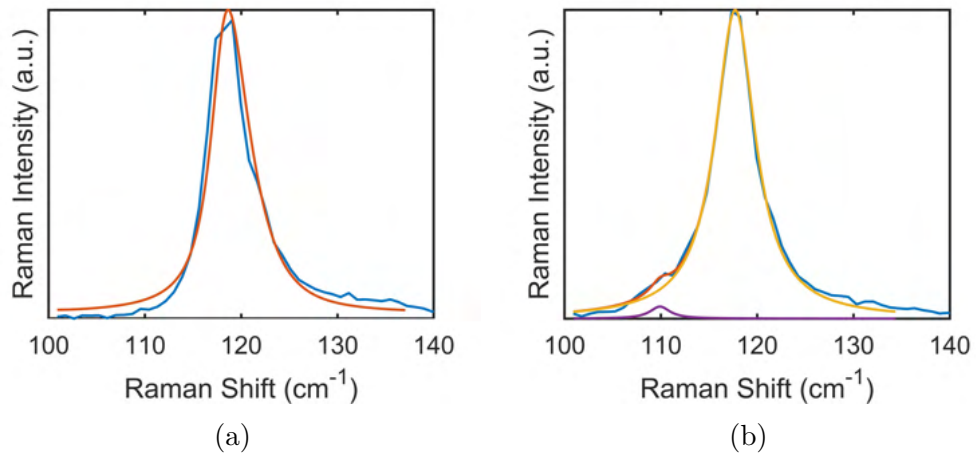


Figure 5.4: Raman spectra of the A_{1g}^1 peak of the InSe (a) control sample and (b) exposed to hydrogen. The peak are fit using an exponential broadened Lorentzian function.

114 An understanding of the structural changes of γ -InSe induced by hydrogen
 115 can be gained from computational methods. Specifically, the frequencies
 116 of the phonon modes can be computed using DFT for different sites of
 117 incorporation, such as those in Figure (5.1). Figure (5.3b) shows the sim-
 118 ulated phonon density of states for unmodified and H-bonded monolayer
 119 InSe. Monolayer InSe was used as the active Raman modes could not be
 120 identified in the H-bonded bulk γ -InSe phonon density of states and a full
 121 Raman calculation was not performed to allow for a precise identification.
 122 Across the range shown ($80 - 245 \text{ cm}^{-1}$) the total number of modes remains
 123 unchanged by hydrogen inclusion. However, following the incorporation of

124 H, the modes broaden, particularly around the E_{2g}^1 mode in the 140 - 190
125 cm^{-1} range. The position of the labelled Raman active modes can also be
126 seen to change. The A_{1g}^1 mode shifts from 102 cm^{-1} to 99 cm^{-1} and the
127 A_{1g}^2 mode shifts from 221 cm^{-1} to 215 cm^{-1} . The shift of the A_{1g}^1 mode is
128 in qualitative agreement with the experimental outcome. This result can
129 be intuitively understood as the modification of the Raman mode by the
130 additional mass of hydrogen present in the crystal. Similarly, the compu-
131 tational prediction of the modification of the E_{2g}^1 mode is consistent with
132 the slight reduction of the intensity of the measured Raman peak relative
133 to the A_{1g}^1 mode. However, the simulation fails to replicate the experi-
134 mental behaviour of the A_{1g}^2 mode (Figure (5.3a)). This may be due to
135 the limits of the simulation and the requirement to run the calculation at
136 very high hydrogen densities. H_2 incorporation fails to explain the Raman
137 changes shown in this sample, discussed later in this chapter and shown in
138 Figure (5.13). The position of the A_{1g}^1 mode shifts in the wrong direction
139 for H_2 incorporated γ -InSe. Ultimately, the H-bonded configuration shown
140 in Figure (5.1c) best explains the observed Raman and XPS behaviour.
141 However, it should be noted that the DFT underestimates the extent of
142 the change in the Raman.

143 **5.2.3 Photoluminescence**

144 The incorporation of hydrogen and/or the modification of the γ -InSe crystal
145 resulting from the interaction with hydrogen can reasonably be expected
146 to modify its optical properties. PL can be especially helpful in this regard
147 due to its sensitivity to impurities and defects within a crystal. To this
148 end room temperature and low temperature PL studies of the masked and
149 H-ion exposed (32 eV and 10 eV) samples were conducted.

150 Figure (5.5a) shows the room temperature PL spectra of masked and H-
151 ion exposed γ -InSe. The PL peak position at 1.25 eV is unaffected by
152 the presence of hydrogen, as is the PL lineshape. The intensity of the
153 PL emission does change with an $18\times$ lower PL intensity recorded in the
154 samples exposed to H-ions at 32 eV and a $10\times$ lower PL intensity recorded
155 in the sample exposed to H-ions at 10 eV, relative to the masked sample.
156 The masked sample recorded no quenching of PL intensity when measured
157 immediately before and after exposure.

158 A better understanding of the origin of the reduced PL intensity can be
159 gathered through low-temperature PL. Low-temperature PL can reveal
160 spectral features unseen at room temperature due to reduced phonon scat-
161 tering of carriers and the preferential recombination of photogenerated car-
162 riers from defect states. Figures (5.5b) and (5.5c) show the PL spectra of
163 unexposed γ -InSe and γ -InSe exposed to H-ions (10 eV) recorded at 10 K
164 for a range of exciting laser powers (P) with $\lambda = 532$ nm. The multiple
165 emission lines at low photon energies (<1.32 eV) are most prominent at
166 low excitation powers and are associated with impurities and/or defects
167 (Shubina et al. (2019); Abay et al. (1998)). No features at photon ener-
168 gies less than 1.32 eV can be successfully attributed to hydrogen, as the
169 variation between the two samples is indistinguishable from the variation
170 found within the individual samples. For photon energies above 1.32 eV,
171 the exciton (X), biexciton (XX) and exciton-exciton scattering (X-X) PL
172 lines can be identified (Shubina et al. (2019); Abay et al. (1998)). They
173 dominate the PL spectra at higher excitation powers. The X-peak in pris-
174 tine and hydrogenated (10 eV) InSe is at 1.340 ± 0.002 eV and 1.337 ± 0.002
175 eV, respectively. The position of the XX-peak in pristine and hydrogenated
176 (10 eV) InSe is at 1.333 ± 0.002 eV and 1.334 ± 0.002 eV, respectively. The
177 position of the X-X peak in pristine and hydrogenated (10 eV) InSe is at

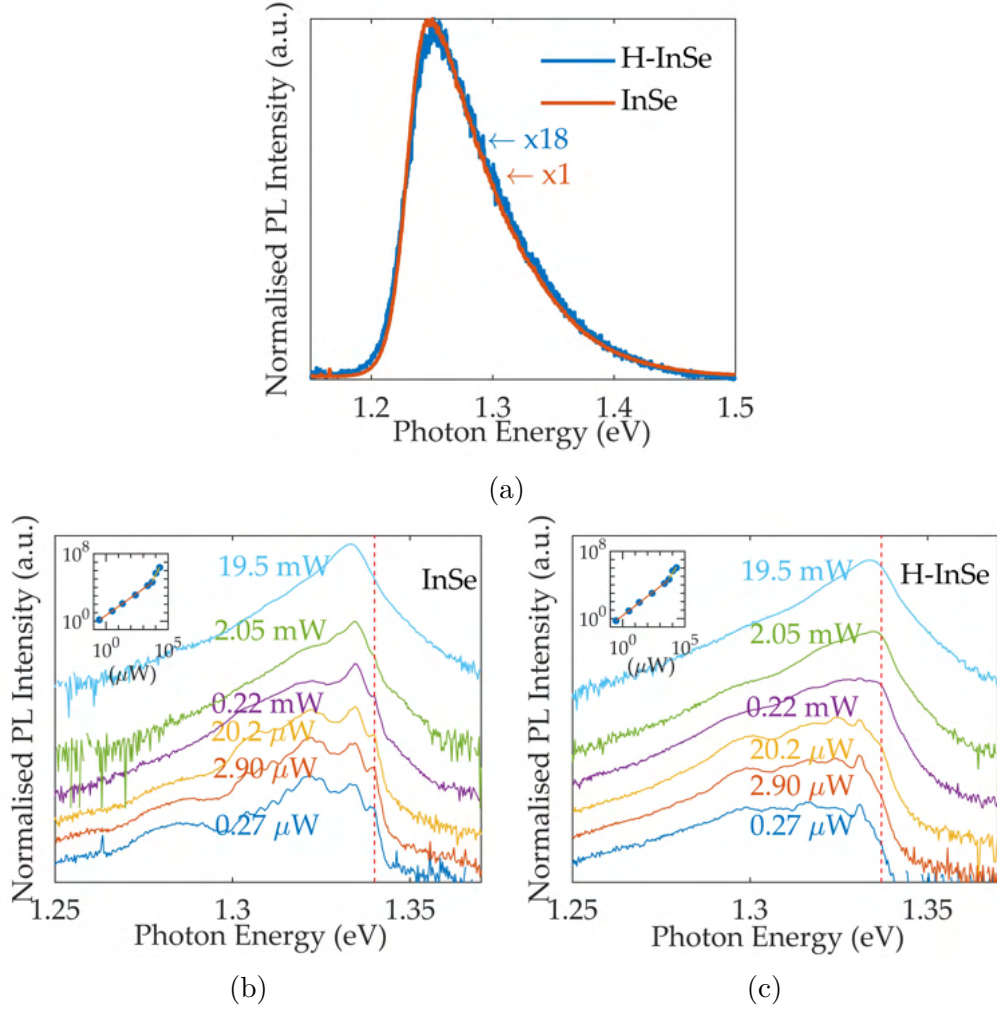


Figure 5.5: (a) Normalised PL spectra measured in masked and hydrogenated (32 eV) γ -InSe, 12 days after hydrogenation focused through a $100\times$ objective with a spot size of $\sim 1 \mu\text{m}$ ($\lambda = 532 \text{ nm}$, $P = 0.2 \text{ mW}$, $T = 300 \text{ K}$). (b,c) PL spectra measured at different exciting laser powers in pristine and hydrogenated (10 eV) γ -InSe ($\lambda = 532 \text{ nm}$, $T = 10 \text{ K}$). The spectra are plotted on a logarithmic scale with the dashed lines denoting the energy position of the exciton line (X). Insets: dependence of the total integrated PL signal on excitation power (P) on a logarithmic scale.

178 $1.331 \pm 0.002 \text{ eV}$ and $1.332 \pm 0.002 \text{ eV}$, respectively. The positions of the X
 179 and XX peaks in pristine γ -InSe are in good agreement with results from
 180 the literature (Shubina et al. (2019); Abay et al. (1998)). However, the
 181 X-X peak position is at a higher energy in both samples than the 1.32 eV
 182 peak reported previously (Shubina et al. (2019)).

183 The insets in Figures (5.5b) and (5.5a) show the dependence on power

184 (P) of the integrated intensity of the PL spectrum (I) in pristine and
185 hydrogenated γ -InSe. This is described by a power law $I \sim P^\alpha$ (Nakayama
186 et al. (2010)). In both samples two distinct regions can be seen. In the
187 pristine sample, α increases from ~ 1.0 to ~ 2.8 with increasing power. A
188 similar behaviour is observed in the hydrogenated sample with the value
189 of α increasing from ~ 1.0 to ~ 2.3 going from low to high powers. The
190 superlinear dependence at high power reflects the contribution to the PL
191 from XX and X-X recombination. The onset of the superlinear dependence
192 occurs at higher power in the hydrogenated sample than in the pristine
193 sample by approximately one order of magnitude when all the tested control
194 and hydrogenated samples were considered. This suggests an increasing
195 concentration of defects and/or impurities in these samples, causing the
196 recombination of carriers from these states to acquire importance relative
197 to that of free excitons. This finding and the lower room temperature
198 PL intensity in the hydrogenated samples suggests that hydrogen acts as a
199 centre for non-radiative recombination of carriers in H-ion exposed samples.

200 If H_2 is present in H-ion exposed samples then a phase-transition might be
201 observed upon varying the temperature. Figure (5.6) shows the tempera-
202 ture dependence of the PL signals in masked and H-ion exposed γ -InSe. A
203 small difference is apparent between the two samples at 10 K due to the
204 reduced excitonic features in hydrogenated γ -InSe. Otherwise, both sam-
205 ples PL signals progress in the same manner towards the expected room
206 temperature lineshapes with the two samples lineshapes and peak positions
207 indistinguishable by 80 K.

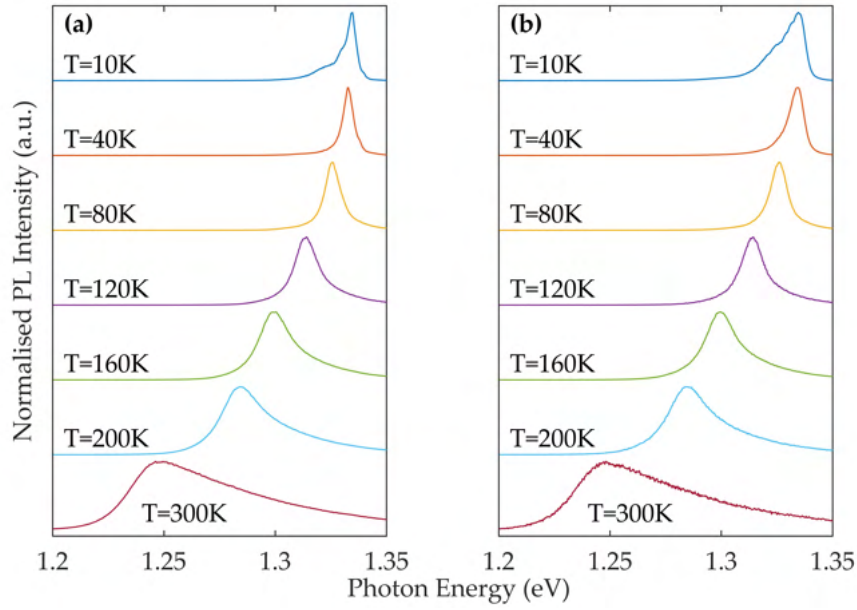


Figure 5.6: PL spectra between $T = 10$ K and 300 K of (a) masked γ -InSe and (b) H^+ exposed γ -InSe (10 eV) ($\lambda = 532$ nm, $P = 2.05$ mW, $100\times$ objective).

208 5.3 Interaction with Molecular Hydrogen

209 The interaction of InSe with molecular hydrogen is important in under-
 210 standing the applicability of InSe to hydrogen technologies and in assess-
 211 ing the ability for molecular hydrogen to modify γ -InSe, for example, via
 212 intercalation, as considered in Figure (5.1b).

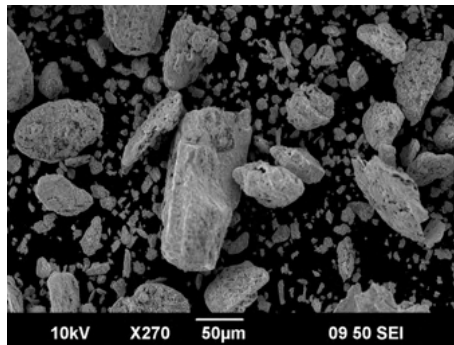


Figure 5.7: SEM image of powdered γ -InSe.

213 The samples considered in this study are bulk freshly exfoliated γ -InSe
 214 and powdered γ -InSe (shown in Figure (5.7)). An additional mechanically

215 exfoliated InSe sample was stamped onto an SiO₂/Si substrate for use in
216 optical studies. Hydrogen exposures were conducted using the Sieverts ap-
217 paratus described in section 3.2.1. Of interest here are two distinct, but
218 related phenomena: first, whether hydrogen can be intercalated within the
219 vdW gaps present in InSe, relevant to potential applications in hydrogen
220 storage, purification, and sensing; second, what modification can be intro-
221 duced to the InSe crystal via an interaction with hydrogen. These aspects
222 are examined below.

223 **5.3.1 Pressure Studies**

224 The Sieverts apparatus used to assess the uptake of H₂ consists of two con-
225 nected chambers of known volume which can be separated or connected
226 via a valve with a pressure transducer attached to the non-sample chamber
227 (manifold). The sample is placed into one of these chambers and both are
228 evacuated. With the chambers separated, the empty chamber is filled with
229 a known pressure of H₂ gas and allowed to stabilise. The valve connecting
230 the two chambers then is opened to allow the gas to interact with the sam-
231 ple. If the hydrogen does not interact with the sample, then the pressure in
232 the combined chambers should match that expected from the non-ideal gas
233 equation. Any deviation from the expected pressure indicates an uptake of
234 H₂ by the sample. This uptake is then converted to a weight percentage
235 (wt%), an important figure of merit for hydrogen storage in mobile appli-
236 cations. The approximate error in wt% for an InSe sample in this system
237 is 0.1 wt% . A full description of the operating principles and calibration
238 of the Sieverts system is given in section 3.2.1.

239 Bulk samples of InSe, grown via the Bridgman method, were the first to be
240 investigated. The typical size of the samples is approximately 2×5×1 mm³.

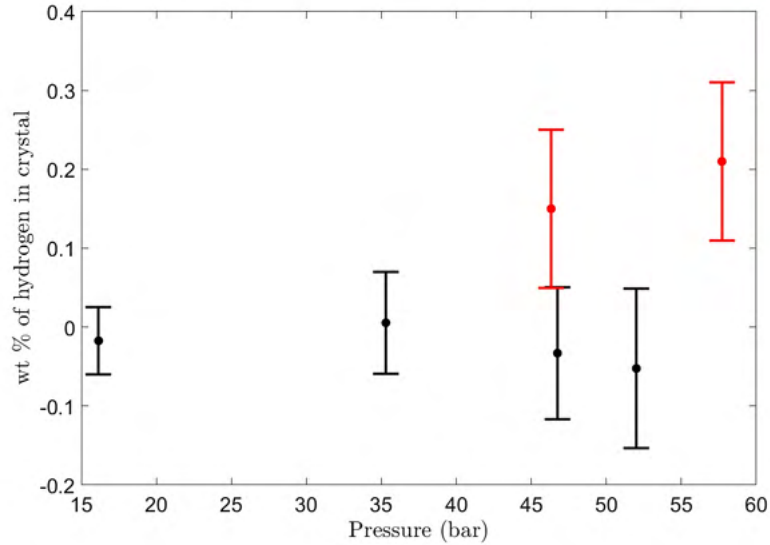


Figure 5.8: The room temperature uptake isotherms of (black) bulk γ -InSe and (red) powdered γ -InSe.

241 The second set of samples to be investigated were powdered InSe with a par-
 242 ticle size of 5-200 μm . Figure (5.8) shows the isotherm generated for bulk
 243 InSe (black) and powdered InSe (red). Here, the wt% is plotted against the
 244 H_2 gas pressure. The isotherm generated for bulk γ -InSe does not reveal any
 245 hydrogen uptake. However, the powdered InSe sample does indicate some
 246 incorporation of H_2 . Additionally, pressure against time plots recorded on
 247 the powdered γ -InSe sample were consistent with hydrogenation upon in-
 248 creasing pressure and dehydrogenating upon decreasing pressure. What is
 249 not clear from the gas-uptake measurements is the method and location of
 250 the hydrogen incorporation and whether the powdered uptake is a result
 251 of surface adsorption or a greater ability for intercalation.

252 5.3.2 Photoluminescence and Raman Studies

253 As with the samples of γ -InSe exposed to H-ions via a Kaufman ion source,
 254 any modification of the γ -InSe crystal structure induced by hydrogenation
 255 can be expected to produce a corresponding change in the PL and Raman

256 spectra.

257 PL and Raman measurements were performed on InSe before and after
 258 exposure to H_2 . In this instance, as the mass limitations of pressure studies
 259 don't apply, additional mechanically exfoliated samples were also studied.
 260 Figures (5.9a) and (5.9b) show the PL and Raman spectra, respectively,
 261 of a typical exfoliated γ -InSe flake. The exposure has very little effect on
 262 either the PL or Raman spectra. The PL spectra show a slight reduction
 263 in intensity by $1.9\times$, whereas the Raman spectra reveal an increase in
 264 intensity by $1.3\times$. Changes of this scale could arise from slight differences
 265 in the optical excitation and detection between the samples resulting from
 266 experimental variation.

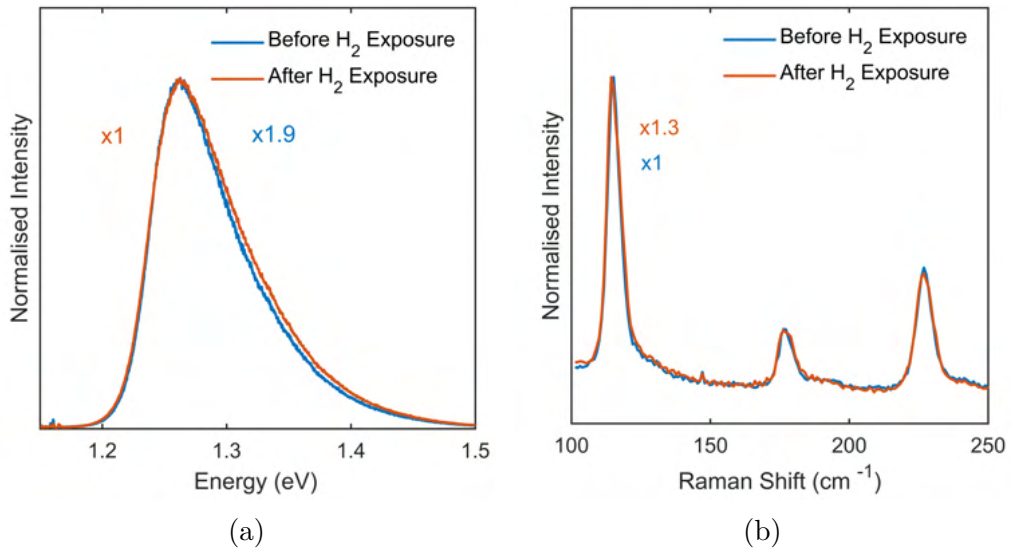


Figure 5.9: (a) Room temperature PL of mechanically exfoliated γ -InSe on a SiO_2/Si substrate before and after exposure to H_2 ($\lambda = 532$ nm, $100\times$ objective). (b) Room temperature Raman spectra of the same flake ($\lambda = 532$ nm, $100\times$ objective).

267 It might be expected that the powdered samples show a more pronounced
 268 modification in optical properties given that they demonstrated a greater
 269 hydrogen uptake than single crystals. Shown in Figure (5.10) are the PL
 270 and Raman spectra from γ -InSe powder before and after exposure to hydro-
 271 gen. The PL measurements reveal a large inhomogeneity across different

272 locations of the sample. This is likely due to degradation in the samples re-
 273 sulting from the milling process. Overall, the typical PL intensity remains
 274 unchanged by the H₂ exposure and any shift in the PL peak position, or the
 275 emergence of new components, is masked by the variation between sample
 276 locations.

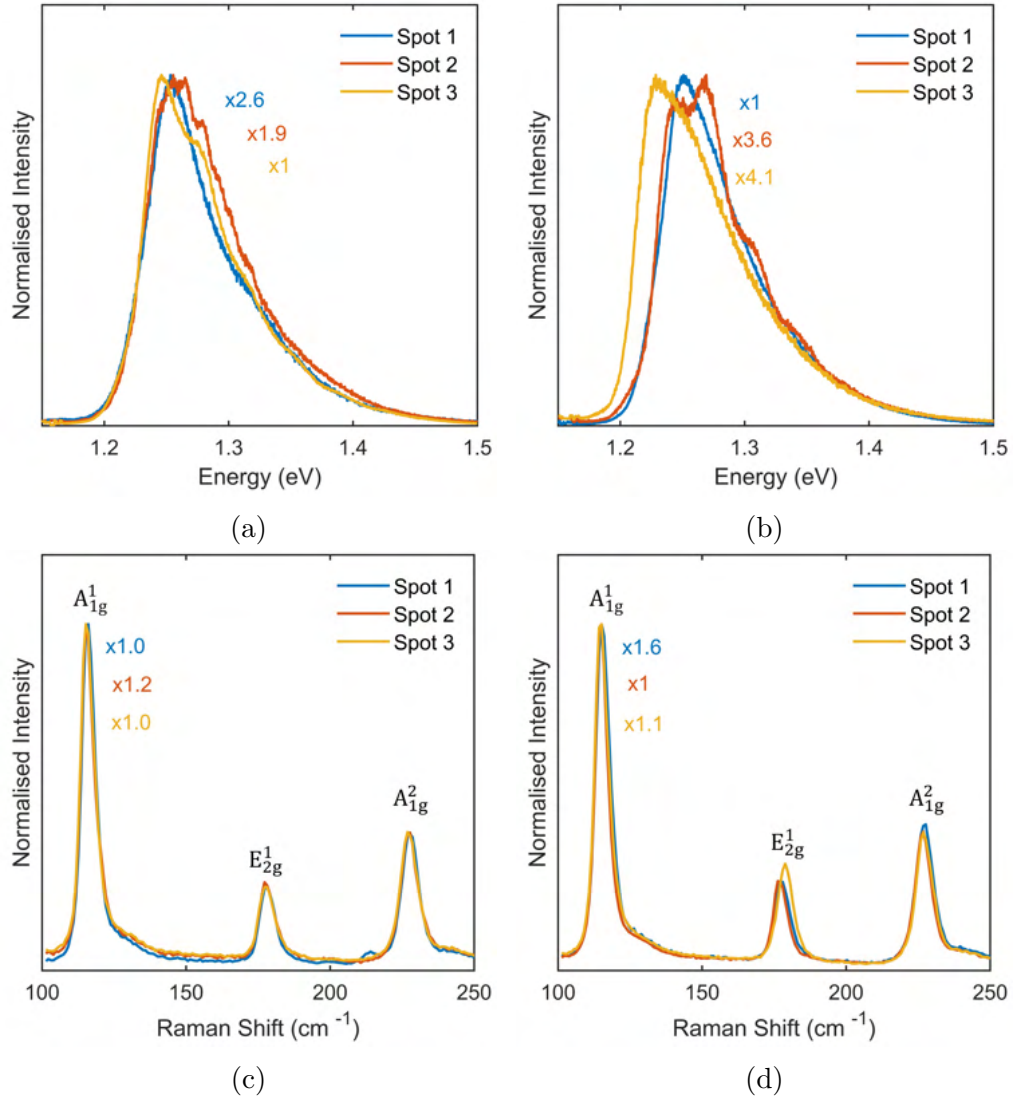


Figure 5.10: Normalised PL measurements of (a) pre-exposure γ -InSe powder and (b) post H₂ exposure γ -InSe powder. Normalised Raman measurements of (c) pre-exposure γ -InSe powder and (d) post H₂ exposure γ -InSe powder. All measurements conducted with $\lambda = 532$ nm, through a 100 \times objective. PL measurements used a 150 g/mm grating and Raman measurements utilised a 1200 g/mm grating.

277 The Raman spectra, shown in Figures (5.10c) and (5.10d), also reveal very

278 little changes resulting from hydrogen exposure. The variation between
 279 location in the Raman measurements is less than that for the PL measure-
 280 ments, with the most significant variation seen in the E_{2g}^1 peak. However,
 281 despite this greater uniformity, there is no change that can be attributed
 282 to the presence of H_2 .

283 5.3.3 Computational Studies

284 Given that uptake of H_2 has been recorded in powdered γ -InSe (see Fig-
 285 ure (5.8)), it is perplexing as to why there is no change attributable to
 286 H_2 present in either PL or Raman measurements. There are two poten-
 287 tial explanations for this. First, that H_2 does not remain in the crystal
 288 at pressures below the pressure at which it was hydrogenated. There is
 289 some experimental evidence for this from the de-hydrogenation gas-uptake
 290 measurements. Second, that the PL and Raman properties of the γ -InSe
 291 crystals are very weakly modified by the incorporation of hydrogen. To test
 292 these possibilities a number of thermodynamic calculations were conducted.

Table 5.1: Energy cost of introducing H_2 into various sites of the InSe crystal in kJ mol^{-1} as determined by DFT. The number in brackets indicate a calculation where the InSe crystal is allowed to relax. All other numbers assume no relaxation of the crystal just atomic positions.

γ-InSe Bulk	Interlayer 30.1 (29.3)	Intralayer 19.8
InSe Monolayer	On Surface -6.0	Intralayer 20.7

293 Thermodynamic calculations conducted using DFT can be used to deter-
 294 mine the formation enthalpies of different states. As such, it can then be
 295 used to determine the energy associated with incorporating hydrogen in
 296 different locations within a structure as compared to the pristine structure
 297 and free hydrogen. Table (5.1) shows the results of such calculations for

298 H₂ introduced to γ -InSe and monolayer-InSe in various configurations. In
299 bulk γ -InSe the incorporation of H₂ in both the interlayer and intralayer
300 spaces is found to be favourable. Unintuitively, it is the incorporation in
301 the intralayer space which is found to be the more favourable of the two
302 configurations. An additional consideration can be made when the cell
303 parameters of the γ -Inse crystal are allowed to relax. In the interlayer
304 configuration, this slightly lowers the energy cost associated with hydrogen
305 incorporation. This requires an increase in the size of the vdW gap from
306 3.6 Å to 6.1 Å. When interaction with an InSe monolayer is considered,
307 the surface adsorption of H₂ is seen to be favourable. As with γ -InSe, the
308 introduction into the intralayer space remains unfavourable.

309 It is clear from DFT calculations that the incorporation of hydrogen in the
310 interlayer space of γ -InSe is energetically unfavourable. This may be due
311 to the high electron densities in the interlayer space of γ -InSe (Li et al.
312 (2019); Sun et al. (2018)). However, the cost of this incorporation can be
313 lowered by allowing an increase in the size of the vdW gap.

314 A full description of the gap-size dependence of hydrogen uptake in γ -InSe
315 was achieved via Grand Canonical Monte Carlo (GCMC) simulations. This
316 process randomly samples the potential landscape of the crystal to deter-
317 mine the preferred sites of adsorption and/or absorption. The final spatial
318 distribution is then given by molecules accepted or rejected from specific
319 sites based on their available thermal energy and the energy required for
320 incorporation.

321 Figure (5.11) shows the heatmaps generated for H₂ at 298 K and a pressure
322 of 20 bar for an unmodified vdW gap (Figure (5.11a)) and a sequence of 1
323 Å vdW gap increases in Figure (5.11b - 5.11f). For the unmodified gap, the
324 site of greatest H₂ incorporation is the surface exposed to H₂ gas. Upon

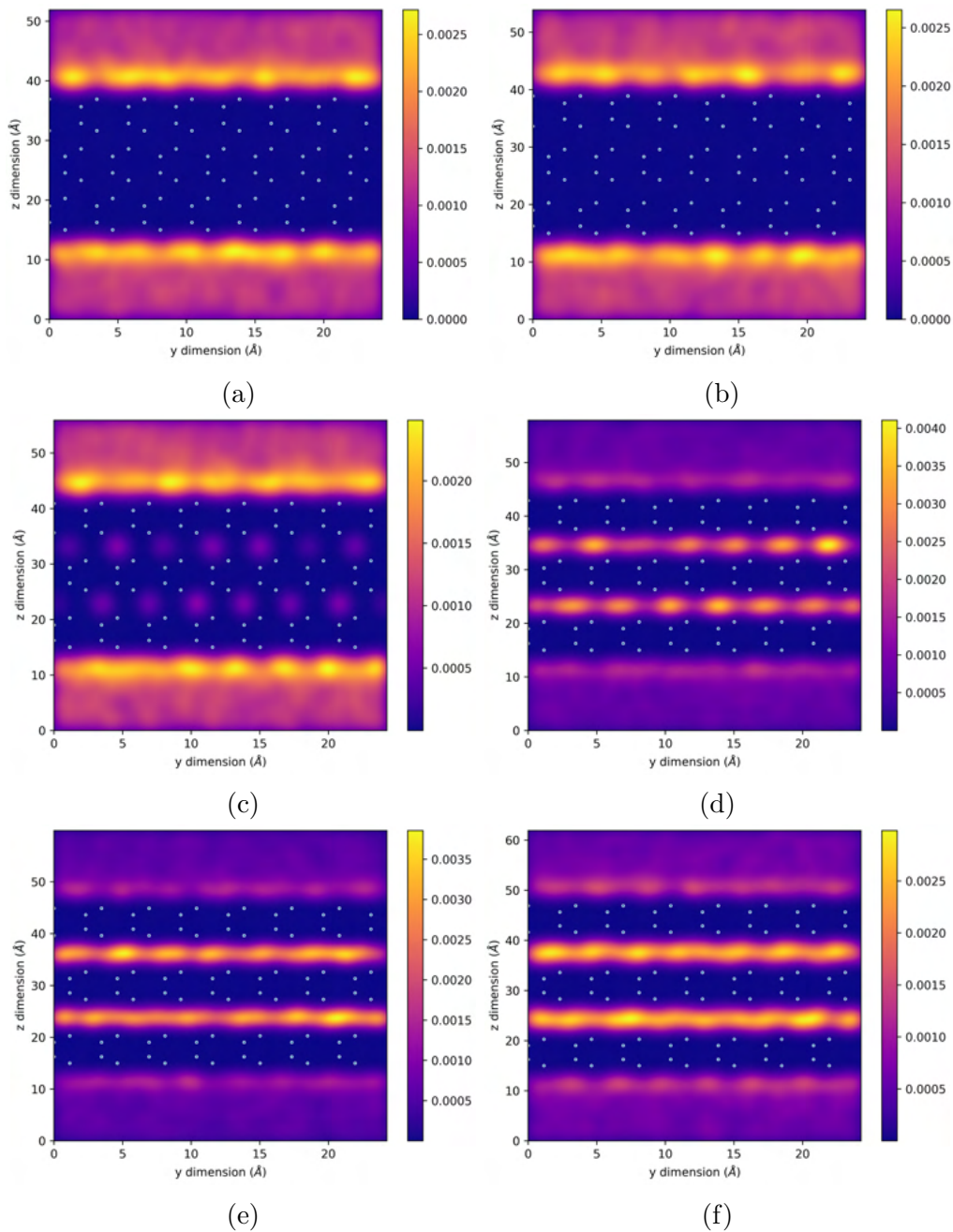


Figure 5.11: Heatmaps showing the H₂ density within a γ -InSe crystal at 20 bar, as calculated using kernel density estimation from GCMC simulations for (a) unmodified γ -InSe, (b) γ -InSe with the vdW gap increased by 1 Å, (c) with the vdW gap increased by 2 Å, (d) with the vdW gap increased by 3 Å, (e) with the vdW gap increased by 4 Å and (f) with the vdW gap increased by 5 Å.

325 increasing the size of the gap, the concentration inside the gap increases. In
 326 particular, when the size of the gap is increased by 3 Å or greater there is a
 327 greater concentration of H₂ in the vdW gap than on the crystal surface. A

328 significant increase in the concentration of H_2 within the vdW gap happens
 329 for increases of 2.5 \AA or above. This compares to the kinetic diameter of
 330 the hydrogen molecule of 2.9 \AA (Ismail et al. (2015)).

331 Hydrogen-uptake isotherms generated from GCMC simulations support the
 332 data shown in the heatmaps. Figure (5.12) shows the hydrogen loading in
 333 three layer InSe. The isotherms with a the increase of the vdW gap of <2.5
 334 \AA represent the hydrogen adsorption on the surface, whilst those of >2.5
 335 \AA indicate the hydrogen incorporated within the gaps. There is very little
 336 difference in the uptake within those systems with the gap increase $\geq 3 \text{ \AA}$
 337 and within those with a gap increase $\leq 2 \text{ \AA}$. The inability of H_2 to enter the
 338 interlayer space may be due to the nature of the P_z orbitals which project
 339 into the interlayer space and result in a high interlayer electron density (Li
 340 et al. (2019); Sun et al. (2018)).

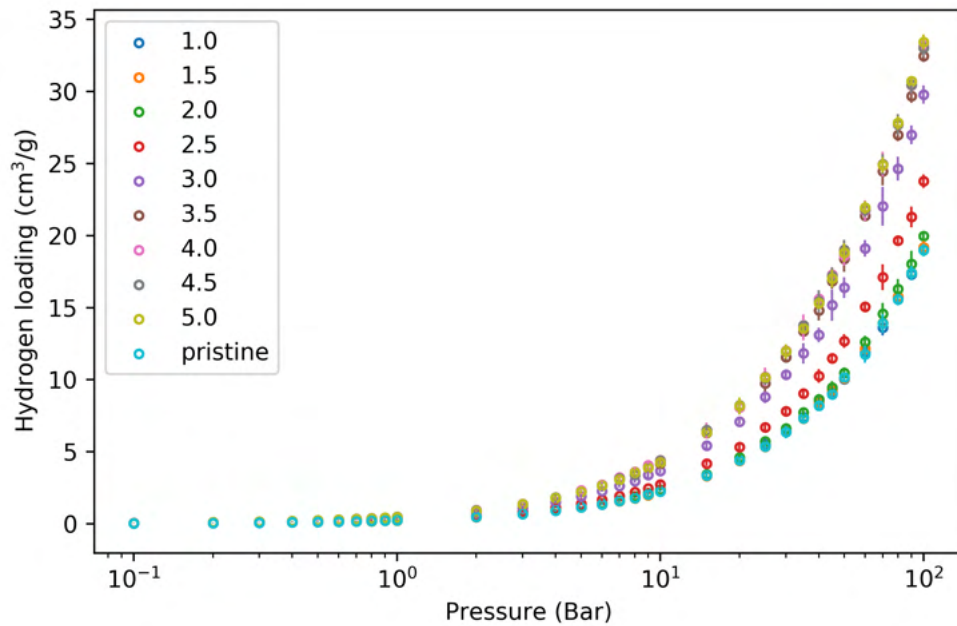


Figure 5.12: Hydrogen uptake isotherms generated from GCMC simulations at 298 K for γ -InSe crystals with different increases in the size of their vdW gaps.

341 As was done for H^+ exposed γ -InSe, the phonon density of states can be

342 calculated for H_2 incorporated γ -InSe. Figures (5.13a) and (5.13b) show
 343 the simulated phonon modes of pristine γ -InSe and hydrogen intercalated
 344 γ -InSe as shown in Figures (5.1a) and (5.1b), respectively. The peaks in the
 345 phonon density of states are noticeably narrowed between 150 cm^{-1} and
 346 190 cm^{-1} in the hydrogenated structure. A new peak emerges between
 347 230 cm^{-1} and 233 cm^{-1} associated with translational modes of hydrogen
 348 within the vdW gap. The position of the active Raman modes is also seen
 349 to shift with the A_{1g}^1 peak shifting from 98 cm^{-1} to 100 cm^{-1} , the E_{2g}^1
 350 mode shifting from 163 cm^{-1} to 161 cm^{-1} and the A_{1g}^2 shifting from 206
 351 cm^{-1} to 214 cm^{-1} . It is notable that the A_{1g}^1 and A_{1g}^2 modes shift towards
 352 their monolayer values (shown in Figure (5.13c)). This is not true for the
 353 E_{2g}^1 mode, likely due to the displacement of the atoms in this mode being
 354 parallel to the vdW gap rather than normal to it as in the case of the A_{1g}^1
 355 and A_{1g}^2 modes.

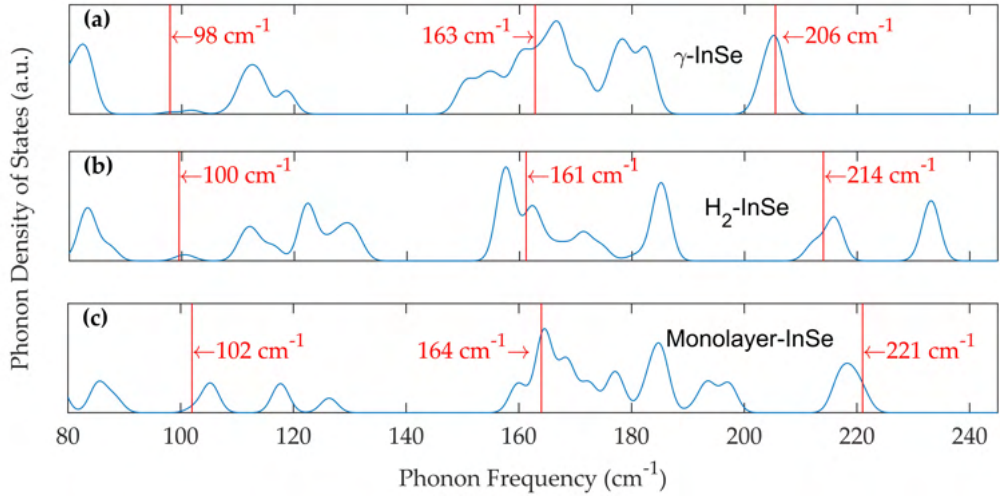


Figure 5.13: DFT-calculated phonon density of states in: (a) Bulk pristine γ -InSe, using a $3 \times 3 \times 2$ supercell, (b) Bulk γ -InSe intercalated with H_2 using a $3 \times 3 \times 2$ supercell and (c) monolayer-InSe. The phonon density of states are Gaussian broadened with $\sigma = 1.5 \text{ cm}^{-1}$. Vertical red lines mark the position of the A_{1g}^1 , E_{2g}^1 and A_{1g}^2 active Raman modes.

356 5.4 Summary

357 Samples of γ -InSe irradiated with H-ions from a Kaufman ion source ex-
358 hibited suppressed room temperature PL intensity and decreased excitonic
359 character at low temperature. This indicates that hydrogen acts as a centre
360 for non-radiative recombination of photo-generated carriers. The incorpo-
361 ration of hydrogen was found to modify the A_{1g}^1 Raman mode of γ -InSe.
362 This modification is qualitatively consistent with the binding of atomic hy-
363 drogen to the selenium atoms in the crystal (shown in Figure (5.1c)) and
364 is considered the most likely scheme of modification. Gas uptake measure-
365 ments have indicated the ability for molecular hydrogen incorporation in
366 powdered γ -InSe. Time-dependent uptake measurements and the lack of
367 modification in PL and Raman properties of the crystal indicate that the
368 hydrogen does not remain in γ -InSe under ambient conditions. This is sup-
369 ported by DFT measurements which indicate that the incorporation of hy-
370 drogen is unfavourable under ambient conditions. Upon increasing the size
371 of the vdW gap by 2.5 Å the incorporation of H_2 becomes favourable and
372 the phonon density of states becomes more monolayer-like in nature. This
373 finding suggests an interesting possibility to create thin layers via interca-
374 lation with H_2 and to modify the interlayer phonon coupling of bulk-like
375 γ -InSe. This possibility could be explored in future experiments at higher
376 H_2 pressures and or temperatures.

377 The behaviour of hydrogen in γ -InSe is qualitatively different from that ob-
378 served in other vdW crystals, such as the transition metal dichacogenides,
379 where the presence of hydrogen in the vdW gap leads to the formation of
380 hydrogen filled 'bubbles' (Tedeschi et al. (2019)). A possible reason for
381 the difference in phenomenology is the strong interlayer vdW interaction
382 of γ -Inse, owing to the projection of P_z orbitals into the vdW gap (Li et al.

383 (2019); Sun et al. (2018)). This is evidenced in the similarities between the
384 kinetic diameter of the H₂ molecule and the vdW gap increase required for
385 the successful incorporation of hydrogen.

Chapter 6

Gallium Selenide for Photocatalysis

This chapter considers the interaction between water and GaSe. This is relevant to the application of solar water splitting, a low carbon method of hydrogen production. Specifically, the modification of the valence band of GaSe by adsorbed water species and permanent water-induced oxidation is considered. This was assessed via the techniques of near ambient pressure X-ray photoelectron spectroscopy (NAP-XPS), atomic force microscopy (AFM), ultraviolet photoelectron spectroscopy (UPS), Raman spectroscopy, photoluminescence spectroscopy (PL) and angle resolved photoelectron spectroscopy (ARPES). The results reveal the morphology of partially oxidised GaSe as well as the water-induced band bending in GaSe and modifications to the valence band of GaSe by partial oxidation. The NAP-XPS work was conducted at the University of Nottingham in collaboration with Jack Hart, a PhD student of Dr James O'Shea; the AFM was conducted in collaboration with Dr Vladimir Korolkov (Park Systems) as well as with Dr Jonathan Bradford (University of Nottingham).

Contents

6.1	GaSe for Solar Water Splitting	122
6.2	XPS Studies of the Interaction Between Water and GaSe	126
6.3	Surface of GaSe	132
6.4	The Optical and Electronic Properties of GaSe	135
6.5	Summary	145

1 **6.1 GaSe for Solar Water Splitting**

2 The process of solar water splitting utilises the energy of incoming solar
3 photons to generate a photovoltage for the separation of water into hy-
4 drogen and oxygen. In solar water splitting devices the photovoltaic and
5 water splitting components are integrated into the same device. In prin-
6 ciple, this has the ability to achieve solar to hydrogen efficiencies greater
7 than that in systems where the photovoltage generation and water splitting
8 are performed by two separate devices, for example by a photovoltaic panel
9 connected to an electrolyser (Juodkazytė et al. (2016)). The difficulty in
10 realising integrated solar water splitting devices is the need for materials
11 with the properties required for both the photovoltaic and catalytic com-
12 ponents of a device. Specifically, the photovoltaic requirements are for a
13 material with efficient absorption of the solar spectrum, an ability for effi-
14 cient charge carrier separation, long carrier lifetimes and a sufficiently large
15 band gap. The catalytic requirements are for large specific surface areas,
16 efficient species (H_2O , OH^- , H^+ , O_2 and H_2) adsorption/desorption, and
17 suitably aligned electronic band edges.

18 2D and vdW crystals are natural candidates when looking for materials
19 with the properties required for photocatalysis. They inherently have large
20 surface area to volume ratios, have been shown to exhibit excellent opto-
21 electronic properties (Lee et al. (2008); Miró et al. (2014)), and with band
22 gaps tuneable through quantum confinement, alloying and strain (Naumis
23 et al. (2017); Kudrynskyi et al. (2020)). It is important when identifying
24 candidate vdW materials for solar water splitting that they meet certain
25 conditions. The first consideration is the suitability of their band edge
26 positions. This requires that the material has a band gap greater than the
27 redox potential of water (1.23 V) and that the conduction band minimum

28 (CBM) is located higher than the H^+/H_2 redox potential, while the valence
 29 band maximum (VBM) is located below the $\text{H}_2\text{O}/\text{O}_2$ redox potential (Jiang
 30 et al. (2017)). These conditions ensure that charge transfer at the material-
 31 electrolyte interfaces is favourable. Depending on the device structure the
 32 position of the band edges might only need to be satisfied at one interface.
 33 Typically, these devices would also require an additional external bias to
 34 operate (Jiang et al. (2017)).

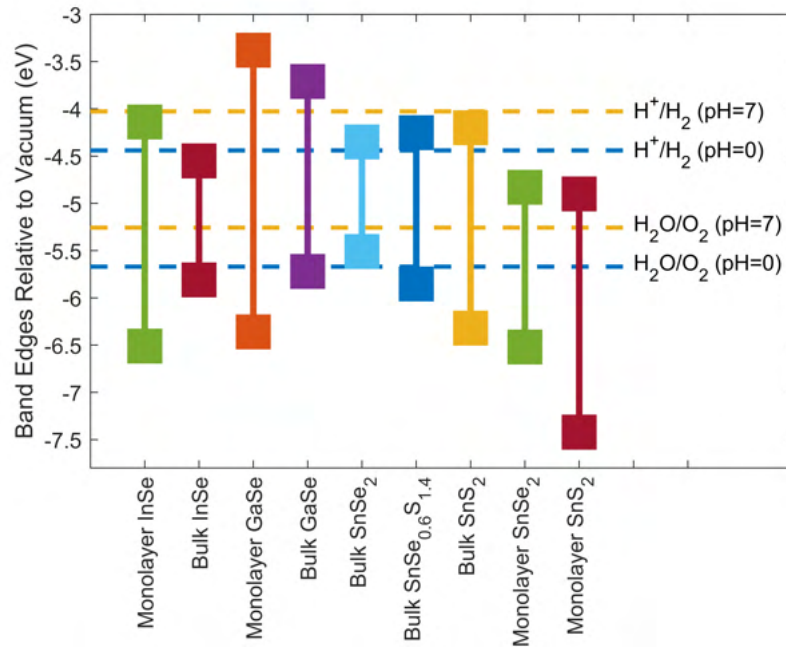


Figure 6.1: The position of the valence band and conduction band edges of various vdW materials relative to the vacuum level and compared to the H^+/H_2 and $\text{H}_2\text{O}/\text{O}_2$ redox potentials. Band edge positions extracted from the literature (Zhuang and Hennig (2013a); Lang et al. (1999); Brudnyi et al. (2015); Zhuang and Hennig (2013b); Fu et al. (2019); Kudrynskyi et al. (2020)).

35 Figure (6.1) shows the band edge positions for a selection of vdW materials
 36 relative to the water redox potentials at $\text{pH} = 7$ and $\text{pH} = 0$. The ability for
 37 the reduction in dimensionality of vdW crystals to modify the band edge
 38 positions and consequently the suitability of a materials for photocatalysis
 39 is demonstrated here. Whilst monolayer InSe, monolayer GaSe, bulk GaSe,
 40 bulk $\text{SnSe}_{0.6}\text{S}_{1.4}$ and bulk SnS_2 all have suitable band edge positions for

41 water splitting at $\text{pH} = 0$, only bulk and monolayer GaSe are suitable
 42 when the $\text{pH} = 7$. Bulk GaSe has a band gap of 2.02 eV, whilst monolayer
 43 GaSe has a larger band gap of between 3 eV and 3.5 eV (Ferrer-Roca et al.
 44 (1999); Rybkovskiy et al. (2011)). Both of these values are above the 1.23
 45 eV minimum required for water splitting and sit within the optimum 1.8
 46 eV - 3.2 eV range required for efficient absorption of the solar spectrum
 47 and for generating a suitably large overpotential required for overcoming
 48 energetic barriers (Jiang et al. (2017)).

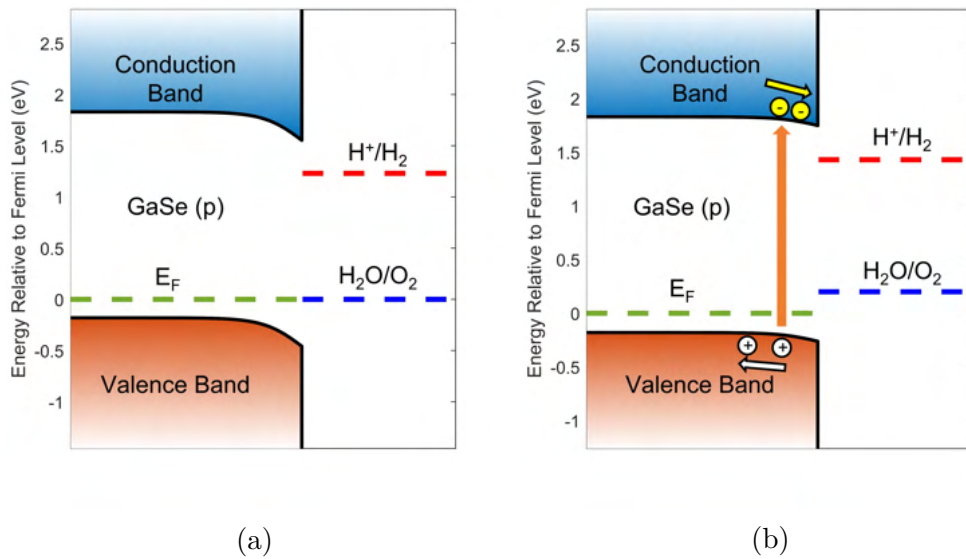


Figure 6.2: The water induced band bending of the GaSe valence and conduction bands near the surface in bulk GaSe under (a) dark conditions and (b) illumination.

49 When placed into water, a semiconductor will experience band bending at
 50 the surface. The nature of the band bending is dependant on the conduc-
 51 tivity type of the semiconductor and the position of its Fermi level relative
 52 to the water redox potential. In n-type semiconductors the band bending
 53 will act to align the Fermi level at the surface with the H^+/H_2 redox po-
 54 tential, in p-type semiconductors the Fermi level will instead align with the
 55 $\text{H}_2\text{O}/\text{O}_2$ potential (Jiang et al. (2017)). As GaSe is a p-type conductor,
 56 the Fermi level aligns with the $\text{H}_2\text{O}/\text{O}_2$ potential. This is shown in Figure

57 (6.2a) for bulk GaSe. As the position of the Fermi level in bulk GaSe is
58 below the $\text{H}_2\text{O}/\text{O}_2$ potential, a downward band bending of up to 0.3 eV
59 would present at the surface if the alignment is assumed to take place en-
60 tirely in GaSe (Balakrishnan et al. (2014)). The origin of the bending is
61 charge transfer between the highest occupied molecular orbital (HOMO)
62 of the water and GaSe. In the electrolyte this corresponds to a higher con-
63 centration of negatively charged water species on/near the surface and the
64 establishment of a Helmholtz layer (Jiang et al. (2017)). A consequence of
65 the band bending is an ability for the separation of mobile charge carriers.
66 Shown in Figure (6.2b) is a sketch of the band bending induced by the sep-
67 aration of photogenerated carriers in water exposed GaSe when illuminated
68 with photons with an energy greater than the band gap. Electrons move
69 towards the surface of the material whilst holes move towards the bulk.
70 This has the effect of reversing some of the water induced band bending
71 and flattening the bands due to a slight build up of negative charge near
72 the surface.

73 The ability for GaSe to to act as both a catalyst and photocatalyst has
74 been demonstrated previously (Zappia et al. (2020); Meng et al. (2022)).
75 In these reports, various modifications have been made to GaSe with the
76 intention of improving its catalytic properties. For example, GaSe-based
77 nanoribbons have a larger surface area than that of a planar structure (Zap-
78 pia et al. (2020)). Similarly, optimisation for the adsorption/desorption of
79 species has been achieved by creating local catalytic centres via oxidation
80 (D'Olimpio et al. (2020)). However, the optimisation studies often fail to
81 consider the effect of the modifications on other properties required for
82 photocatalysis. For example, the increasing catalytic activity via oxidation
83 would also be expected to introduce centres for charge carrier recombina-
84 tion and might also modify the band edge positions and optical absorption

85 characteristics.

86 With these concepts in mind, it was decided to investigate some of the
87 properties of GaSe relevant for water splitting. Given the propensity for
88 oxide formation in GaSe exposed to water, it is important that the modifi-
89 cation of the electrical band structure and the positions of the band edges
90 are understood in oxidised GaSe. For this purpose the techniques of near
91 ambient pressure X-ray photoelectron spectroscopy (NAP-XPS), atomic
92 force microscopy (AFM), ultraviolet photoelectron spectroscopy (UPS),
93 Raman spectroscopy, photoluminescence (PL) spectroscopy and angle re-
94 solved photoelectron spectroscopy (ARPES) were used.

95 **6.2 XPS Studies of the Interaction Between** 96 **Water and GaSe**

97 XPS is routinely used to study the core level electrons within a material.
98 However, in materials with a sufficiently large XPS cross-section, it can
99 also be used to study the valence band. The resulting spectrum reflects the
100 density of states within the valence band of the material. Also, available in
101 this instance, is the ability to conduct near ambient pressure XPS (NAP-
102 XPS), which allows for in-situ XPS of systems under pressures of several
103 mbar. This facilitates an in-situ study of the valence band and core shell
104 electrons in GaSe before, during and after exposure to water. The system
105 also includes a 1.5 solar global air mass simulator, which provides additional
106 data of how the system behaves under illumination.

107 A sample of bulk GaSe was freshly cleaved and secured to a standard
108 XPS sample plate using carbon tape. Whilst acting quickly to minimise

109 air exposure, the sample was loaded into the NAP-XPS system. Once
110 loaded and under pressures of better than 10^{-9} mbar, spectra of the valence
111 band, O 1s, Ga 2p and Se 3d regions were obtained in dark conditions and
112 under illumination by the solar simulator. The sample was then exposed
113 to water vapour at 1.5 mbar ($T = 298$ K, 2 hours), with the same peaks
114 measured under dark and solar simulator illumination conditions in the
115 NAP configuration. Finally, after water exposure, low pressure ($<10^{-9}$
116 mbar) XPS spectra of the same peaks were recorded under dark and light
117 conditions.

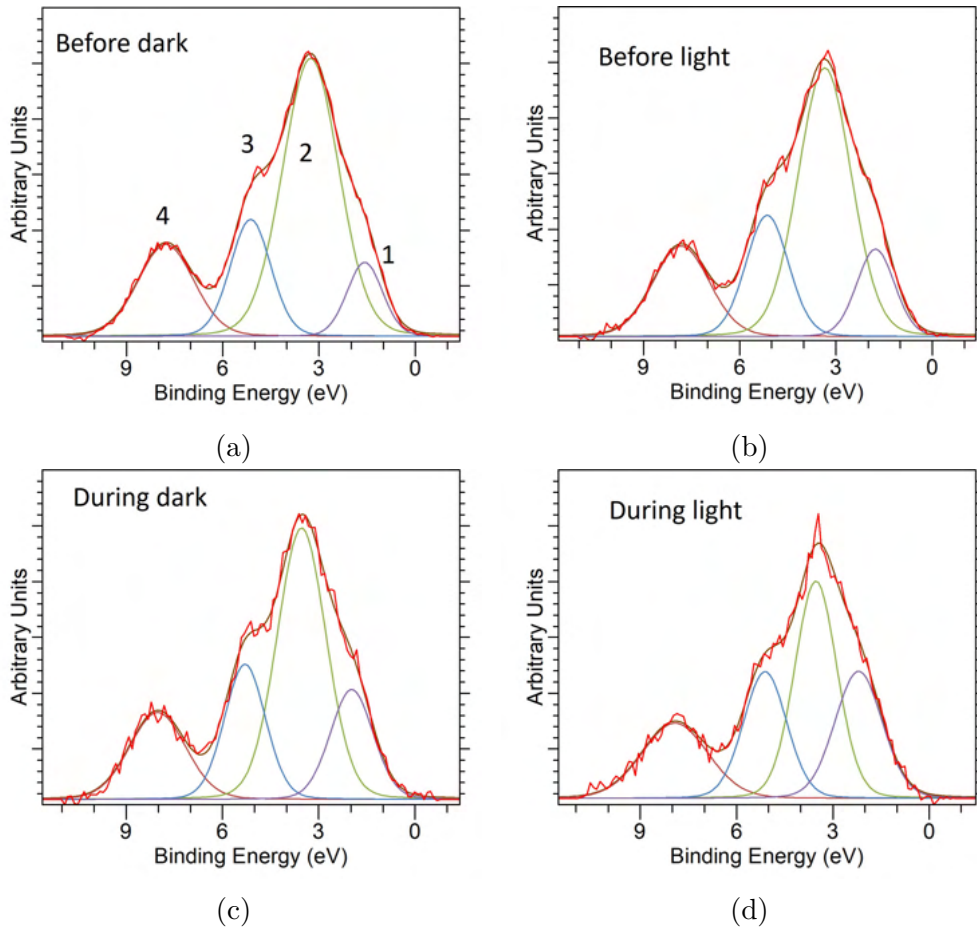


Figure 6.3: The XPS valence band spectra of GaSe are displayed with their component fits for samples (a) before water exposure in dark conditions, (b) before water exposure under illumination by a solar simulator, (c) during water exposure in dark conditions, and (d) during water exposure under illumination by a solar simulator. A Tougaard background and 10/90 Lorentzian Gaussian blend was used for the fitting.

Table 6.1: Valence band component positions corresponding to the fittings in Figure 6.3.

	Peak 1 (eV)	Peak 2 (eV)	Peak 3 (eV)	Peak 4 (eV)
Before Dark	1.58	3.26	5.13	7.77
Before Light	1.77	3.35	5.14	7.82
During Dark	1.97	3.53	5.30	8.02
During Light	2.20	3.46	5.11	7.92
D'Olimpio et al.	-	3.1	4.7	7.6

118 Figure (6.3) shows the fittings to the valence band of GaSe under vacuum
 119 and during water exposure in dark conditions and under illumination with a
 120 solar simulator. The peak positions are quoted in Table (6.1) and compared
 121 with those from air exposed GaSe obtained by D'Olimpio et al. (2020).

122 The fits in Figure (6.3) have been overlaid in Figure (6.4) to allow for direct
 123 comparison of the spectra. Before exposure to water, four components
 124 can be seen in the valence band spectra. Of which, peaks 2, 3, and 4
 125 compare favourably to previously reported peaks at 3.1 eV, 4.7 eV and 7.6
 126 eV (D'Olimpio et al. (2020)). Peaks 3 and 4 are ascribed to Ga 4p - Se 4s
 127 and Ga 4p - Se 4p states, respectively. Peak 3 is ascribed to the mixing of
 128 hybridised orbitals and peak 1 remains unattributed. The difference with
 129 the measured peak positions of peaks 2, 3, and 4 and those reported in the
 130 literature is the same at 0.16 eV. This difference is likely due to a difference
 131 of charging. The difference between the measured 5.13 eV and reported
 132 4.7 eV is greater at 0.43 eV. This difference is currently unaccounted for
 133 but may be explained by slight differences in sample composition and/or
 134 structure. The intensity ratios of the four peaks shown in Figure (6.4a)
 135 is qualitatively the same as reported in the literature (D'Olimpio et al.
 136 (2020)). It is notable that before exposure to water, illumination by a solar
 137 simulator does not modify the valence band spectrum significantly.

138 In-situ NAP-XPS was conducted on the GaSe sample during water expo-

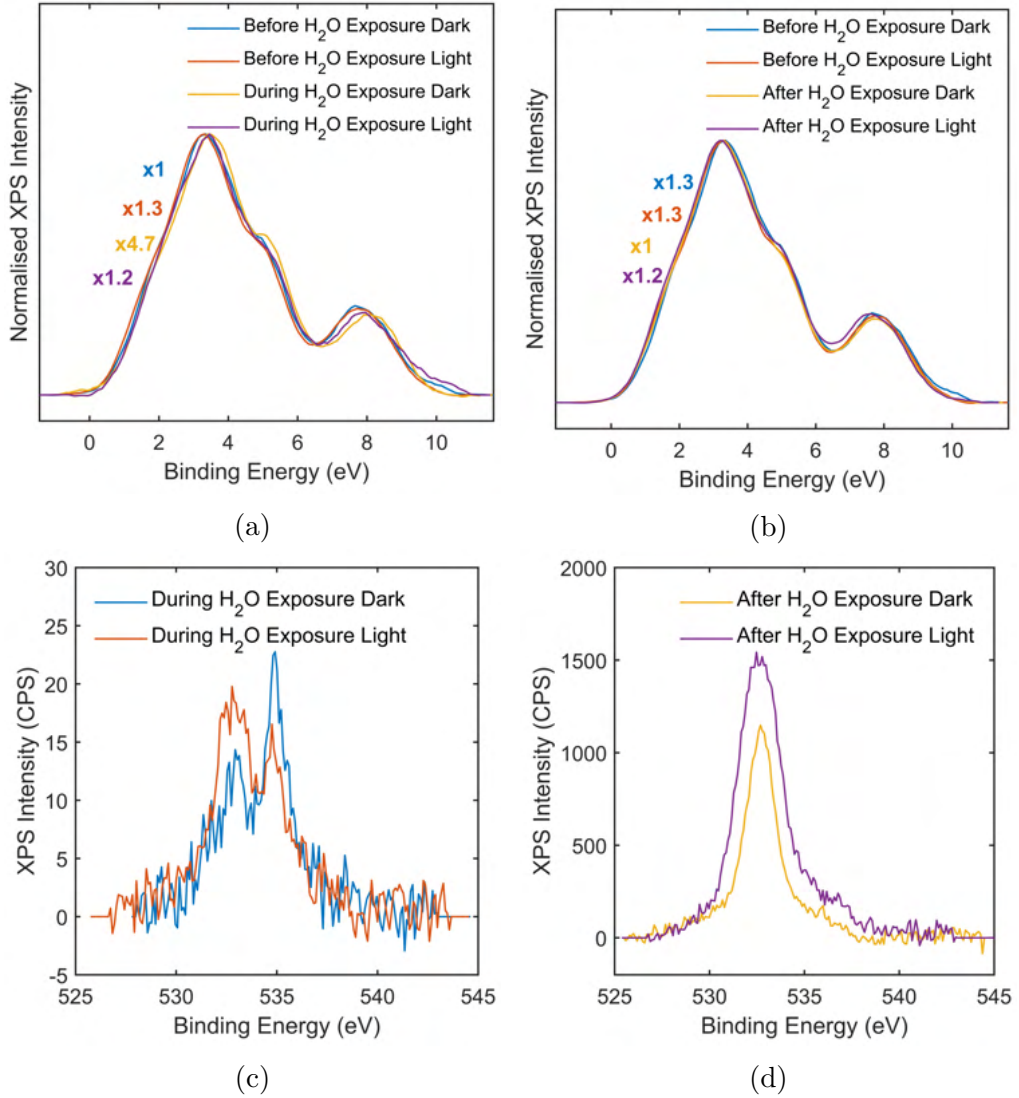


Figure 6.4: XPS spectra of a bulk GaSe sample before, during and after exposure to water vapour. The valence band spectrum (a) before and during water exposure and (b) before and after exposure. The O 1s spectrum (c) during water exposure and (d) after water exposure. Light illumination was achieved using a 1.5 global air mass solar simulator.

139 sure. The in-situ valence band spectra are shown in Figure (6.4a). The
 140 intensity of the valence band spectrum is reduced during the in-situ experi-
 141 ments due to the presence of water vapour and the geometrical restrictions
 142 of the NAP cell. With the in-situ spectra normalised to the largest peak, a
 143 change in the relative intensity of the components can be seen. The po-
 144 sition of the most prominent peak (peak 2) is shifted by 0.27 eV to 3.53 eV,
 145 consistent with that expected for adsorbed water species of GaSe. When

146 illuminated, the position of this peak moves to 3.46 eV. Without illumi-
147 nation, the peak 3 is seen to have an increased contribution as compared
148 to the pre-exposure measurements. When the sample is illuminated, this
149 increased contribution disappears and reverts to approximately the pre-
150 exposure levels. Similarly, peak 4 is seen to change significantly during the
151 water exposure under dark conditions with the peak reverting back towards
152 the pre-exposure contribution when the sample is illuminated.

153 To assess any permanent changes to the valence band spectra of GaSe
154 as a consequence of water exposure, the valence band spectra were mea-
155 sured before and after water exposure and are displayed in Figure (6.4b).
156 Under dark conditions the valence band spectrum post water exposure is
157 unchanged when compared to the before exposure measurement. However,
158 when the sample is illuminated, a change is observed with peak 3 recording
159 a slight increase in intensity and peak 4 seeing a larger increase in intensity.

160 To understand the underlying phenomena responsible for the behaviour
161 of the valence band spectra, the core level spectra must also be studied.
162 Shown in Figure (6.4c) and Figure (6.4d) are the O 1s spectra of the GaSe
163 sample during and after water exposure, respectively. Before water expo-
164 sure there were no O 1s associated peaks visible. The in-situ spectra, shown
165 in Figure (6.4c), reveal the presence of two O 1s peaks at 533.2 eV and 535.3
166 eV, associated with oxide species and adsorbed water species, respectively
167 (D'Olimpio et al. (2020)). When illuminated the intensity of the oxide peak
168 increases whilst that of the adsorbed water species decreases. The post ex-
169 posure XPS of the O 1s peak reveals a strong oxide associated feature and
170 a smaller shoulder associated with residual adsorbed water species. The
171 presence of oxides was also confirmed in spectra of the Ga 2p and Se 3d
172 peaks, both of which displayed new components consistent with the par-
173 tial oxidation of GaSe. This is shown for the Ga 2p peak in Figure (6.5),

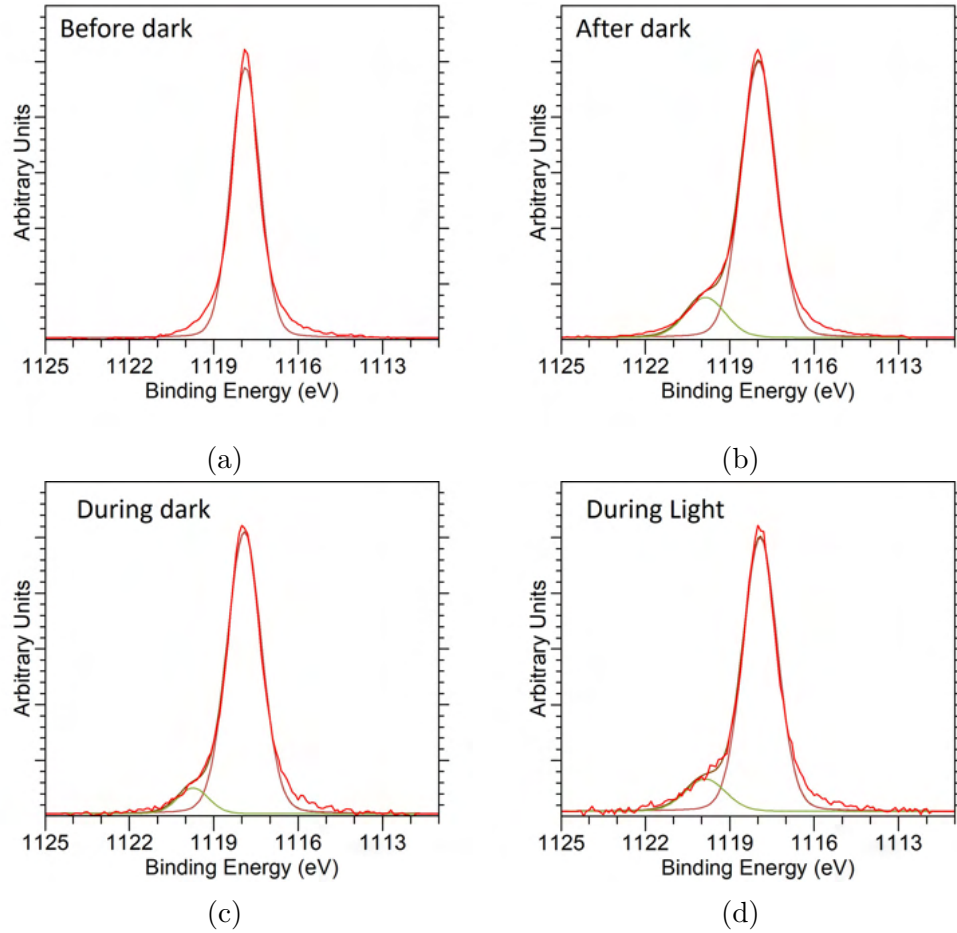


Figure 6.5: XPS spectra of the Ga 2P peak recorded in (a) dark conditions before water exposure, (b) dark conditions after water exposure, (c) dark conditions during water exposure, and (d) light conditions during water exposure. A Tougaard background and 50/50 Lorentzian Gaussian blend was used for the fitting.

174 where an oxide feature appears at a binding energy of 1119.9 eV, 1.9 eV
 175 above the previously recorded peak in unexposed GaSe. This compares to
 176 previously reported descriptions of oxidised GaSe which recorded the new
 177 feature 1.5 eV higher than in pristine GaSe (Susoma et al. (2017)). The
 178 position of the GaSe associated peak changes very little on water exposure,
 179 shifting to higher binding energy by only 0.03 eV and exhibiting no shift
 180 upon illumination. However, the oxide peak shifts to a higher binding en-
 181 ergy by 0.13 when exposed to water under no illumination as compared to
 182 vacuum. When illuminated, the position of the oxide peak returns to its
 183 vacuum value. This indicates that the oxide is likely playing a significant

184 role in any band bending at the surface.

185 The behaviour seen in the XPS spectra of GaSe in response to water expo-
186 sure and illumination via a solar simulator can be understood with reference
187 to Figure (6.2a). Upon water exposure there is a slight shift in the posi-
188 tions of the valence band features associated with the water induced band
189 bending. In this instance the shift was measured at 0.27 eV in the valence
190 band. The presence of water also modifies the relative intensities of the
191 components in the valence band spectrum. When illuminated, many of
192 these features shift back towards their pre-exposure positions and relative
193 intensities (Figure (6.2b)). This is likely due to charge carrier separation
194 taking place in the bent bands near the crystal surface, with the separated
195 charges acting to reverse the water induced band bending. This has the sec-
196 ondary effect of a reduction in the concentration of water adsorbed species
197 on the surface, as evidenced by the reduction in the water species inten-
198 sity in the O 1s spectra when illuminated. A permanent modification of
199 the material also occurs and manifests through the formation of an oxide.
200 This oxide is likely responsible for the differences between the valence band
201 spectra of GaSe post water exposure in the dark and under illumination.

202 **6.3 Surface of GaSe**

203 We conducted AFM of GaSe to gain a better understanding of its oxida-
204 tion, specifically its surface morphology. The AFM measurements were
205 performed on exfoliated large-area GaSe samples with extended areas (\sim
206 50 - 100 μm) of thin flakes (<10 layers thick). The sample also contained
207 thicker bulk-like flakes. The sample was on a gold substrate.

208 On a thick bulk-like flake investigated by AFM, bump-like protrusions in

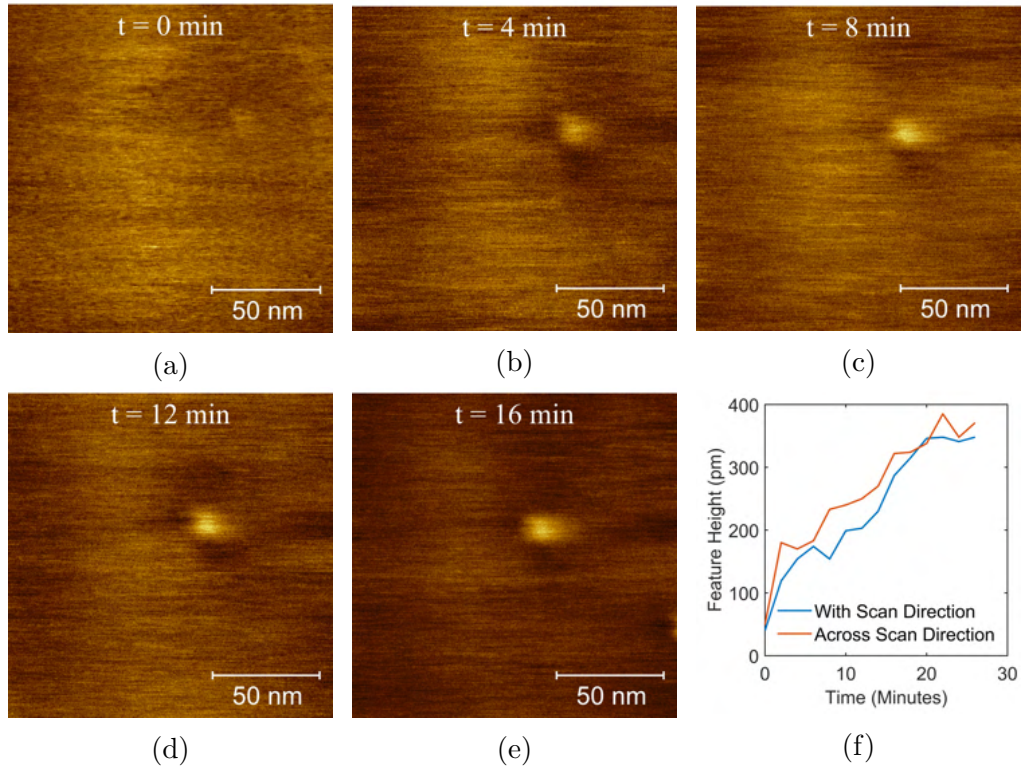


Figure 6.6: AFM height maps of the same location of a bulk GaSe flake at time (a) $t = 0$ min, (b) $t = 4$ min, (c) $t = 8$ min, (d) $t = 12$ min and (e) $t = 16$ min. (f) Plot of the feature height in (a-e) plotted as a function of time.

209 the surface morphology were observed. The density of these bumps was
 210 approximately $108 \mu\text{m}^{-2}$ whilst their vertical size size was up to 1.6 nm and
 211 their horizontal size was up to 36 nm. However, tip convolution (tip radius
 212 ~ 10 nm) can be expected to increase this value, meaning the true diameter
 213 is likely significantly smaller. Phase measurements on the bumps were out
 214 of phase with the inter-bump regions by approximately 8° , indicative of a
 215 different material composition. In the inter-bump regions the surface had
 216 a root mean square roughness of approximately 44 pm.

217 A similar set of observations was made on thin flakes. On a flake of thick-
 218 ness 1.7 nm, corresponding to 2 layers, the same bump features were ob-
 219 served. In this instance the density of the features was approximately 20
 220 μm^{-2} , with a maximum vertical size of approximately 0.9 nm and approx-

221 imate maximum width of 50 nm (with tip convolution). The difference in
222 bump size and density is likely due to the difficulty in accurately identify
223 the bump features as a result of the increased roughness of the thin flake
224 at 0.17 nm.

225 When measuring the surface roughness of an inter-bump region of the bulk-
226 like GaSe flake, it was fortuitous that the growth of a new bump feature
227 was observed. A sequence of AFM height maps recorded at different times
228 during this observation are shown in Figure (6.6a - 6.6e). A similar set of
229 AFM images recorded for phase data shows the same characteristics seen
230 on other bump features. Figure (6.6f) shows how the feature height grows
231 with time. It appears as though the rate at which the bump grows slows
232 with time. It is possible that the height may even be starting to plateau,
233 indicating a maximum/natural size of the bumps. A similar sequence of im-
234 ages was gathered on the thin 2 layer thick flakes with the same behaviours
235 observed. The feature growth is reflected in the phase data, confirming
236 suggesting that they may have a similar composition.

237 It is not known the mechanism which induced the formation of the bumps
238 at the time at which AFM imaging was taking place. Tip-induced de-
239 fects are a possible explanation here. Given the similarity in morphology
240 and phase characteristics between the previously measured bumps and the
241 bump observed during growth, it is likely that their growth mechanisms are
242 the same. Given the ability for GaSe to oxidise has already observed via
243 XPS (Section 6.2) and later via Raman (Figure (6.7b)), it is highly likely
244 that the bumps are comprised of oxidised GaSe. However, their low surface
245 coverage of less than 0.4 % suggests that the sample will contain oxide in
246 other forms given the relatively large XPS oxide peak in Figure (6.5b).

247 6.4 The Optical and Electronic Properties 248 of GaSe

249 It is clear from the AFM and core-level XPS data that oxidation modifies
250 the surface of GaSe. It is also apparent from the valence band XPS data
251 that this modification extends to the electronic band structure of GaSe. It
252 is possible using nano electron spectroscopy for chemical analysis (Nano-
253 ESCA), described in Section 3.2.4, to access the valence band structure of
254 GaSe and observe the permanent modifications induced by oxidation.

255 A large area GaSe sample, similar to that measured in Section 6.3, was
256 used for these experiments. As Nano-ESCA can selectively probe a surface
257 down to a resolution of 10 μm or less, several flakes of different thicknesses
258 were sampled. A summary of the flakes thicknesses and surface roughness,
259 as evaluated using AFM, of the sampled flakes is shown in Table (6.2). The
260 100 layer and 5 layer flakes had notably rougher surfaces than the others.
261 For the 100 layer sample this appeared to be due to surface contamination,
262 as revealed by AFM images. For the 5 layer sample it was instead the
263 surface of the flake in itself which appeared noticeably rougher, possibly
264 due to increased oxidation over the other flakes.

Table 6.2: AFM derived properties of ϵ -GaSe flakes used in the Nano-ESCA studies.

Material	Thickness (nm)	No. of Layers	RMS Roughness (pm)
GaSe	80	~ 100	560
GaSe	4.6	6	341
GaSe	4.0	5	751
GaSe	1.6	2	240
Substrate (Au)	-	-	270

265 The first tool available when utilising the Nano-ESCA is ultraviolet photo-
266 electron spectroscopy (UPS), which works on the same principles as XPS

267 but with incoming photons of energy $h\nu = 21.219$ eV as opposed to $h\nu$
 268 $= 1486.7$ eV. The reduced photon energy results in an increased inter-
 269 action cross section with energy levels near the valence band maximum.
 270 This makes UPS particularly well suited to studying the valence band of a
 271 material as well as providing information on the work function.

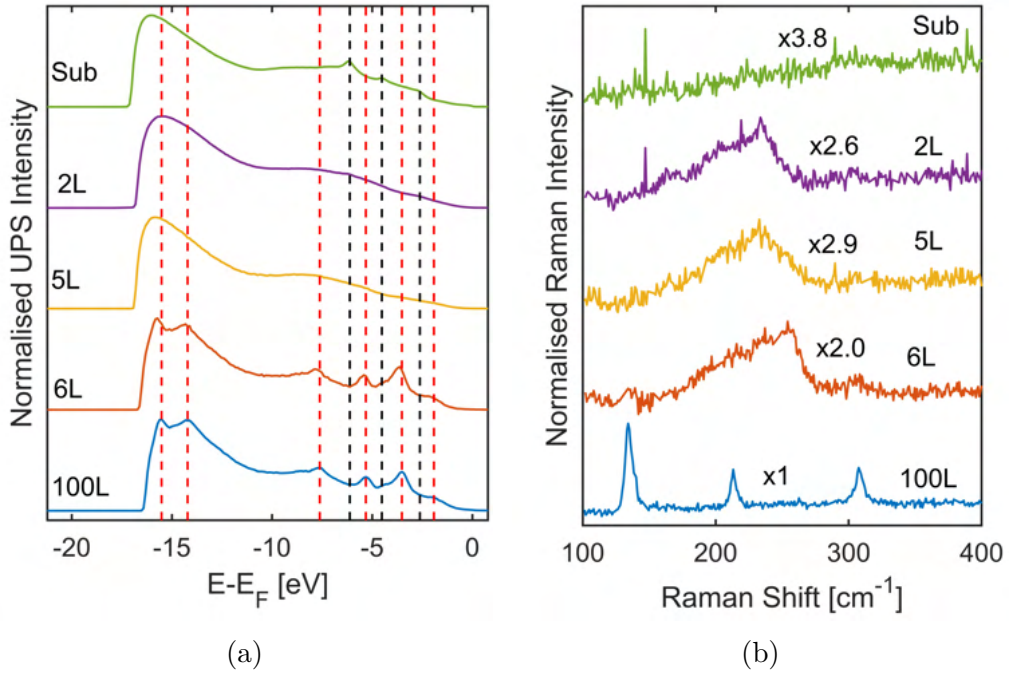


Figure 6.7: (a) UPS spectra of GaSe flakes of different thickness and of the Au/Ti/SiO₂ substrate. The red lines correspond to the locations of significant peaks in the 100 layer bulk-like sample. The black lines correspond to the positions of significant peaks of the Au substrate. (b) Raman spectra of the same flakes studied in (a) ($\lambda = 532$ nm, $T = 297$ K, 1200 g/mm grating).

272 Figure (6.7a) shows the UPS spectra for the GaSe flakes and the Au sub-
 273 strate described in Table (6.2). All the spectra share some key features.
 274 Moving from left to right, the first of these features is the secondary elec-
 275 tron cutoff characterised by a sudden increase in intensity associated with
 276 the work function of the material. Next is a large broad feature present
 277 due to the secondary electron pileup. Third is a plateau followed by a
 278 slow decline in intensity associated with the valence band states and the
 279 valence band cutoff, respectively. In some of the spectra prominent peaks

280 can be seen. These are associated with either atomic orbitals or hybridised
281 orbitals in the valence band. Marked in Figure (6.7a) are the positions of
282 the most prominent peaks in the Au substrate (black vertical lines). The
283 Au peaks are associated with the 5d band of Au and are positioned at -2.6
284 eV, -4.5 eV and -6.1 eV, in reasonable agreement with previously reported
285 values (Gelius et al. (1984); Eastman and Grobman (1972)). It is possible
286 to resolve some of the Au peaks in the 2 layer flake. In the 5 layer flake
287 the Au peaks are no longer visible. The peaks associated with GaSe are
288 visible in the 100 layer UPS spectrum of Figure (6.7a) and marked in red.
289 The four features nearest the Fermi level are positioned at -1.9 eV, -3.5
290 eV, -5.3 eV and -7.6 eV. With reference to Figure (6.4a) and to the liter-
291 ature, the features at -3.5 eV and -7.6 eV are attributed to the Ga 4p-
292 4s and Ga 4p-Se 4p mixed states, respectively (D'Olimpio et al. (2020)).
293 Two additional features are seen in the 100 layer GaSe spectrum at -14.2
294 eV and -15.5 eV. These peaks are attributed to the Ga 3d level (Wagner
295 et al. (2003)). However, the difference of 1.3 eV between the two features
296 is too great to be explained by the peak splitting of Ga 3d and instead at-
297 tributed to the presence of mixed GaSe and oxidised material (D'Olimpio
298 et al. (2020)). The GaSe peaks are also visible in the 6 layer thick sample.
299 However, they are shifted slightly by 0.2 eV, likely due to a slight charging
300 of the thicker 100 layer GaSe sample. In the 5 and 2 layer thick samples
301 the peaks associated with GaSe are no longer visible.

302 It is not immediately obvious why the 100 layer and 6 layer GaSe flakes
303 reveal GaSe associated UPS peaks, whilst the 5 layer and 2 layer flakes
304 don't. An understanding of the structural properties of the various flakes
305 achieved via Raman spectroscopy is helpful in this regard. Figure (6.7b)
306 shows the Raman spectra gathered for each of the flakes. In the 100 layer
307 flake three peaks are visible at Raman shifts of 134.2 cm^{-1} , 213.2 cm^{-1} and

308 307.5 cm^{-1} , associated with the $A'_1(1)$, $E''(2)$ and $A'_1(2)$ Raman modes, re-
 309 spectively (Molas et al. (2021)). The $A'_1(1)$ and $A'_1(2)$ modes are still visible
 310 at a reduced intensity in the 6 layer flake. However, the $E''(2)$ mode is ob-
 311 scured by a new broad feature between 150 cm^{-1} and 275 cm^{-1} , which is
 312 attributed to Ga_2Se_3 and amorphous selenium present due to the oxidation
 313 of GaSe (Zhao et al. (2018); Susoma et al. (2017)). With decreasing flake
 314 thickness to 5 or 2 layers the GaSe Raman peaks are no longer visible, with
 315 only the broad oxide feature remaining.

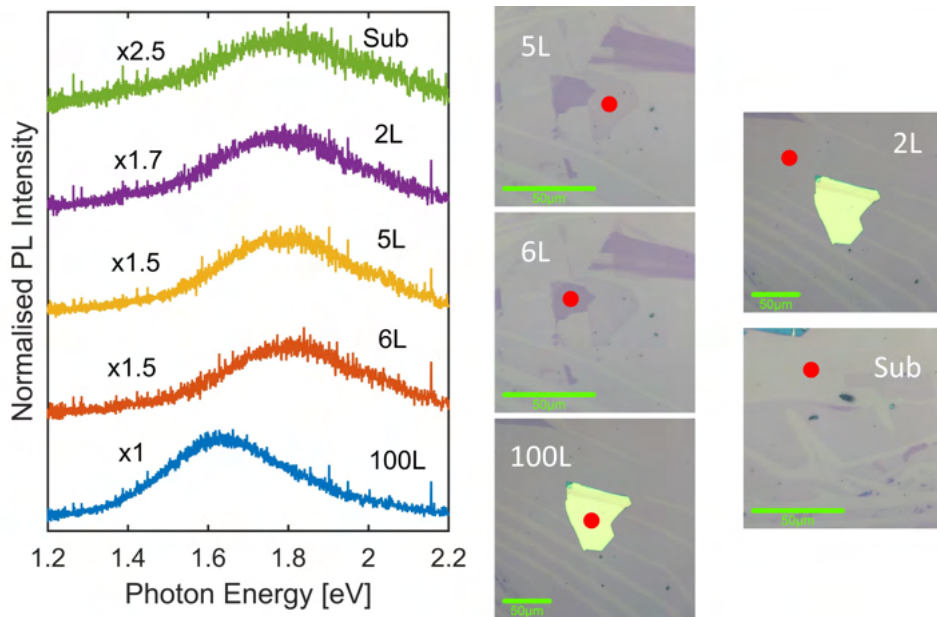


Figure 6.8: PL spectra of GaSe flakes of different thickness and of the Au/Ti/SiO₂ substrate ($\lambda = 532 \text{ nm}$, $T = 297 \text{ K}$, 150 g/mm grating). Optical images of the flakes are also provided with the spectra locations marked in red. These are the same locations used for the Raman and UPS measurements in Figure (6.7).

316 PL measurements reveal a similar trend regarding the oxidation. It would
 317 be expected for bulk-like GaSe that the room temperature PL emission
 318 would be centred at 2 eV in bulk GaSe and at 2.17 eV in 6 layer GaSe
 319 (Arutyunyan et al. (2022)). However, in the 100 layer flake the PL emission
 320 is centred at 1.63 eV , likely due to defect levels introduced in the gap via
 321 oxidation (Savchyn and Stakhira (1996)). When the thickness is reduced to
 322 6, 5 or 2 layers, the PL emission shifts to 1.81 eV . The position of this peak

323 aligns with that of the substrate. Thus, it corresponds to the background
 324 signal.

325 Another powerful tool available using the Nano-ESCA is angle resolved
 326 photoemission spectroscopy (ARPES). This, much like UPS, can selec-
 327 tively probe the electron energy states in a material but with additional
 328 momentum space (k -space) resolution. This information is recorded in 2D
 329 slices of the in-plane k vectors k_x and k_y at a constant energy. By stacking
 330 these slices and extracting 2D profiles, the valence band dispersion along
 331 different crystallographic orientations can be produced.

332 ARPES does not conserve the k_z component of momentum, it instead sam-
 333 ples a position in k_z determined by the photon energy and projects it into
 334 a 2D image over a width in k_z , also defined by the photon energy. The
 335 width is given by Equation (3.9) and was determined to be of the order
 336 $\Delta k_z = 0.1 \text{ \AA}^{-1}$ in the Nano-ESCA. This compares to a Brillouin zone size
 337 of 0.38 \AA^{-1} along the k_z direction in GaSe. The position in k_z is given by,

$$k_z = \sqrt{\frac{2m(E_k + V_0)}{\hbar^2}}, \quad (6.1)$$

338 where the $\cos \theta$ term from Equation 3.8 is equal to 1 in the geometry of the
 339 Nano-ESCA. For GaSe the value of V_0 is approximately 10 eV (Plucinski
 340 et al. (2003)), and for electrons near the valence band maximum the kinetic
 341 energy is approximately 20 eV. This results in the Nano-ESCA sampling
 342 the Brillouin Zone of GaSe at $k_z = 0.04 \text{ \AA}^{-1}$. Given the broadening of 0.1
 343 \AA^{-1} , this range includes the Γ , M and K points. This is in agreement with
 344 previous measurements which finds a maximum in emission at Γ for normal
 345 emission with a photon energy of 23 eV (Plucinski et al. (2003)). As such,
 346 in the projected representation the points encompassing Γ , K, and M are

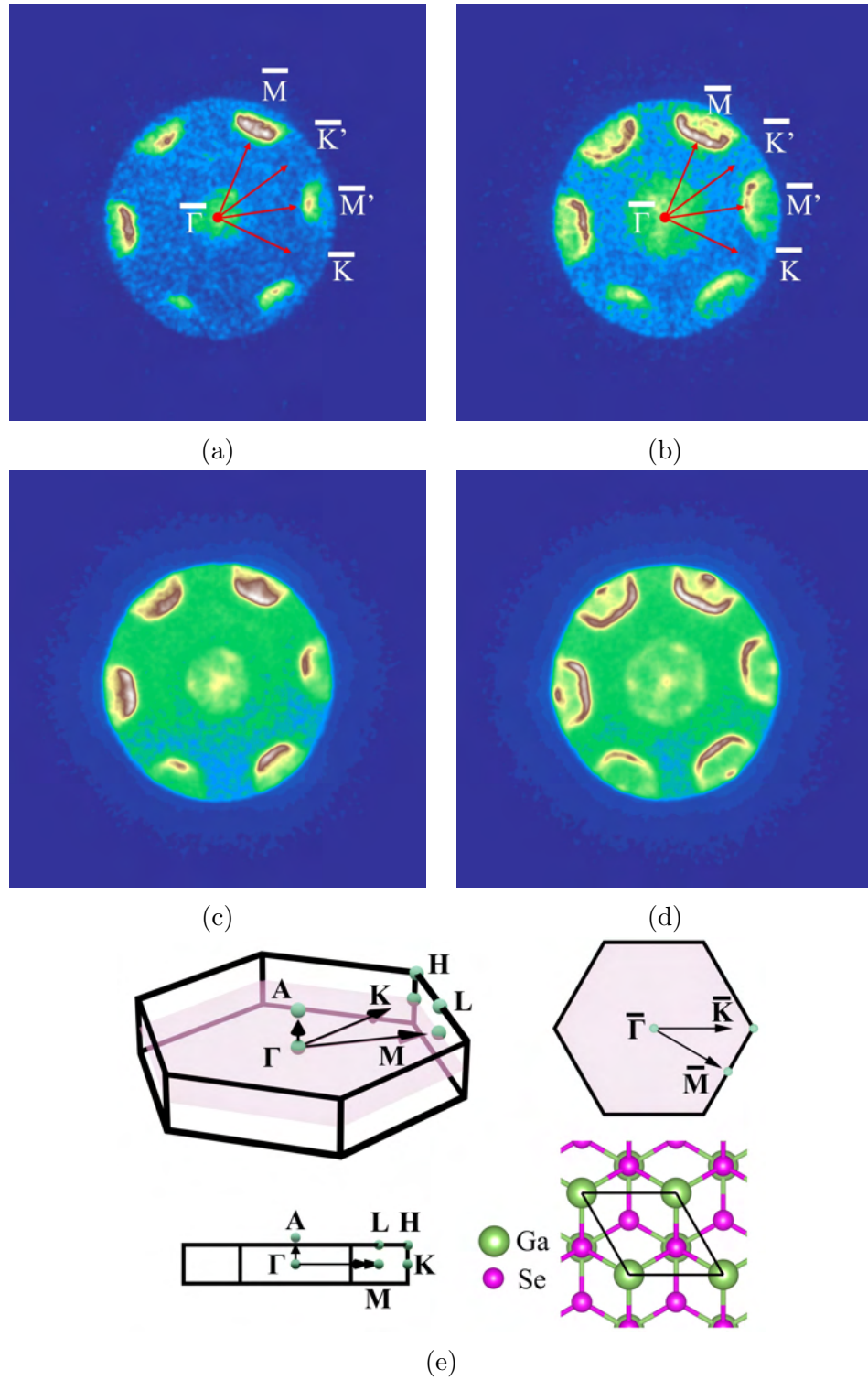


Figure 6.9: Constant energy ARPES slices of 6L GaSe at (a) 1.711 eV below the Fermi level and (b) 2.175 eV below the Fermi level. Constant energy ARPES slices of 100 layer GaSe at (c) 1.711 eV below the Fermi level and (d) 2.175 eV below the Fermi level. (e) Schematic of the 1st Brillouin zone of bulk ϵ -GaSe.

347 referred to as $\bar{\Gamma}$, \bar{K} , and \bar{M} , respectively.

348 Shown in Figure (6.9) are four ARPES constant energy slices recorded in
349 6 layer (6.9a & 6.9b) and 100 layer (6.9c & 6.9d) flakes of GaSe. With
350 reference the 1st Brillouin zone of bulk GaSe (Figure (6.9e)) and to the
351 literature, the high symmetry point of \bar{M} , \bar{M}' , \bar{K} and \bar{K}' alongside the
352 position of the Γ point are marked (Chen et al. (2018b)). The M and
353 K points are positioned 0.97 \AA^{-1} and 1.12 \AA^{-1} away from the Γ point,
354 respectively. In real-space the \bar{M}' - \bar{M}' direction corresponds to the armchair
355 direction in GaSe, whilst the \bar{K} - \bar{K}' direction corresponds to the zig-zag
356 direction. The presence of non-degenerate \bar{M} and \bar{M}' vectors is a result
357 of a three-fold symmetry, not expected from the 6-fold symmetry present
358 in ϵ -GaSe. As the Nano-ESCA light source is polarised, this effect is most
359 likely due to the sample. In fact, this symmetry breaking has been reported
360 previously and is believed to be due to differential screening of 3d orbitals
361 located on the Ga atoms (Plucinski et al. (2003)). The differences between
362 the 6 layer and 100 layer constant energy slices are very minimal. The
363 primary difference in the intensity is due to the planar size difference of the
364 flakes, allowing for the collection of electrons from a larger area in the 100
365 layer sample.

366 To properly understand the differences in the valence band structure of the
367 two flakes, the constant energy slices must be stacked and then sections
368 taken along the high-symmetry directions. This data is shown in Figure
369 (6.10) for a wide field of view and over a wide energy range of up to nearly
370 5 eV below the Fermi level alongside the corresponding UPS data. The
371 first thing to note is the origin of the peaks in the UPS data located at
372 -3.57 eV and -2.07 eV in the 100 layer sample and at -3.77 eV and -2.17
373 eV in the 6 layer sample. These peaks are the same as those previously
374 recorded in the wide energy range UPS (Figure (6.7a)) where the deeper

375 of these peaks was attributed to the mixing of the Ga 4p and Se 4s states.

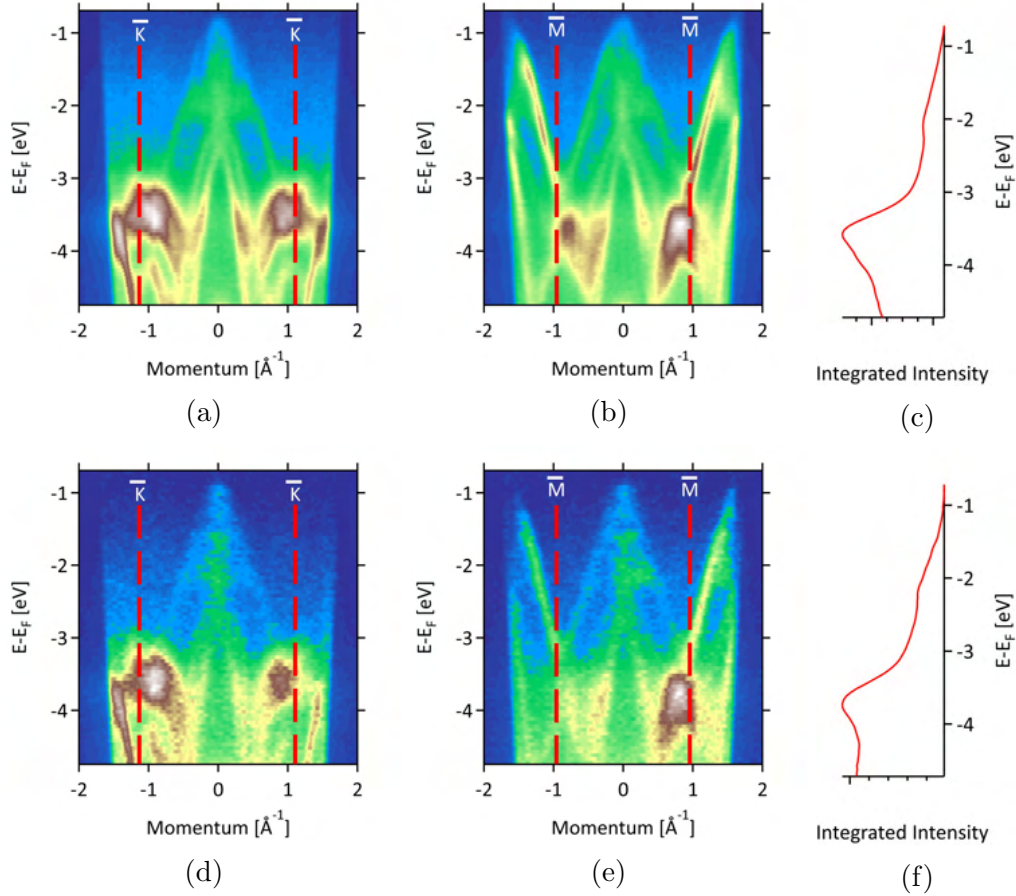


Figure 6.10: ARPES maps of the valence band dispersion of the 100 layer thick GaSe sample along the (a) $\bar{K}\bar{\Gamma}\bar{K}'$ and (b) $\bar{M}\bar{\Gamma}\bar{M}'$ directions. (c) UPS spectra gathered from the central $\pm 1 \text{ \AA}^{-1}$ regions of (a) and (b). ARPES maps of the valence band dispersion of the 6 layer thick GaSe sample along the (d) $\bar{K}\bar{\Gamma}\bar{K}'$ and (e) $\bar{M}\bar{\Gamma}\bar{M}'$ directions. (f) UPS spectra gathered from the central $\pm 1 \text{ \AA}^{-1}$ regions of (d) and (e). The spectra were recorded with a stepsize of 50 meV and a 6.5 \AA^{-1} field of view.

376 The positions of the peaks in the UPS spectra can be ascribed to features
 377 in the valence band by looking at the high symmetry sections of the valence
 378 band shown in Figure (6.10). The two prominent peaks in this range at
 379 -3.57 eV and -2.07 eV in 100 layer GaSe and at -3.77 eV and -2.17 eV in
 380 6 layer GaSe are associated with band crossings and the associated state
 381 hybridisation. This hybridisation is responsible for a high density of states
 382 at these points. In k-space the positions of these crossing points for the
 383 100 layer sample are at $\pm 0.91 \text{ \AA}^{-1}$ and $\pm 0.82 \text{ \AA}^{-1}$ along the $\bar{K}\bar{\Gamma}\bar{K}'$ and

384 $\bar{M}\bar{\Gamma}\bar{M}'$ directions, respectively. For the 6 layer sample the crossing points
 385 are at $\pm 0.90 \text{ \AA}^{-1}$ and $\pm 0.79 \text{ \AA}^{-1}$ along the $\bar{K}\bar{\Gamma}\bar{K}'$ and $\bar{M}\bar{\Gamma}\bar{M}'$ directions,
 386 respectively.

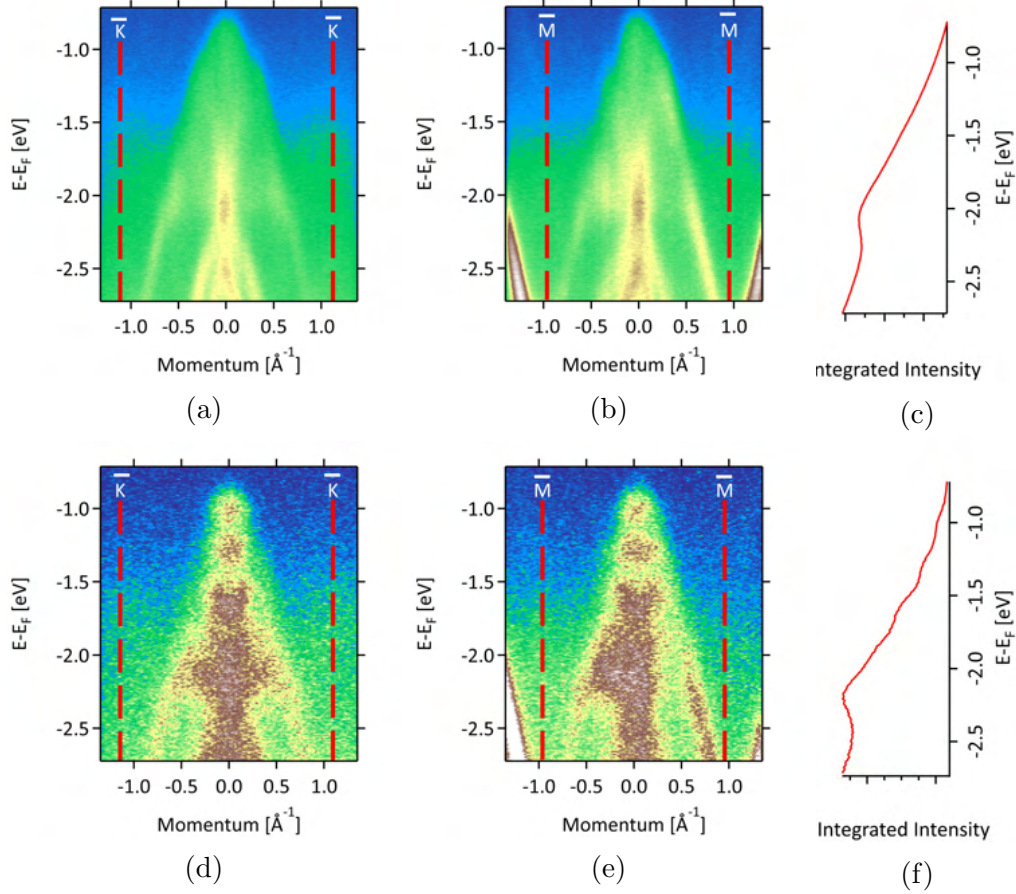


Figure 6.11: ARPES maps of the valence band dispersion of the 100 layer thick GaSe sample along the (a) $\bar{K}\bar{\Gamma}\bar{K}'$ and (b) $\bar{M}\bar{\Gamma}\bar{M}'$ directions. (c) UPS spectra gathered from the central $\pm 1 \text{ \AA}^{-1}$ regions of (a) and (b). ARPES maps of the valence band dispersion of the 6 layer thick GaSe sample along the (d) $\bar{K}\bar{\Gamma}\bar{K}'$ and (e) $\bar{M}\bar{\Gamma}\bar{M}'$ directions. (f) UPS spectra gathered from the central $\pm 1 \text{ \AA}^{-1}$ regions of (d) and (e). The spectra were recorded with a step size of 10 meV and a 2.7 \AA^{-1} field of view.

387 By reducing the region of interest in ARPES to look only at those states
 388 closer to the valence band maximum, more detail can be gathered. The
 389 resulting dispersions and reduced view UPS spectra are shown in Figure
 390 (6.11). Here, the valence maxima are at 0.78 eV and 0.91 eV below the
 391 Fermi level in the 100 layer and 6 layer flakes, respectively. By fitting a
 392 parabolic curve to the top of the valence band, the hole effective mass can

393 be determined via the expression:

$$E(\mathbf{k}) = E_0 - \frac{\hbar^2 \mathbf{k}^2}{2m^*}, \quad (6.2)$$

394 where $E(\mathbf{k})$ is the carrier energy at point \mathbf{k} in the Brillouin zone, E_0 is
 395 the position of the valence band maximum, \hbar is reduced Planck's constant
 396 and m^* is the hole effective mass. Using this expression, the hole effective
 397 mass in the 100 layer sample was found to be $1.2 \pm 0.4 m_e$ along both the
 398 $\bar{K}\bar{\Gamma}\bar{K}'$ and $\bar{M}\bar{\Gamma}\bar{M}'$ directions. Similarly, for the 6 layer sample, the hole
 399 effective mass is $1.1 \pm 0.4 m_e$ and $1.2 \pm 0.4 m_e$ along the $\bar{K}\bar{\Gamma}\bar{K}'$ and $\bar{M}\bar{\Gamma}\bar{M}'$
 400 directions, respectively. The difference between the two samples is within
 401 the uncertainty of the measurement ($\pm 0.4 m_e$), which is large owing to the
 402 inaccuracy inherent to directly fitting the ARPES spectrum. For a more
 403 accurate value, a more detailed study of the energy distribution curves
 404 should be made such that the band positions can be extracted for fitting.
 405 Both sets of carrier masses are above that but within the error range re-
 406 ported previously for pristine GaSe at $0.9 m_e$, as determined via ARPES
 407 (Eremeev et al. (2020)).

408 Studying the UPS data in Figures (6.11c & 6.11f), a feature common to
 409 both samples can be seen at -2.08 eV and -2.19 eV in the 100 layer and
 410 6 layer samples, respectively. This feature most likely corresponds to hy-
 411 bridisation of the Se p_x and p_y orbitals (Eremeev et al. (2020)) and was
 412 seen in the XPS valence band spectra at a binding energy of 1.94 eV (Fig-
 413 ure (6.4a)). When moving closer to the valence band maxima, a difference
 414 between the 100 layer and 6 layer flakes can be observed with a series of
 415 3 peaks present in the 6 layer sample but not in the 100 layer sample.
 416 These peaks are positioned at energies of -1.61 eV, -1.30 eV and -1.00 eV
 417 below the Fermi level. The dispersions in Figures (6.11d & 6.11e) reveal

418 that they are centred at the Γ point. These roughly equally spaced lev-
419 els in the 6 layer GaSe sample have not been reported in previous GaSe
420 APRES band dispersion measurements (Ben Aziza et al. (2016); Ereemeev
421 et al. (2020); Aziza et al. (2018)). They likely represent band splitting as
422 a result of quantum confinement in the layers, similar to previous results
423 demonstrated in MoS₂ (Jin et al. (2013))

424 **6.5 Summary**

425 The modification of the valence band by water adsorption and water-
426 induced oxidation of GaSe has been demonstrated. In-situ XPS measure-
427 ments indicate a possible band bending of up to 0.27 eV due to the adsorbed
428 water species. This band bending is partially reversed by illumination. The
429 adsorbed water also modifies states deep within the valence band. These
430 modifications are due to both adsorbed water and permanent water-induced
431 oxidation of GaSe. As such, it is unavoidable in any solar water splitting
432 application or any other moisture containing operating environment. The
433 oxide is considered to partially manifests as a series of small oxide bumps
434 on the exposed surface of GaSe. These bumps appear to grow to a ther-
435 modynamically favourable or diffusion rate limited size. The seed of the
436 bumps is unknown, but observations via AFM may suggest surface defects
437 as a possible cause. The ARPES measurements of bulk-like and 6 layer
438 thick (partially oxidised) GaSe reveal some changes in the valence band
439 structure when compared to pristine GaSe from the literature. Notably,
440 these include a larger hole effective mass and the appearance of three high
441 density of states features in 6 layer GaSe near the valence band maximum.
442 It would be suspected that both of these features are relevant to the pho-
443 tovoltaic (carrier mass) and catalytic (new valence band states) activity of

444 GaSe when considered for solar water splitting.

445 To better understand the impact of oxidation on these properties, a fur-
446 ther study of pristine GaSe would be desirable. The exchange of samples
447 between the Nano-ESCA and NAP-XPS equipment under vacuum would
448 allow for holistic studies on individual flakes. If combined with successful
449 UPS work function measurements, this would allow for a full water split-
450 ting relevant description of the valence band of GaSe in response to water
451 exposure.

Chapter 7

Summary, Open Questions & Outlook

This thesis explored a range of phenomena occurring when a vdW material is exposed to hydrogen. The exciting effects observed in hydrogen intercalated γ -InSe were presented; the formation of a SnS/SnS₂ heterostructure was demonstrated; likewise, the properties of partially oxidised ϵ -GaSe were examined in the context of solar water splitting. Here, the valence band structure and the effects of water-induced oxidation were observed. This chapter discusses the key results from chapters 4, 5 and 6, then describes currently unanswered questions before providing details of potential future work.

1 **7.1 Summary of Results**

2 The interactions investigated over the course of this PhD are relevant to
3 the applications of hydrogen technologies and vdW materials modification.
4 These results are discussed in their contexts for each of the materials sys-
5 tems below.

6 **7.1.1 SnS/SnS₂**

7 SnS₂ exhibited the most dramatic change upon exposure to H₂, with hydro-
8 gen acting to reduce SnS₂ to SnS and generate a SnS/SnS₂ heterostructure.
9 The thickness of the heterostructure is controllable and can be varied by
10 altering the hydrogen exposure time. The cross-sectional TEM images of
11 the heterostructure reveal a striking step-like interface between the SnS
12 and SnS₂ regions. Furthermore, the basal planes of both materials are
13 aligned and the generated SnS reveals continuous uninterrupted layers of
14 high quality. This is unlike other similar methods of producing similar het-
15 erostructures, such as via argon plasma sputtering, which yields inclusions
16 of SnS near the surface of SnS₂ and does not contain aligned basal layers
17 (Kim et al. (2018)).

18 Thickness uniformity of the heterostructure across large distances was con-
19 firmed via Raman mapping measurements, with the ratio in the intensity
20 of SnS to SnS₂ Raman peaks recorded over distances of several microns.
21 The variation across regions of constant thickness was found to be less
22 than 14 %, whilst discrepancies between regions of different thickness ex-
23 plained via an interference effect. The uniformity extended to the edges of
24 the flakes. However, the XPS indicates a variation between flakes possibly
25 due to residue left by the exfoliation process preventing conversion or by

26 some unknown mechanism by which the conversion rate varies significantly
27 between flakes.

28 The TEM and Raman results taken together provide compelling evidence
29 for the ability of H₂ to readily reduce SnS₂ to SnS and produce a highly
30 ordered heterostructure. Unlike alternative methods of producing such a
31 structure, this method has fewer compromises when considering the trade-
32 off between structural quality of the heterostructure and large area cov-
33 erage. The heterostructure retained optical activity, as confirmed via PL
34 mapping.

35 Under more reactive conditions (exposure to a proton beam or H₂ at
36 > 250 °C), the further conversion of SnS to β -Sn was confirmed. The
37 relative reactivity of hydrogen with SnS₂ under these more reactive condi-
38 tions can be understood in terms of greater energy barrier to the conversion
39 of SnS to β -Sn than for SnS₂ to SnS. By understanding this, the exposure
40 of SnS₂ or SnS to different forms of hydrogen can be utilised to convert or
41 etch the materials.

42 **7.1.2 γ -InSe**

43 γ -InSe behaves fundamentally differently to SnS₂ when exposed to both H₂
44 and H-ions. Instead of hydrogen accessing different crystal stoichiometries
45 and atomic oxidation states, hydrogen acts to modify the γ -InSe crystal
46 structure.

47 Exposure to a H-ion beam modifies γ -InSe. It is possible that this is caused
48 by the bonding of hydrogen atoms to Se while retaining the crystal struc-
49 ture of γ -InSe. This process was confirmed via Raman spectroscopy, which
50 revealed the modification of Raman modes qualitatively similar to theoret-

51 ical predictions and consistent with an increased mass present on the Se
52 atoms. However, it is worth noting the DFT underestimates the size of the
53 change. The presence of the additional H-atom in the structure was found
54 to suppress the PL signal of γ -InSe at room temperature. At low temper-
55 ature (10 K) the presence of the H-atoms was found to increase the power
56 density required to observe the onset of excitonic behaviours of γ -InSe.
57 These two results point to hydrogen acting as a centre for non-radiative
58 recombination in γ -InSe.

59 H₂ exposure of γ -InSe was performed for both powdered and bulk material.
60 Bulk γ -InSe showed no measurable hydrogen uptake, whilst powdered γ -
61 InSe recorded ~ 0.2 wt.% uptake. This compares to reports of hydrogen
62 uptake of up to 2.5 wt.% achieved electrochemically (Zhirko et al. (2007)).
63 The gas phase uptake was found to be reversible on reducing the pressure of
64 hydrogen in the chamber, making experimental studies of the exact nature
65 of the incorporation difficult.

66 Theoretical results provided some insight to the mode of hydrogen incor-
67 poration from the gas phase. In particular, they reveal that hydrogen
68 uptake is only favourable in γ -InSe when the vdW gap is increased by 2.5
69 Å or greater. This is due to the high interlayer electron density in the
70 gap of γ -InSe owing to Se orbitals projecting into the interlayer space. In
71 this configuration, the increased layer separation partially decouples the
72 vdW layers and produces phonons with a more monolayer-like character.
73 This offers an exciting method for modifying the vibrational and structural
74 properties of γ -InSe.

75 7.1.3 ϵ -GaSe

76 ϵ -GaSe was investigated for its ability to act as a photocatalyst for solar
77 water splitting. In particular, water exposed ϵ -GaSe becomes partially
78 oxidised. This has been demonstrated previously (D'Olimpio et al. (2020))
79 and was confirmed here via NAP-XPS experiments. It is expected that
80 the presence of oxide on the surface of ϵ -GaSe modifies its electronic band
81 properties. This is significant as the band edge positions and band structure
82 of a material are important factors in determining its suitability for solar
83 water splitting.

84 NAP-XPS of ϵ -GaSe revealed the modification of the material via oxidation
85 due to water exposure, with oxygen in the form of oxide and adsorbed
86 water species observed in-situ. When illuminated via a solar simulator, the
87 water concentration on the surface was found to decrease. A water induced
88 band bending of up to 2.7 eV, within expectations, was also observed in
89 the spectra. At the same time, a modification in the relative intensity of
90 valence band states was observed. The oxide growth was also observed
91 on the nano-scale with a series of consecutive AFM images documenting
92 the growth of a surface oxide feature. The nature of this growth suggests
93 defects on the surface of ϵ -GaSe as possibly initiating the oxidation process.
94 Although the coverage of oxide bumps in AFM doesn't fully account for
95 the oxide observed in XPS.

96 ARPES measurements confirmed the band dispersions of partially oxidised
97 bulk-like and 6 layer thick ϵ -GaSe. The measured hole effective masses are
98 higher than those reported for pristine ϵ -GaSe in the literature. Addition-
99 ally, the presence of previously unreported states were observed near the
100 valence band maximum of partially oxidised 6 layer ϵ -GaSe.

101 The results illustrate the modification of ϵ -GaSe by water exposure. The
102 changes to the band structure of the material should be noted when con-
103 sidering ϵ -GaSe for solar water splitting applications and are relevant to
104 other applications where the material might become oxidised.

105 **7.2 Unanswered Questions**

106 The detailed investigations described in this thesis have contributed to the
107 the discovery of new phenomena of fundamental and technological inter-
108 est. However, they have also raised some unanswered questions. These
109 knowledge gaps are detailed here.

110 **7.2.1 SnS/SnS₂**

111 The formation of a SnS/SnS₂ heterostructure requires the permeation of
112 hydrogen across SnS layers. However, the method of diffusion of H₂ within
113 SnS/SnS₂ is currently unknown. If SnS and SnS₂ behave similarly to other
114 vdW materials and are impermeable to hydrogen (Sun et al. (2020)), then
115 the effect of grain boundaries, step-edges and defects might be important
116 in this process. Understanding this would allow for the modification of
117 material in such a way as to effect the rate at which SnS₂ is converted to
118 SnS. Similarly, a better understanding of this rate would allow for devices
119 of accurate and predictable dimensions to be produced.

120 The SnS/SnS₂ heterostructure produced via an interaction with hydro-
121 gen should form a p - n junction. This junction should then be able to
122 demonstrate both current rectification and photovoltaic behaviours. How-
123 ever, attempts to date have failed to probe the electrical properties of such

124 a junction. This is due to the inability to utilise polydimethylsiloxane
125 (PDMS) to position the initial SnS₂ flake on a set of contacts. This is
126 because it inhibits the interaction between hydrogen and SnS₂. As such, a
127 PDMS free approach to producing a device must be sought such that the
128 electronic properties of the junction can be evaluated.

129 Finally, it is currently not known if there is a preferential orientation for
130 which the SnS aligns with SnS₂. Knowing this would be beneficial for un-
131 derstanding processes at the interface and the prediction of any twistrionic
132 properties.

133 **7.2.2 γ -InSe**

134 Powdered γ -InSe showed some hydrogen uptake when exposed to gas phase
135 H₂. However, once the hydrogen pressure is reduced, the hydrogen uptake
136 is reversed. In-situ measurements would be valuable here to understand
137 the nature of the hydrogen incorporation. In-particular, to assess how the
138 uptake compares to theoretical results predicting the increased interlayer
139 separation and the effect that has on the phonon modes of γ -InSe.

140 **7.2.3 ϵ -GaSe**

141 The ϵ -GaSe experiments have thus far been limited by inability to confi-
142 dently measure the band structure of unoxidised pristine ϵ -GaSe. Measure-
143 ment of the same sample of GaSe before and after oxidation is important
144 in confirming that the observed features are due to oxidation and not a
145 batch related issue. This would also allow for the study of how a different
146 oxide loadings on the surface of ϵ -GaSe effects any changes.

147 **7.3 Prospects and Outlook**

148 The currently open questions surrounding the materials and their interac-
149 tions are of importance both fundamentally and to their future application.
150 Here, are described potential future experiments answering these questions.

151 The facilities of the Nano-ESCA allow for the observation of the reciprocal
152 space electronic dispersion of a material. As this retains angular informa-
153 tion, by a comparison of constant energy slices before and after exposure
154 to hydrogen, the relative orientation of SnS₂ and SnS layers can be deter-
155 mined. This is dependent on the material quality and the ability to avoid
156 surface contamination. Utilising a NAP-XPS system, the exposure to H₂
157 can be monitored in-situ, and via the use of a solar simulator the open
158 circuit voltage of the heterostructure determined, confirming the presence
159 of a *p-n* junction.

160 The epitaxial growth and in-situ analysis of 2-dimensional semiconductors
161 (EPI2SEM) combines the processes of molecular beam epitaxy (MBE),
162 scanning probe microscopy (SPM) and ARPES via a vacuum system. This
163 allows for the utilisation of these three systems without the exposure of a
164 sample to air. ϵ -GaSe produced via MBE in this system can therefore be
165 guaranteed oxygen free. This allows for the measurement of the valence
166 band dispersion of pristine ϵ -GaSe. Features of partially oxidised ϵ -GaSe
167 can then be accurately attributed to the presence of oxide.

168 A hydrogen cell for the in-situ measurement of electronic properties is cur-
169 rently under construction. This equipment will allow for the measurement
170 of the electronic properties of any vdW material whilst exposed to hydro-
171 gen. As such, it can asses some of the change to γ -InSe under hydrogen
172 exposure and monitor the interactions between H₂ and SnS₂.

173 7.4 Conclusions

174 Over the course of this PhD the properties and interactions of materi-
175 als for various hydrogen related applications have been investigated. This
176 includes the production of a SnS/SnS₂ heterostructure by hydrogen, the
177 experimental and theoretical modification of the vibrational properties of
178 γ -InSe by hydrogen, and the changing valence band structure of ϵ -GaSe by
179 water-induced oxidation. Often surprising in their phenomenology, these
180 interactions should prove useful to the further design of hydrogen tech-
181 nologies or to those looking for a means to modify the properties of vdW
182 materials. Most importantly, the unexpected nature of many of the inter-
183 actions lends credibility to the notion that the fundamental properties of
184 the interactions between vdW materials and hydrogen should be extended
185 to include the full diverse range of vdW materials.

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